



**La Région**  
Auvergne-Rhône-Alpes

**Loire**  
LE DÉPARTEMENT

**SAINT-ÉTIENNE**  
la métropole **SÉM**



*Design-moi une surface*

# SYNTHÈSE CONFÉRENCES PW2023



ÉCOLE  
CENTRALE LYON

**ENISE**  
École Nationale d'Ingénieurs de Saint-Étienne



**MINES**  
Saint-Étienne

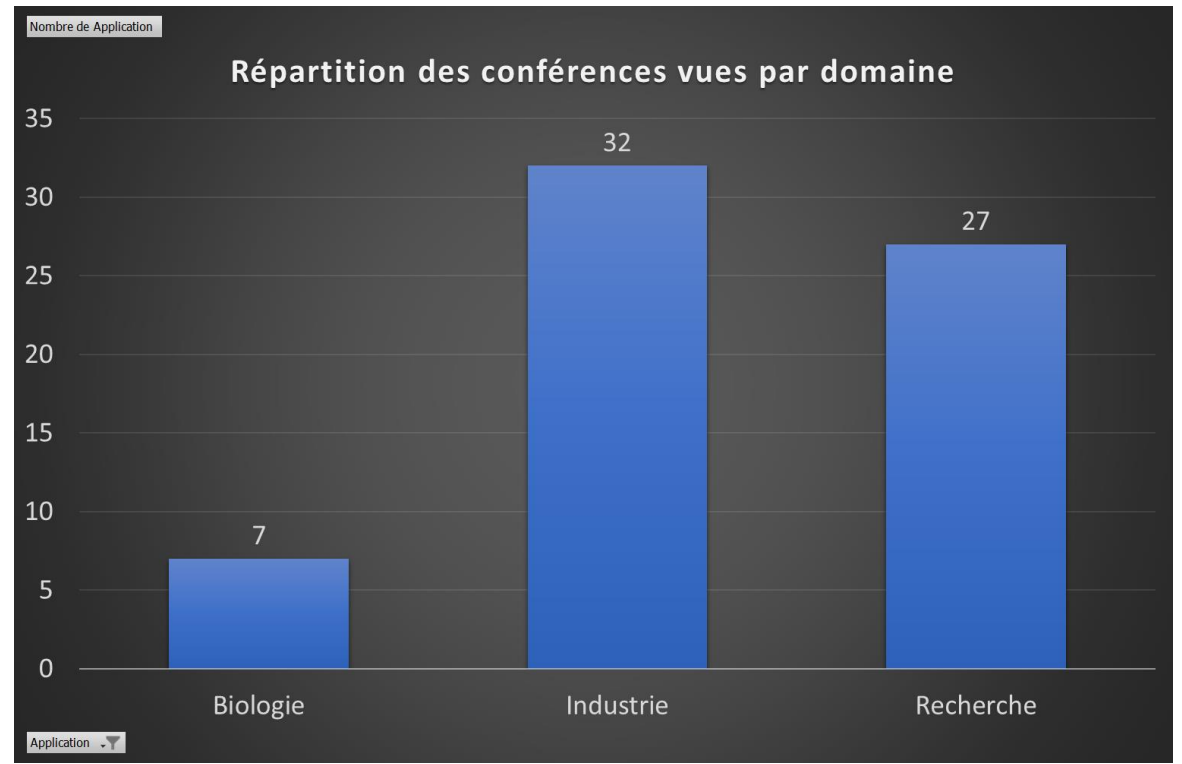
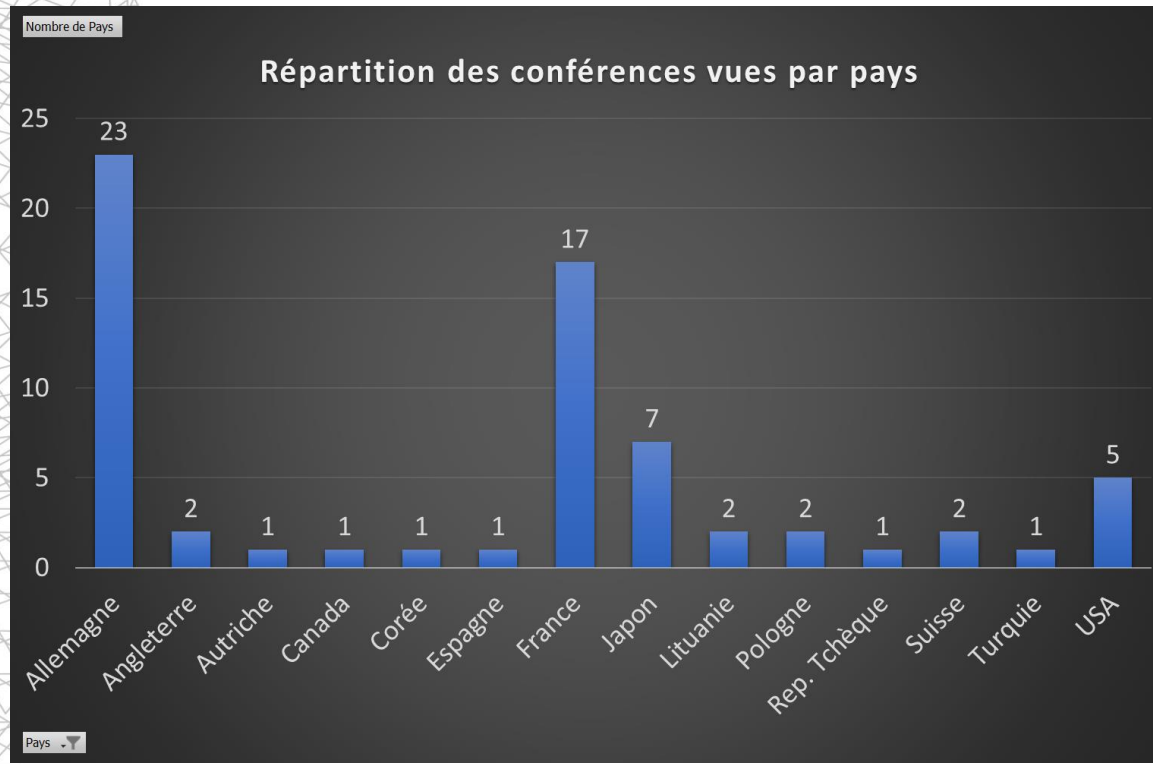


ONE LYON  
ST-ETIENNE

[www.manutech-usd.fr](http://www.manutech-usd.fr)

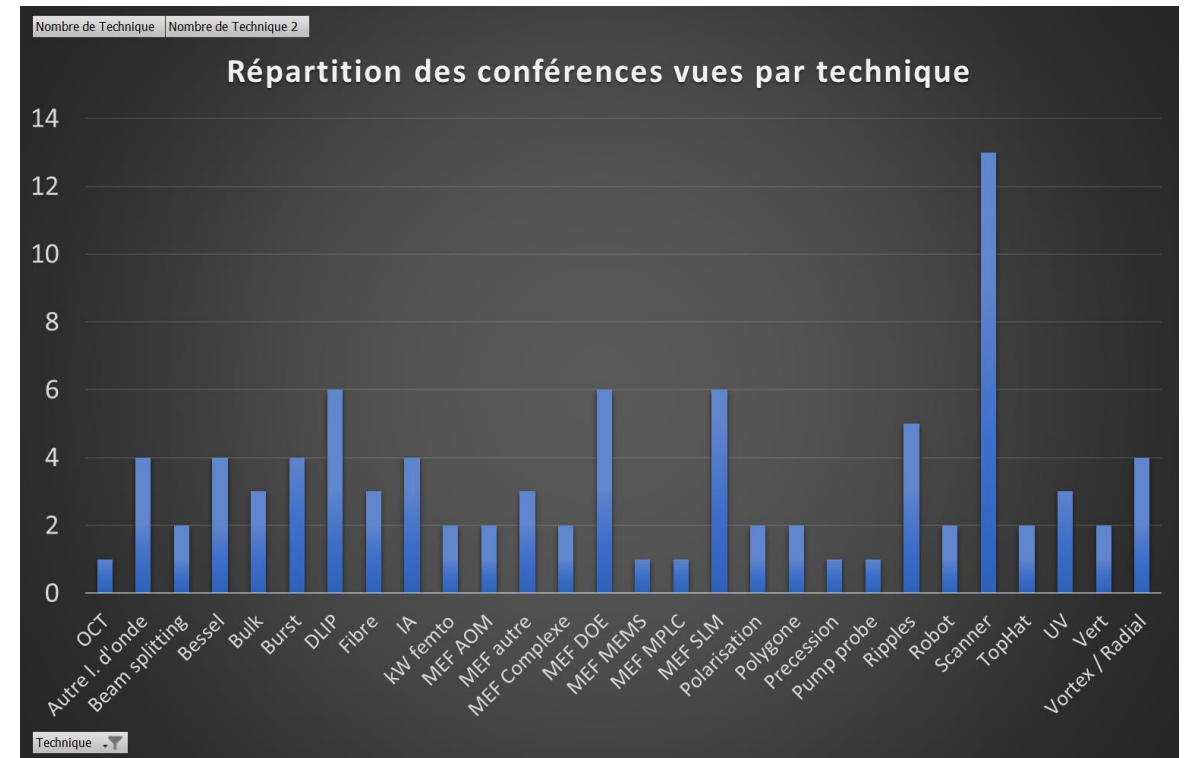
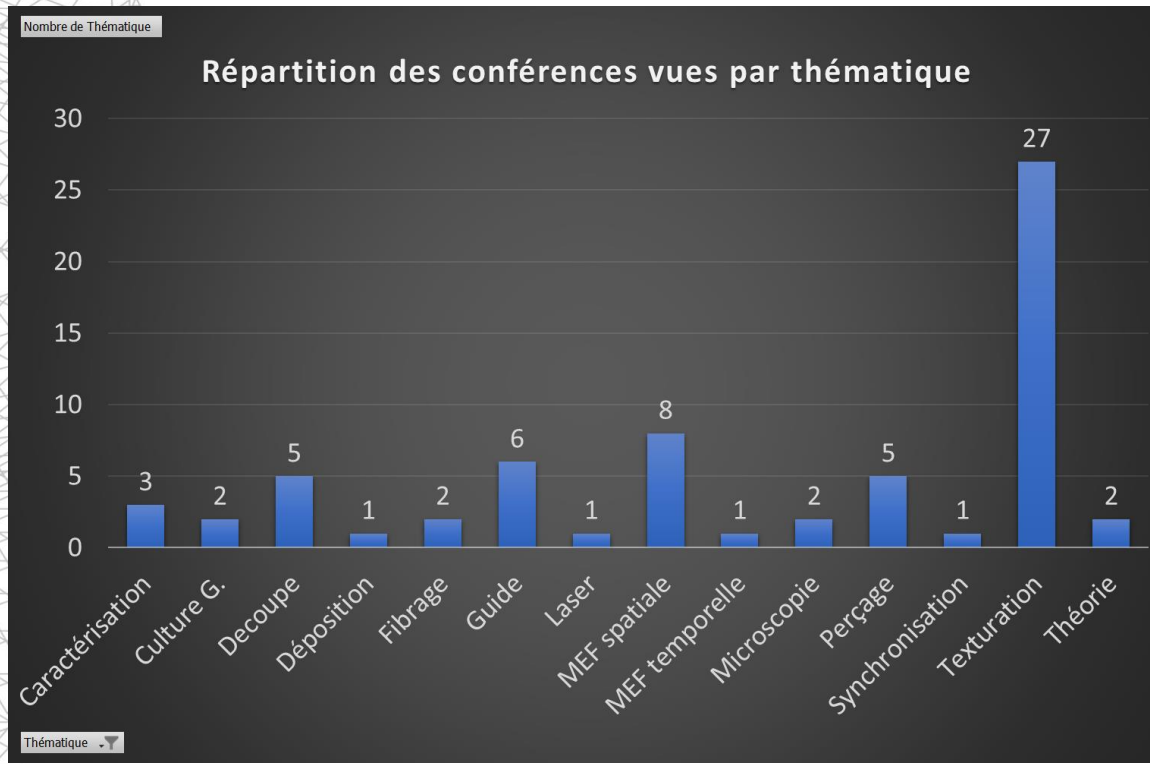
# STATISTIQUES DIVERSES

- Environ 75 conférences suivies (Yoan + Julien) => **+50% vs 2022**
- Environ 2 sans implications directes sur Manutech (Culture générale) => **-80% vs 2022**



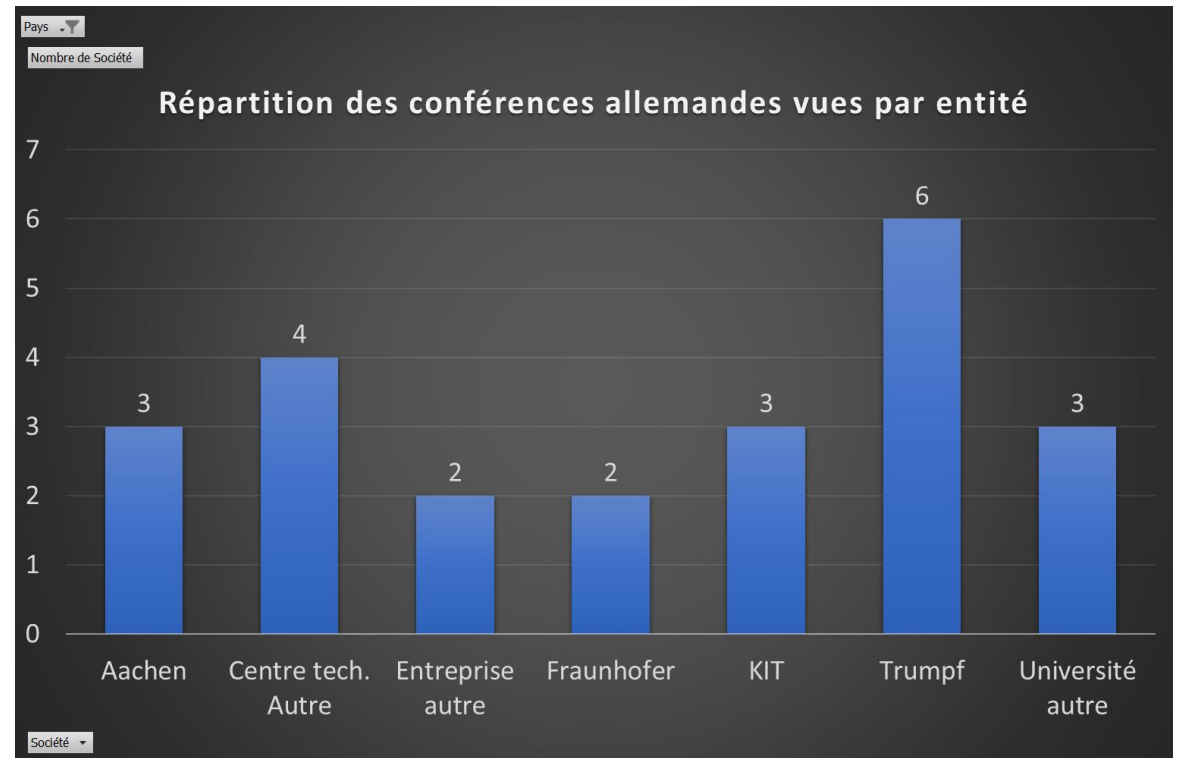
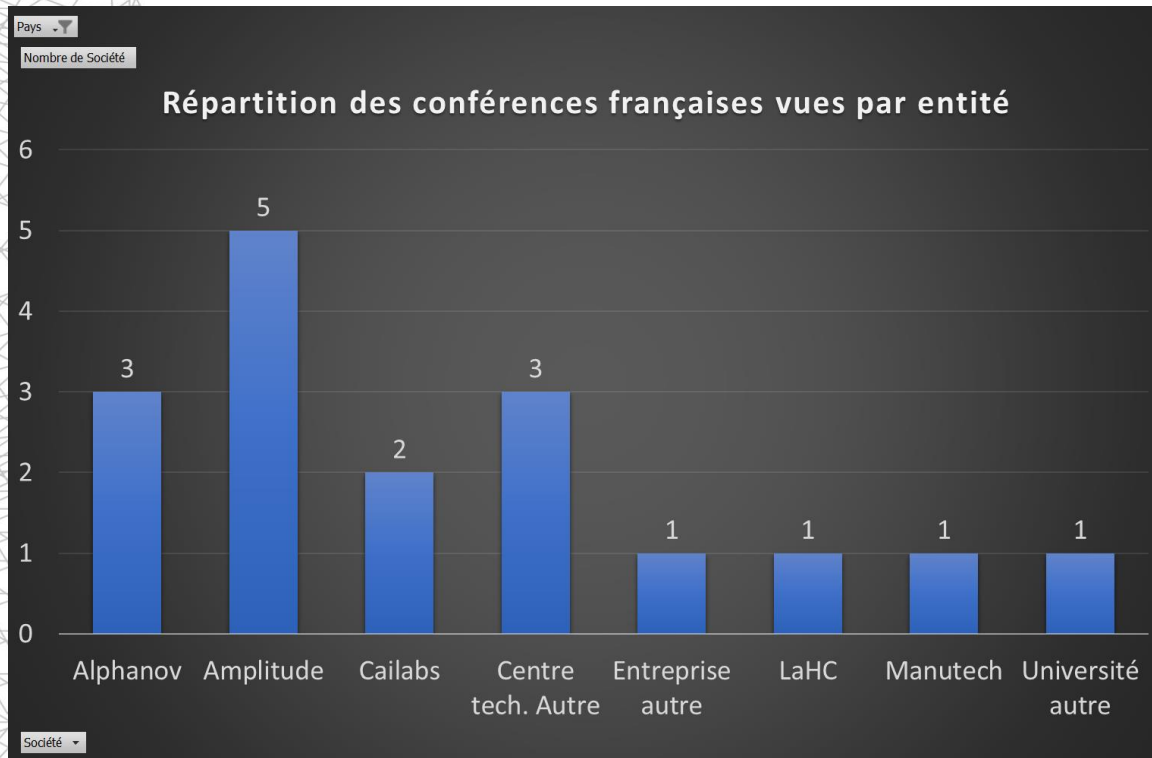
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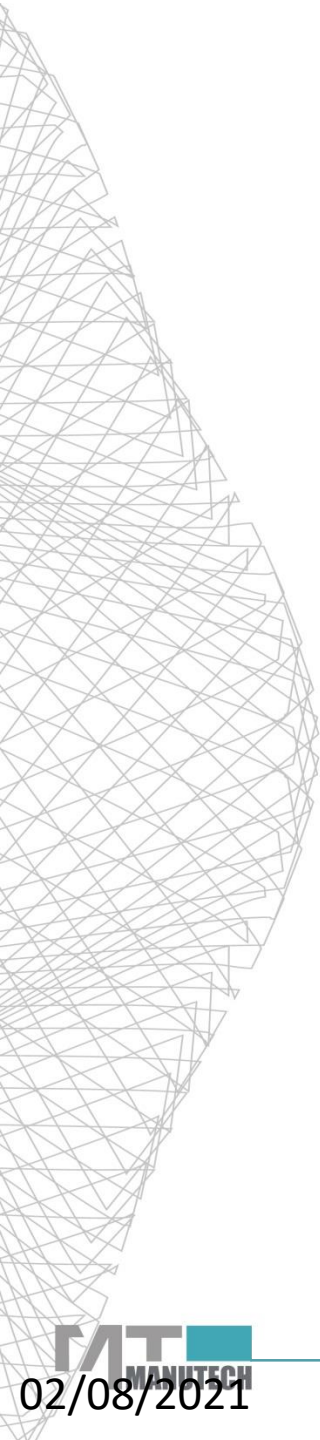


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# Dimanche 29-01-2023

## Femtosecond fiber delivery for industrial applications

Auteur(s) S. Guillemet

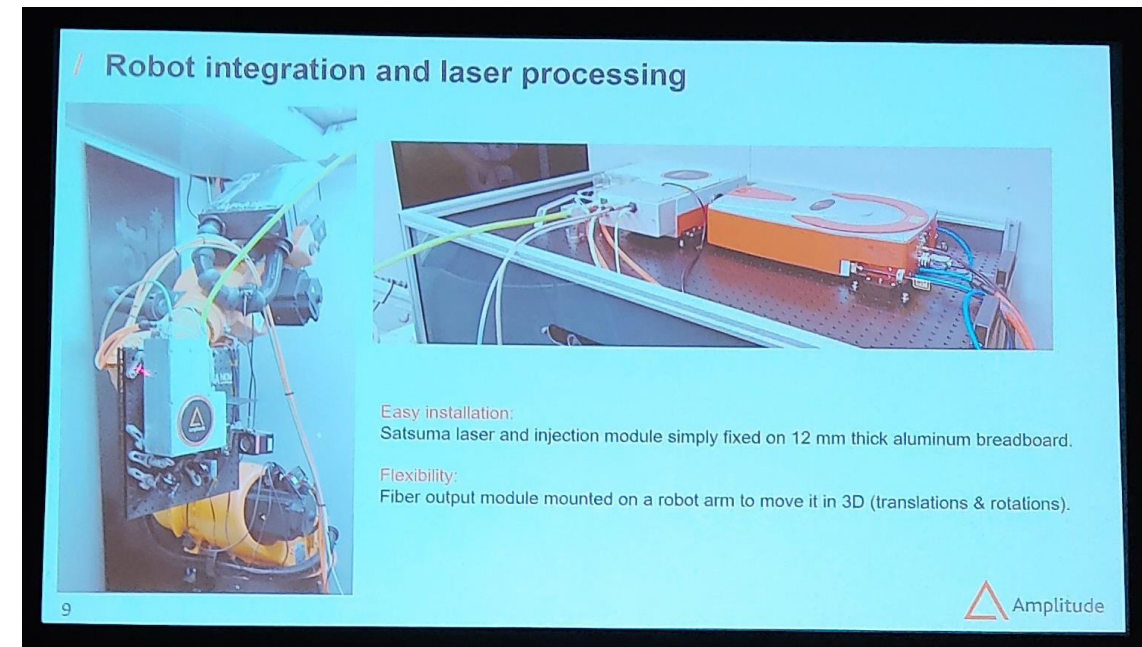
Soc. / Lab. Amplitude (Fr.)

Intérêts • Laser fibering + robot demonstration

## Informations clés

1 photos

- Glo (complete watercooling) + Satsuma 20W – 60μJ
- + bras robot (Alphanov)
- 1-Couplage Power and analyse de faisceau sur la tete du robot
- Video live : few Y beam deviation but quite stable P – XY
- 2-Processing un echantillon H et un V demo Alphanov + Amplitude logo : ripples très similaires
- To demonstrate : 300W Tangor Laser
- Questions : watercooling (Yes) ; Z axis precision (ok) ;  $M^2$  (1.2 demonstrated, slight decrease). Thinking of integrating injection inside the laser. Loss of 5% (during propagation) ; Pulse duration preserved (demosntrated 267fs)



29/01/2023

N°12411-3

Title : Versatile phase & amplitude pulse shaping with SLM

Auteur(s) Lingxia Yang

Soc. / Lab. Illinois Biophotonics university (USA)

Intérêts

## Informations clés

0 *photos*

- Multiphoton microscopy
- Grating disperser + focal + SLM + SLM + Grating compressor
- Custom SLM (15k\$, higher speed)
- Half waveplate + SLM + return half wave plate + polar filter...



29/01/2023

N°12411-6

Black marking for medical industry with USP lasers at different pulse durations

Auteur(s) Steffen Rübling

Soc. / Lab. Trumpf (Fr.)

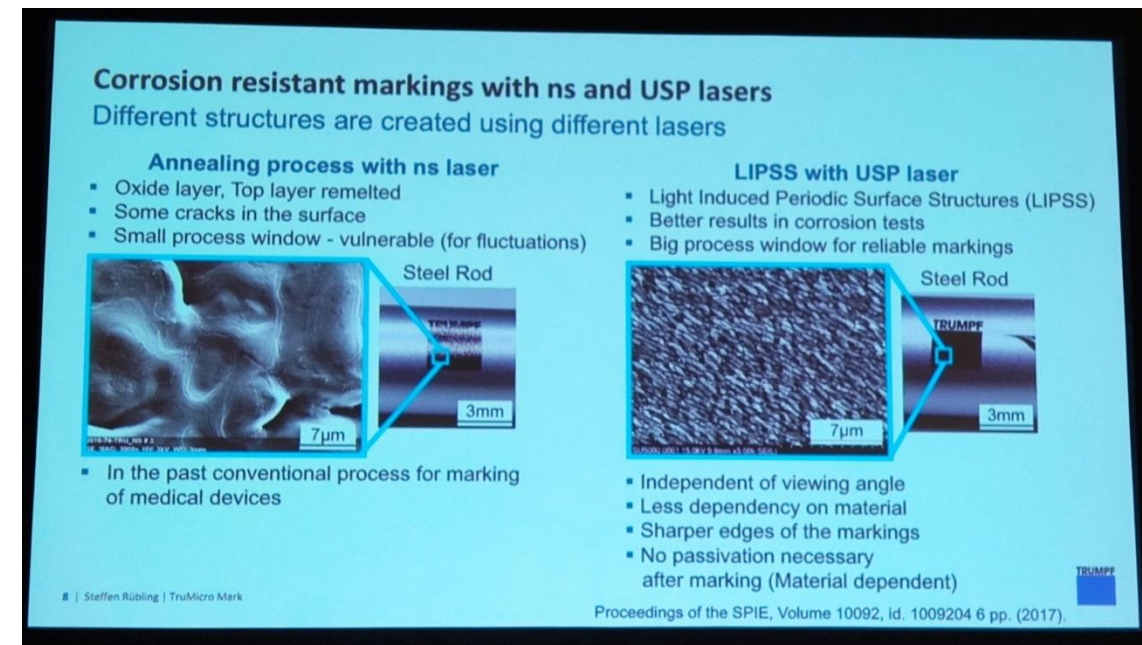
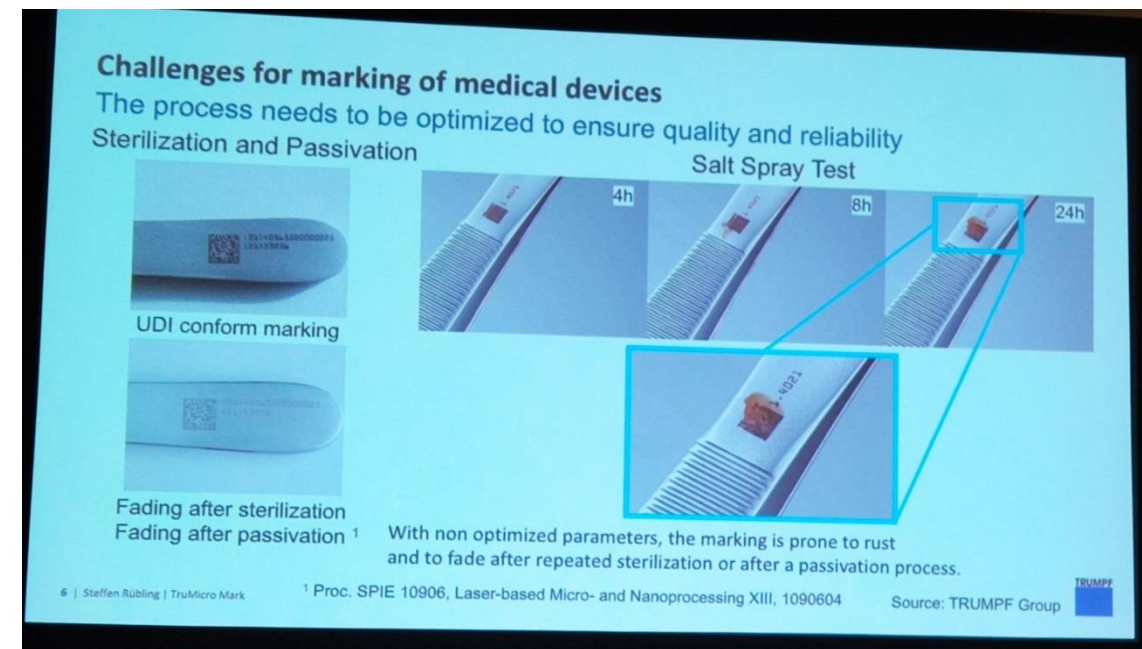
Intérêts

- Complete solution for Pharma Id
- Black marking with ripples...

Informations clés

2 photos

- Complete supply chain from identification to marking and processing data
- Process definition to avoid fading after sterilization and passivation ranging from ns to fs.
- USP Lipss = black marking and better corrosion effects
- Laser+Vision+Eclairage+Pointer all in one solution for product identification. Medical conform markings
- Question : black marking on glass?



29/01/2023

N°12411-7

## Towards precision tumour surgery with picosecond lasers

Auteur(s) Jon Shepard

Soc. / Lab. Heriot Watt University (Angl.)

Intérêts

- Thématique : Usinage de tissus vivants cancérigènes

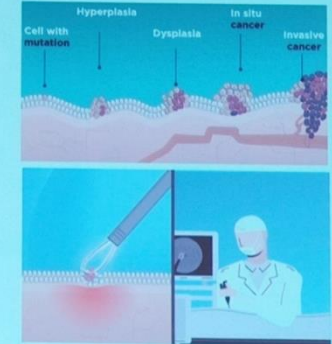
### Informations clés

3 photos

- Control of ablation on alive tissues to remove cancer cells.
- Demonstration on fresh colorectal tissues. 90% recovering. Up to 600µm deep ablation depending on energy (few 10s µJ)
- Speed upscaling : be careful of deep thermal effects
- Fibering delivery issues, new cores

### Motivation

- Malignant cells co-exist with healthy tissue
- Multi-modal imaging: detection and diagnosis
  - Opportunities for minimally invasive surgery
- Current surgical tools
  - Lack precision, control, selectivity
  - Order of magnitude worse than required
- Default practice
  - Remove cancers with margin of normal tissue
  - Try and ensure complete cancer eradication
  - Leaving cancer cells = recurrent disease
- Current surgical strategy = compromise:



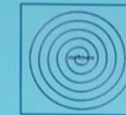
<https://youtu.be/okO1RYevtXY>

3

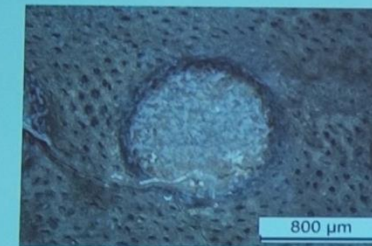
### Laser resection of porcine tissue at 1030 nm (near IR)

Outward spiral, 1 kHz repetition rate and 90% spot overlap

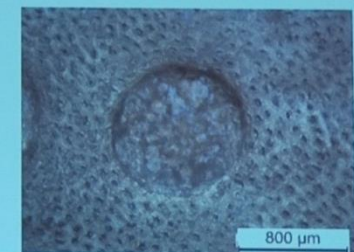
Spiral Pattern  
(control heat accumulation and  
mitigate cavitation effects)



All performed on  
fresh, ex-vivo tissue  
Clinically relevant!



70 µJ



Pulse energy

30 µJ

See Beck et al BIOS 2023 "Precision resection of soft tissue using picosecond laser pulses" Paper No 12377-16

9



29/01/2023

N° 12360-35

## Wavefront shaping and optical memory effect of excised crystalline lenses

Auteur(s) Alba Paniagua

Soc. / Lab. Universidad de murcia (Esp.)

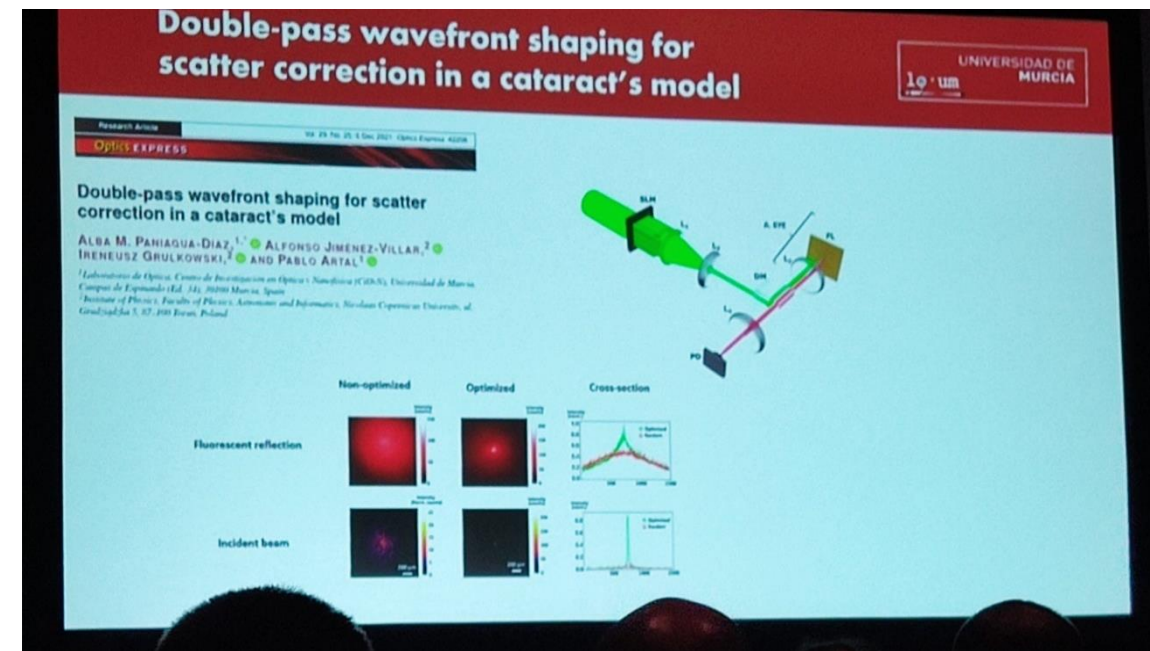
Intérêts

- Travaux sur le cristallin

### Informations clés

1 photos

- Optimisation of the Point Spread Function when view blurring due to cataract effects
- Use of Beam shaping to improve vision
- Excised human caractous lenses
- 12360-60 poster



29/01/2023

N° 12360-36

OCT images of the human crystalline lens reveal local changes in the morphology and transparency with ageing

Auteur(s) Danniell Ruminski

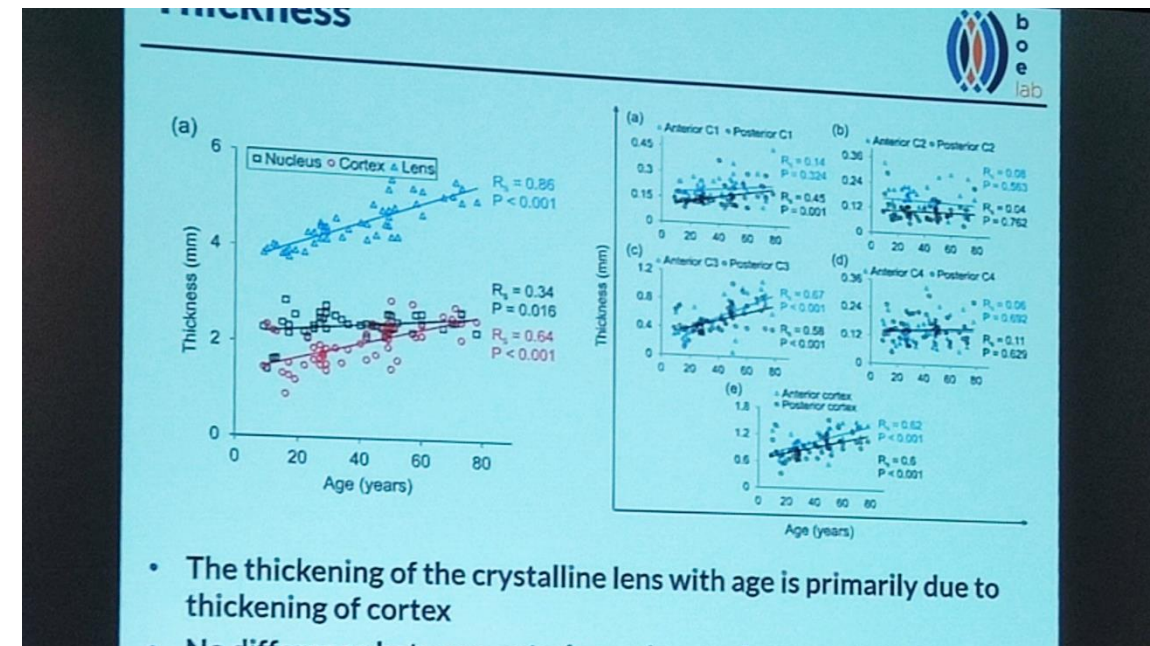
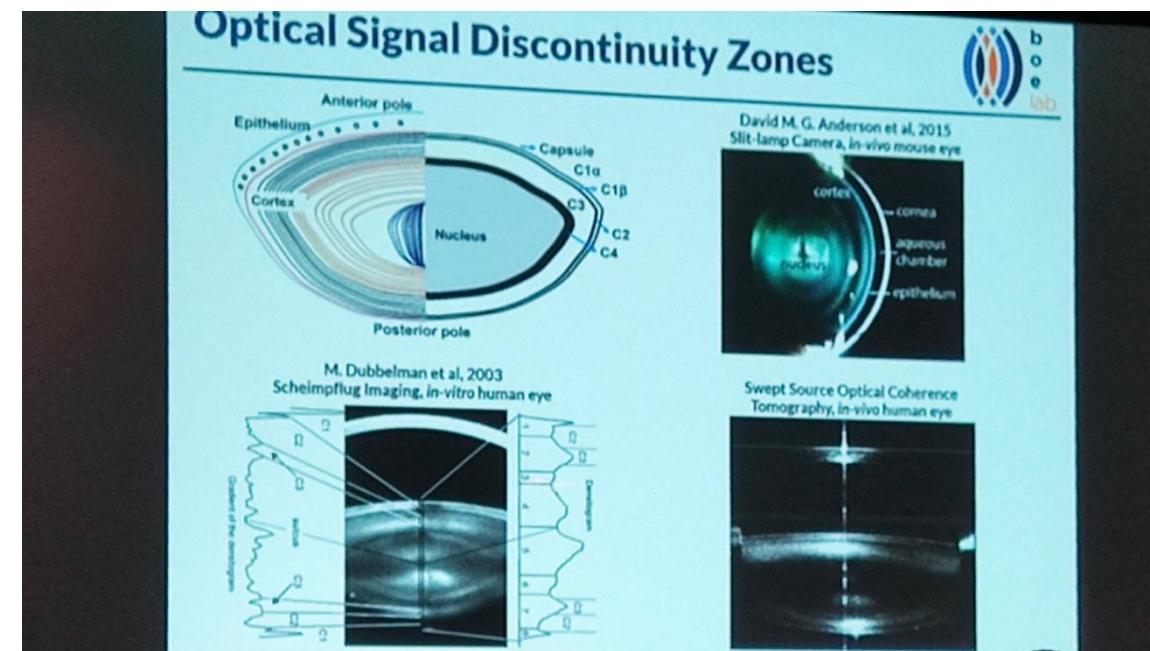
Soc. / Lab. Nicolaus Copernicus Univ., BOE Lab, (Pol.)

Intérêts • Travaux sur le cristallin

## Informations clés

6 photos

- Thickening of crystalline lens with age, mainly due to cortex
- More convex also and less transparent
- Experts in OCT for crystalline analysis
- In vivo analyze of age dependency of geometry and light back scattering



- The thickening of the crystalline lens with age is primarily due to thickening of cortex



29/01/2023

12411-10

## Ultrafast ablation of bone tissue : process optimisation and species dependence

Auteur(s) Laura Gemini

Soc. / Lab. Alphanov (Fr.)

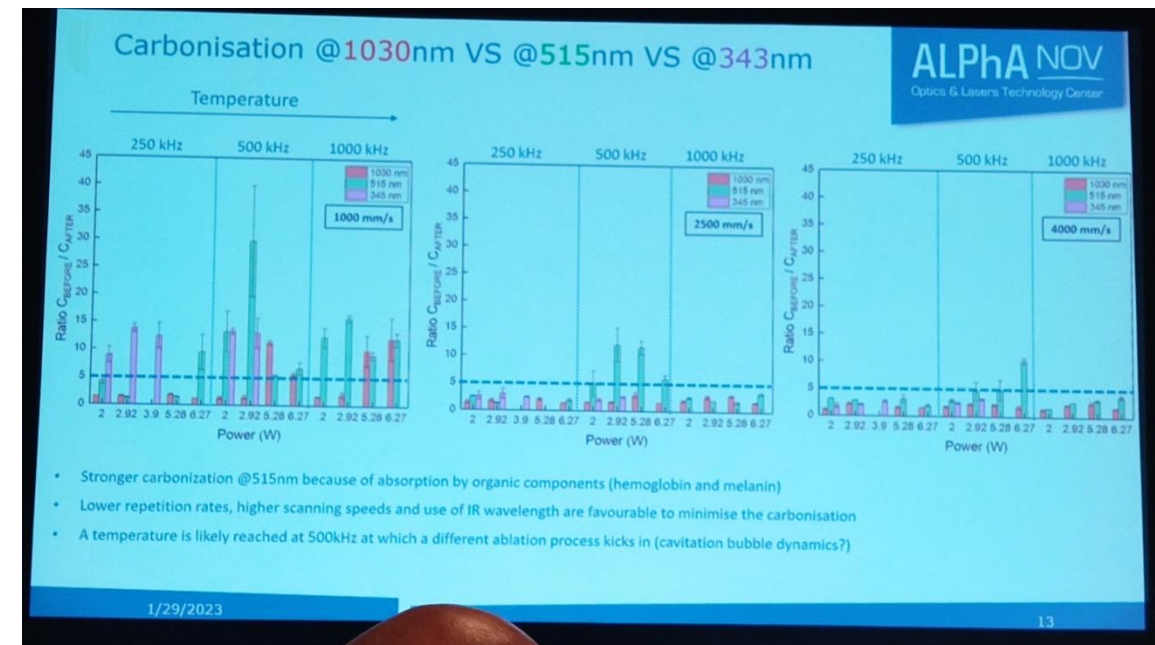
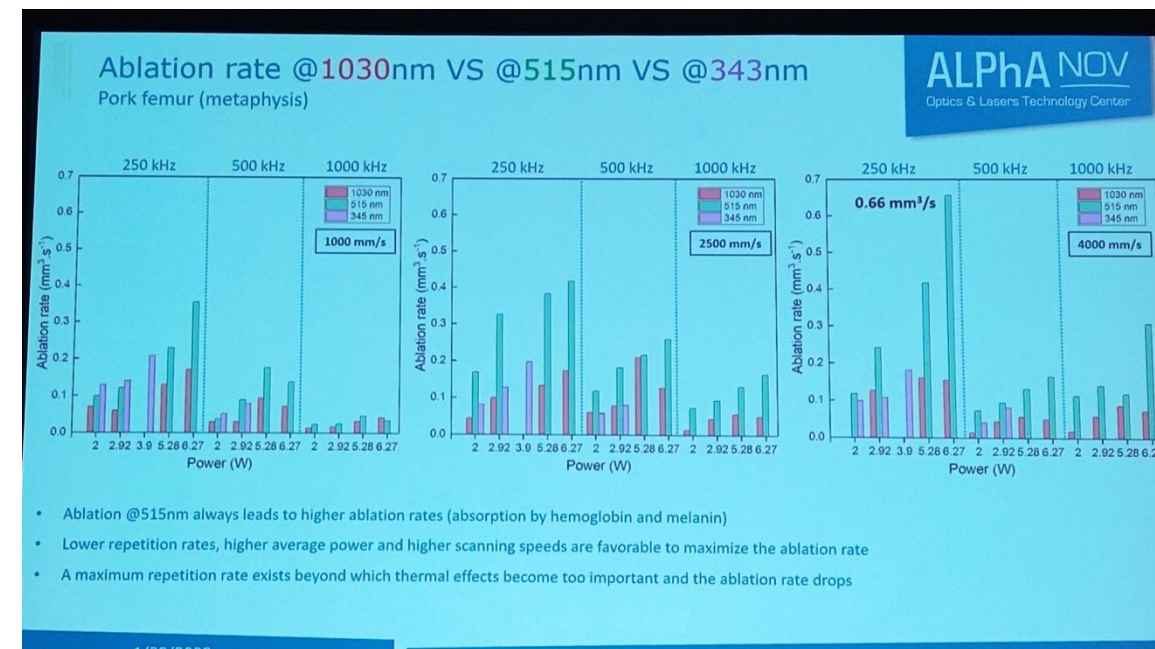
Intérêts

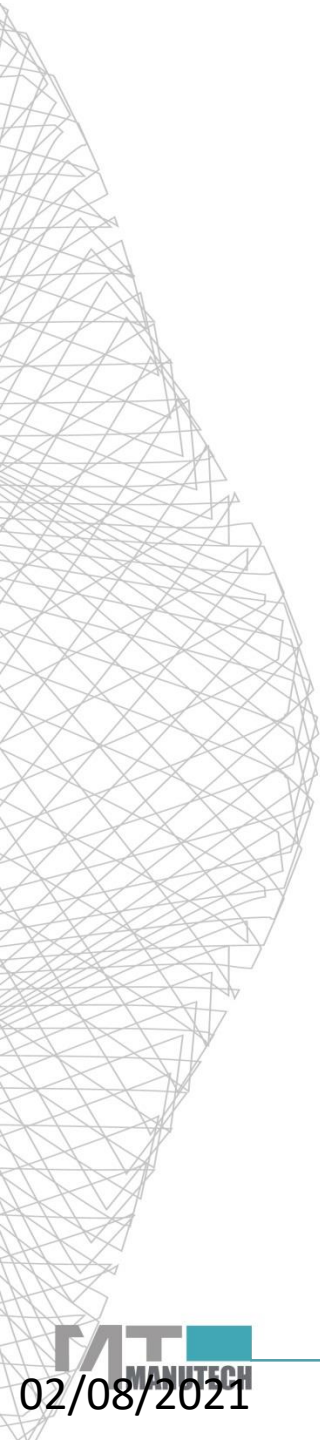
- Projets Alphanov dans l'usinage de tissus vivants

## Informations clés

5 photos

- Cutting of bones with femtosecond laser to avoid thermal effects compared to Ns lasers
- Today : low ablation rate of fs ( $<0.15\text{mm}^3/\text{s}$ ) depending also on the origin of the bone (for animal tests for instance)
- Better ablation rate in Green, 6W, high speed (4m/s)
- But IR, 500kHz 1m/s, Green, 3W also better for lower carbonization
- Better in Air rather than water or air knife or water spray for ablation rate but better for carbonization (LIBS analysis)
  - BioTIS : bone patterning for better osteointegration
  - Project LARA (Laser Robotic Application) 3 years





Lundi 30-01-2023



30/01/2023

12408-1

## Deep learning based simulator for femtosecond laser micromachining

Auteur(s) Shuntaro Kani

Soc. / Lab. University of Tokyo (Jap.)

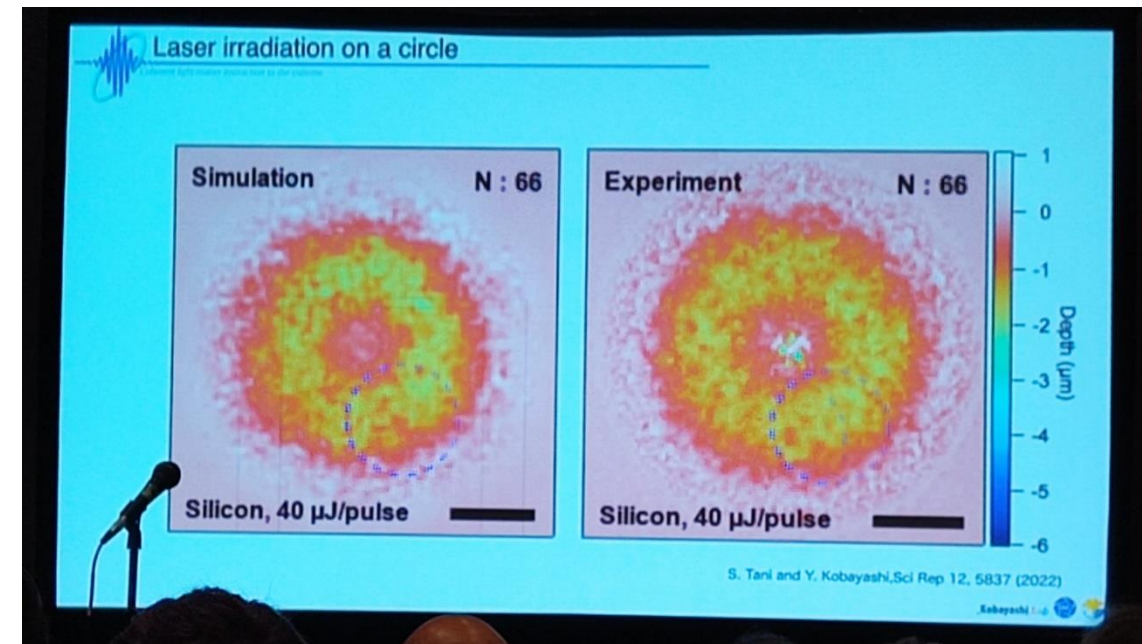
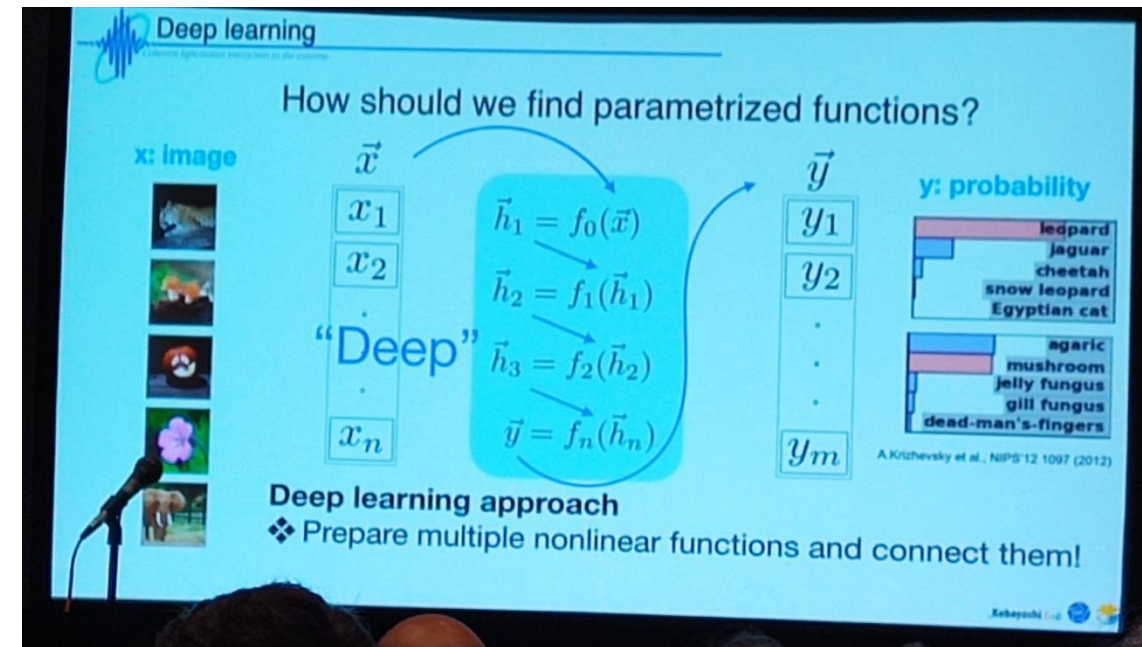
Intérêts

- Utilisation d'IA H24 pour BdD d'anticipation des usinages

## Informations clés

5 photos

- Deep learning basé sur une somme de fonctions simple
- Model 2D basé sur des vecteurs locaux pour tenir compte de la rugosité
- Appliqué aux multi pulses
- Appliqué à l'optimisation des paramètres
- Meister data generator : system tournant H24 laser+carac pour cumuler des données
- Metals hard to predict because based on roughness and amorphisation surface difficult to estimate.
- Question : rep rate? One shot data. Did not take into account accumulation effects yet
- From 1 material, transferable to another material? Not as easy but trying



30/01/2023

12411-20

High-quality cutting of heat-sensitive polymers with a high-power femtosecond UV laser

Auteur(s) Jim Bovatsek

Soc. / Lab. MKS Instruments

Intérêts • Usinage UV

## Informations clés

0 photos

- Laser 40 W – 1 MHz – UV
- Bonne qualité d'usinage sur des échantillons polymères transparents
- Découpe de PI épaisseur 75  $\mu\text{m}$
- Avantage de l'UV sur des matériaux polymères



30/01/2023

12411-22

## Generation of micro pillars by ultrafast first order bessel beam

Auteur(s) Valeria Viviana Belloni

Soc. / Lab. Femto st (Fr.)

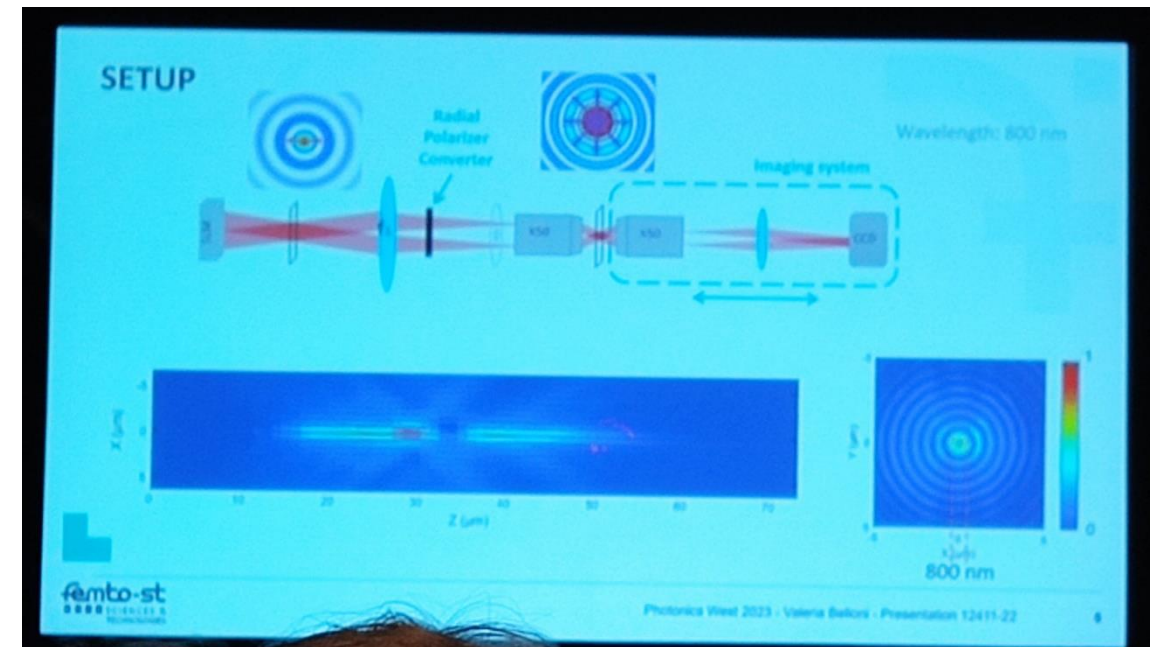
Intérêts

- Couplage de MEF sur verre pour fabrication de nano piliers sur verre

### Informations clés

3 photos

- Vortex beams / Bessel beams
- Bessel beams : 8mm thick glass cutting / Nanorprotusions
- Higher order bessel beams (bessel + vortex phase). SLM + focale + radial polarizer converter + focale + echantillon
- => piliers protubérants de quelques 100aine de nm de large et dizaine de microns de haut.
- Testé jusqu'à 1ps : ok ; 1kHz ;
- Matrix of pillars : 7 $\mu$ m spaced
- Surface anti-bactérienne mais temps d'usinage très long



### CONCLUSIONS

We obtained positive structures with Bessel beams radially and azimuthally polarized

We obtained structures up to 15  $\mu$ m in height with sub- $\mu$ m diameter

We propose a model for the pillar generation based on jet of liquid material

Applications: MEMS, NEMS, metamaterials, ...

Thank you for your attention!

femto-st

Photonics West 2023 - Valeria Belloni - Presentation 12411-22

22



30/01/2023

12411-23

Time-resolved measurement of stress wave profile during femtosecond laser processing of synthetic silica glass

Auteur(s) Junya Hattori

Soc. / Lab. University of Tokyo (Jap.)

Intérêts • Observation d'ondes de choc dans le verre

## Informations clés

0 *photos*

- Laser on glass : in air = shock wave ; in glass = stress wave. Optics express 27(20) . Fs laser drilling : stress wave causes cracks. Shock peening : residual stress due to stress wave improves material properties.

30/01/2023

12408-4

Advanced laser processing and its optimization with machine learning

Auteur(s) Andreas Michalowski (Ger.)

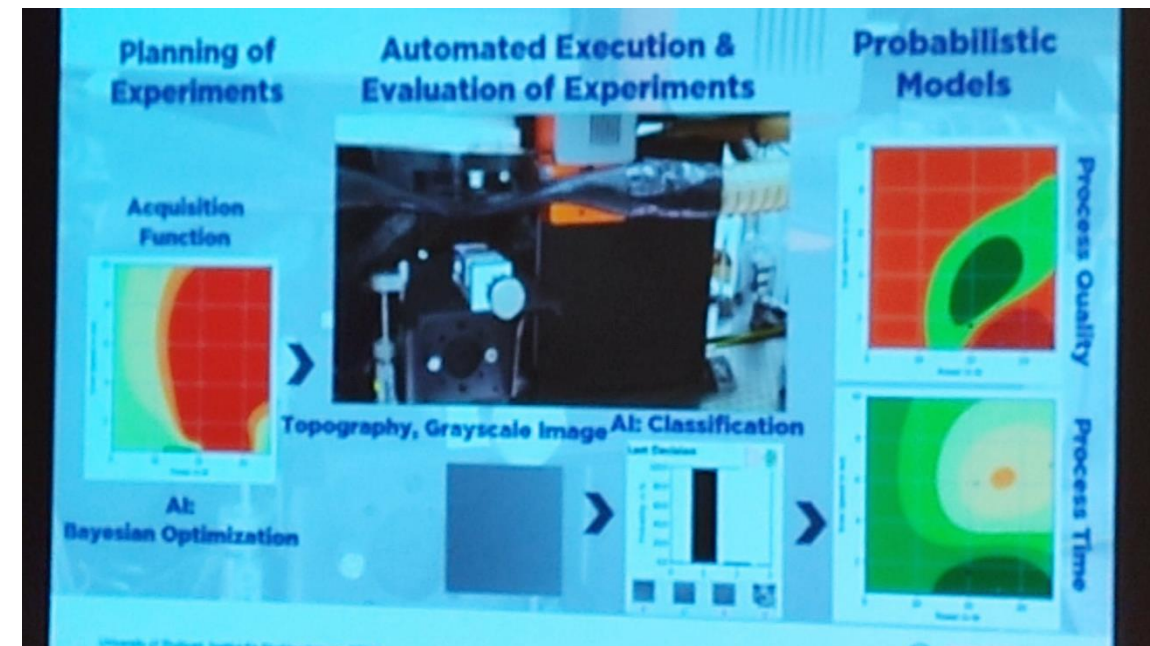
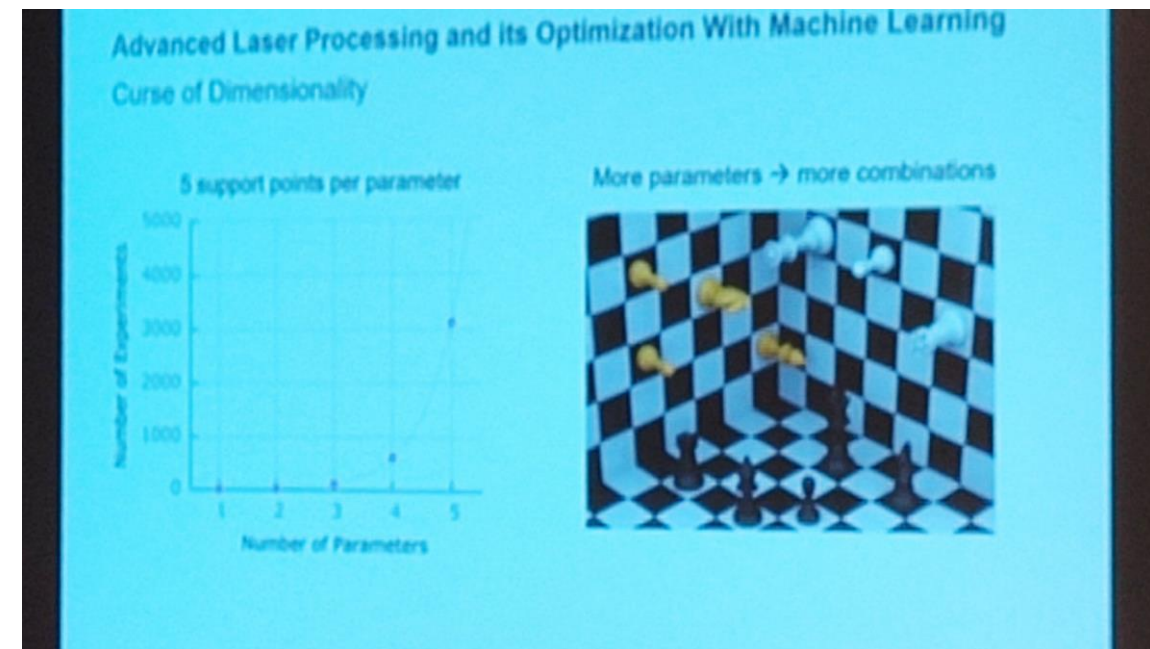
Soc. / Lab. IFSW

Intérêts • Approche IA pour usinage optimisé

## Informations clés

5 photos

- Qq noms de fusion bionic
- High power usp can work now continuously : one laser for all kind of processes + today Each kind process requires knowledge. => Deep learning aims at changing that
- New project addsub mix of 3D and laser ablation
- Photonics res 2200045 (2022) : smoothing with burst
- Step by step milling + smoothing
- Civan ultra fast beam shaping at kW
- High number of exp depending on number of param (expo). Can AI help?
- Bosh





30/01/2023

12411-24

Ultrafast laser microfabrication of guided wave components for spatial mode manipulation

Auteur(s) Robert Thomson

Soc. / Lab. Heriott Watt Univ. (UK)

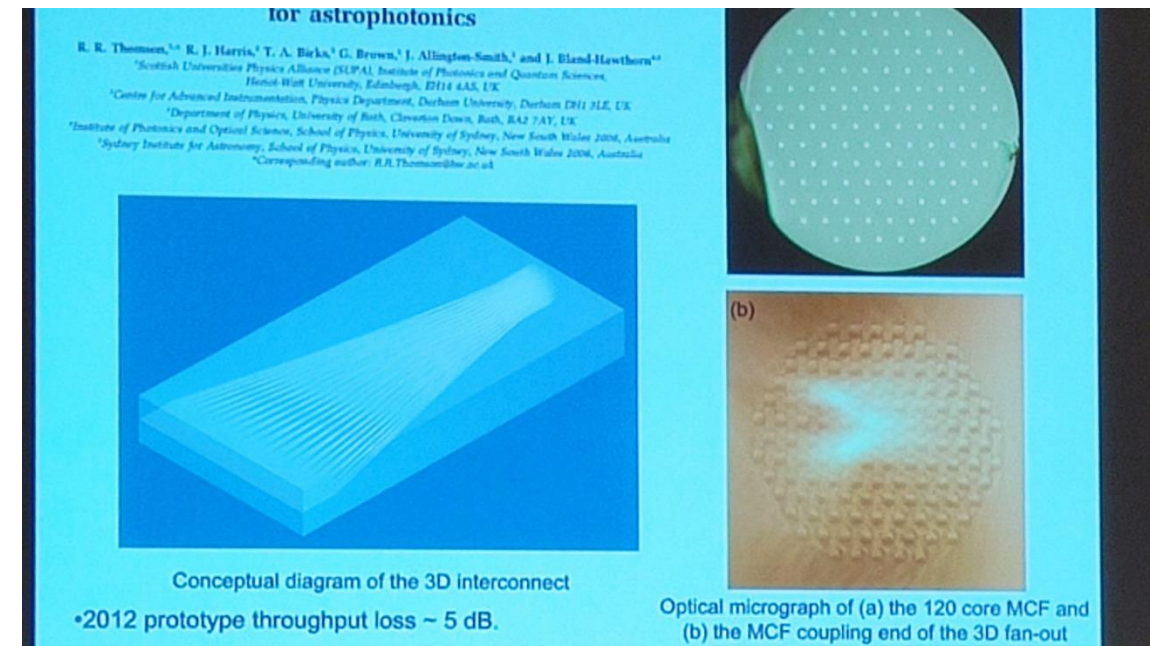
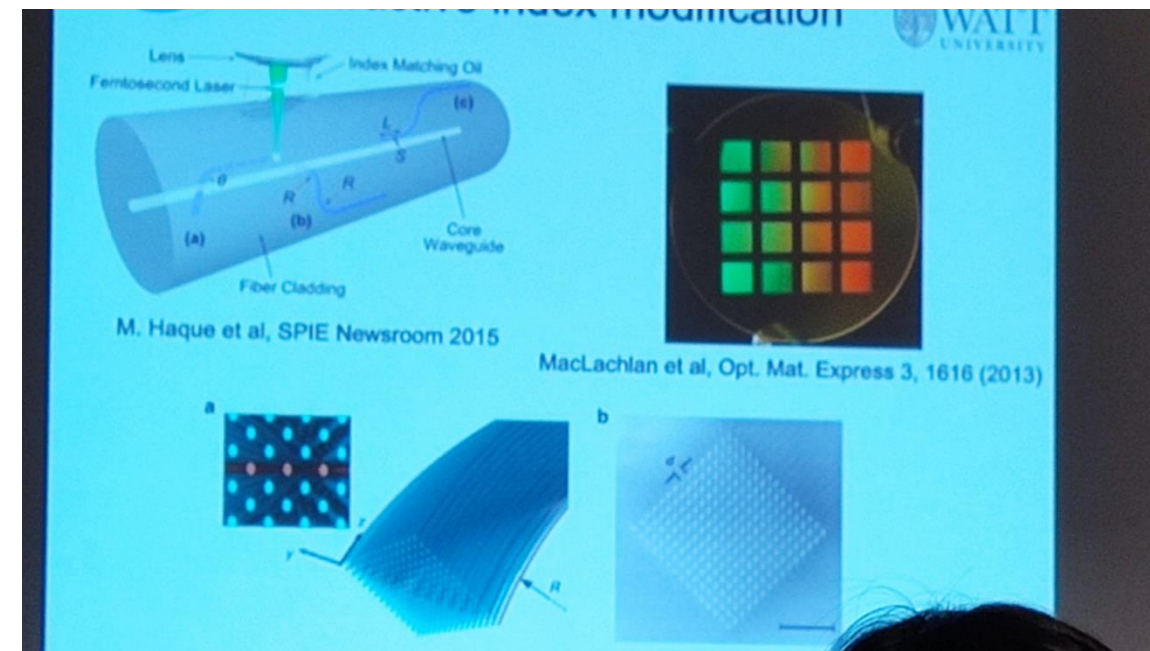
Intérêts

- Usinage dans la masse de verre pour du guide d'onde

Informations clés

4 photos

- Challenges for multiplex / demultiplex fibers => Use of USP laser bulk inscription of fused silica for integrated coupling systems
- MCF : Multi Core Fiber
- 3rd harmonic to see the refractive index change





30/01/2023

12411-25

Comparative study of laser-assisted etching using femtosecond laser pulses emitted at IR (1030 nm) and UV (343 nm) wavelengths

Auteur(s)    Benedikt Hermann

Soc. / Lab.    EPFL (Suisse) Polytechnique Lausanne

Intérêts    •    Usinage du verre sous UV + Etching

## Informations clés

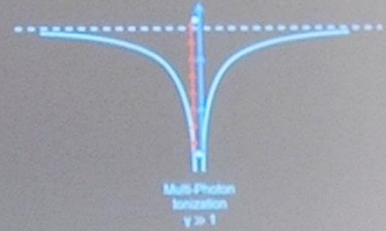
5 photos

- IR / UV use for photoinscription in Glass
- HF or NaOH etching solvent
- 100nJ / pristine material / NA 0.23 30mm working distance

### Introduction Ultra-Fast UV Pulses

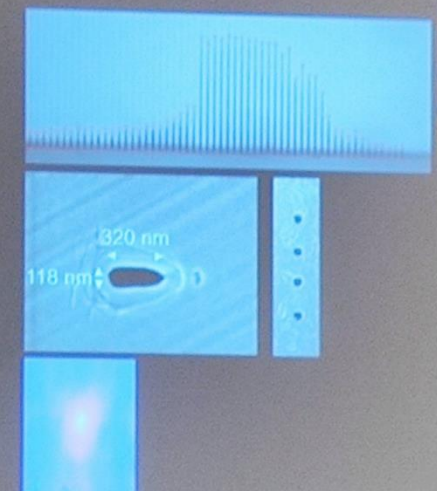
Why use UV instead of IR wavelength?

- Higher confinement, improved resolution
- Fewer photons needed for ionization
  - Lower pulse energy  
→ Less cumulative (thermal) effects
- Laser used in this study: Amplitude Tangor
  - Avg. power: 100 W (IR)
  - Pulse duration: 450 fs
  - Wavelength: 1030, 515, 343 nm
  - Focusing: Reflective Objective, NA: 0.23, WD: 30 mm



### Conclusions & Outlook

- Highly efficient etching regime using fs-UV
  - Etching rate up to 380  $\mu\text{m}$  / h (NaOH)
  - Low dose, few pulses (8-10 pulses /  $\mu\text{m}$ )
  - Laser rep. rate > 2 MHz
  - Machining speeds > 200 mm/s  
→ Galvo scanning or holographic writing
- Self-focusing → highly confined pores
  - Nano-scale fluidic devices
  - Porous membranes down to 100 nm
  - Photonic crystals
- Direct write waveguides with fs-UV
  - Few pulses (~4 pulses /  $\mu\text{m}$ )
  - Very high processing speeds: 500 mm/s  
→ Measurement of losses and refractive index



30/01/2023

12411-27

## First demonstration of a type 1 volume Bragg grating for the Vis-NIR applications

Auteur(s) Lauris Talbot

Soc. / Lab. Univ. Laval (Can.)

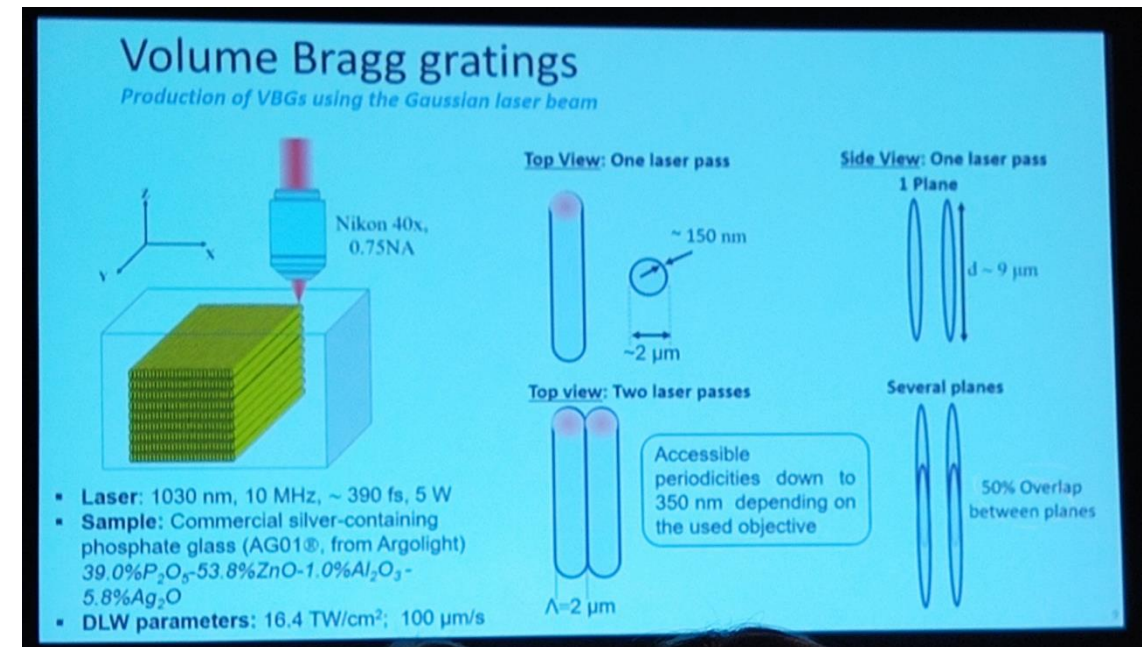
Intérêts

- Comparaison Gaussien / Bessel pour gravure de grating dans la masse de verre

## Informations clés

1 photos

- Fs IR writing of phosphate glasses (french company ArgoLight) never done but interesting because can be mixed with silver ions. High refractive index change
- New type of modification Type A
- Gaussian beam : Objective 40x,  $16.4 \text{ TW/cm}^2$  ;  $100 \mu\text{m/s}$  ; beam diameter  $2 \mu\text{m}$  with tangential lines. 3D gratings. So  $9 \mu\text{m}$  distance between horizontal planes, repeated to attain  $45 \mu\text{m}$  depth
- Fluorescence images excitation at  $375 \text{ nm}$  to see the index change
- Comparison with Bessel beam : axicon alpha  $2^\circ$ , focale  $100 \text{ mm}$ , x40 obj =>  $336 \mu\text{m}$  depth bessel ; Helium Neon diffraction characterization ;  $20 \mu\text{m/s}$  –  $5 \text{ TW/cm}^2$  . Much faster (1pass for all the depth) ; Almost 95% diffraction efficiency
- Eu project FUN GLASS





30/01/2023

12408-7

## Picosecond laser shock micro-forming of stainless steel

Auteur(s)

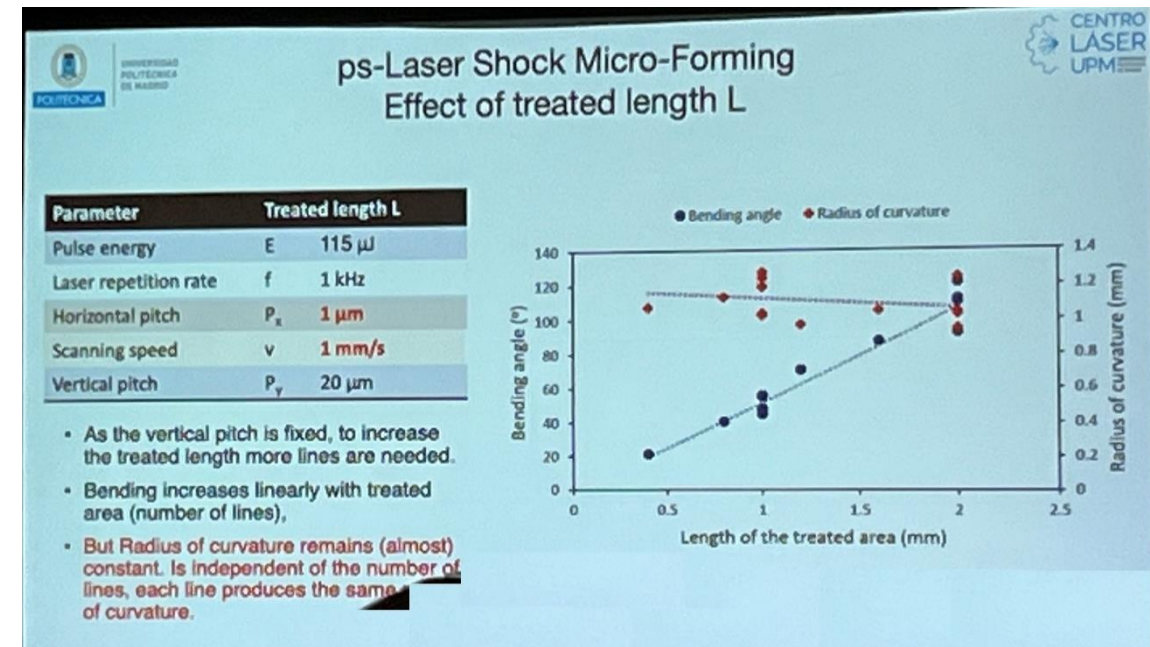
Soc. / Lab. Politecnica Madrid (Espagne)

Intérêts • Shock Pinning

## Informations clés

1 photos

- Utilisation du shock pinning pour améliorer la souplesse de l'Inox – mesure de la déformation après pliage
- Paramètres accessibles avec les outils Manutech





30/01/2023

12411-29

Beam shaping of high-energy beams for laser micromachining of transparent materials

Auteur(s) Vytautas Jukna

Soc. / Lab. Vilnius Univ. (Lit.)

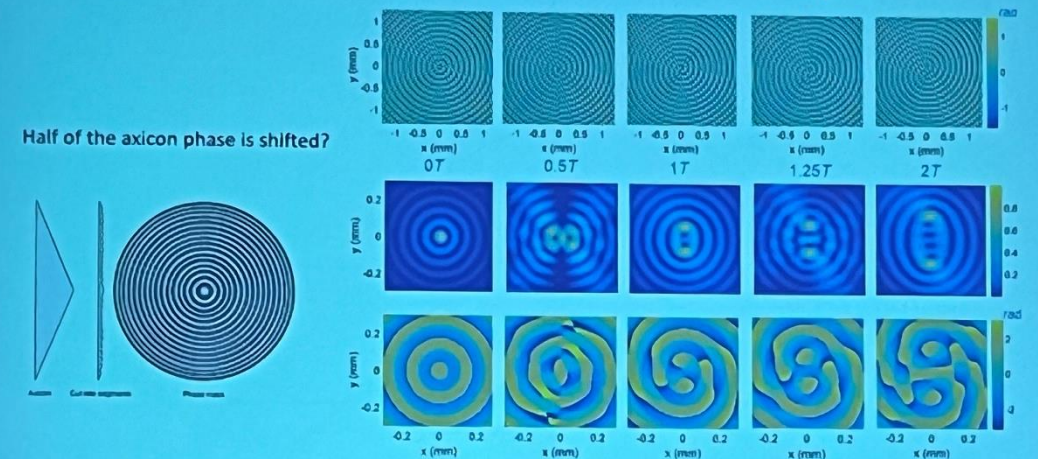
Intérêts • Nouvelles formes spatiales

## Informations clés

6 photos

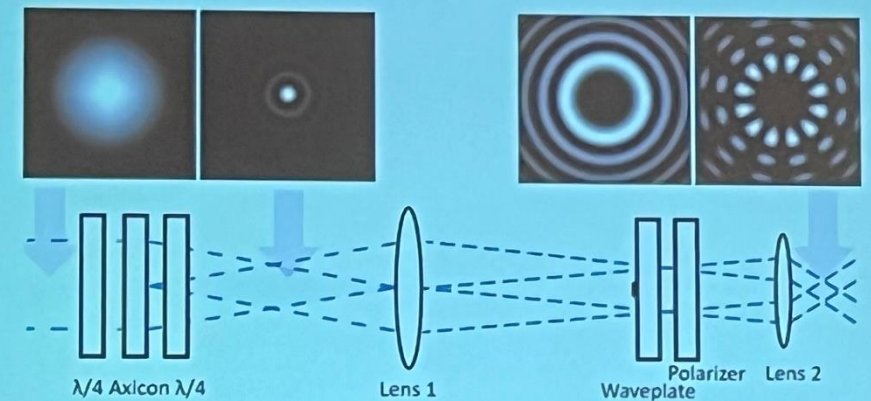
- How making higher order beams? Annular slits with vortex beam
- Amélioration des défauts du a l'angle des axicon en mettant un filtre circulaire (et pas disque) au niveau du cercle.
- Well, review of original beams

Is it possible to play with the axicon phase?



E. Nacijs, P. Gotovskis, O. Užinas, S. Orlov, A. Urbas, and V. Jukna, "Spatially displaced and superposed Bessel beams for transparent material laser microprocessing," *J. Opt. Soc. Am. B* 38, 3886-3895 (2021)

## Experiment scheme



30/01/2023

12411-30

## Laser glass cutting of complex contours with tailored edges

Auteur(s) Daniel Flamm

Soc. / Lab.    Trumpf (Ger.)

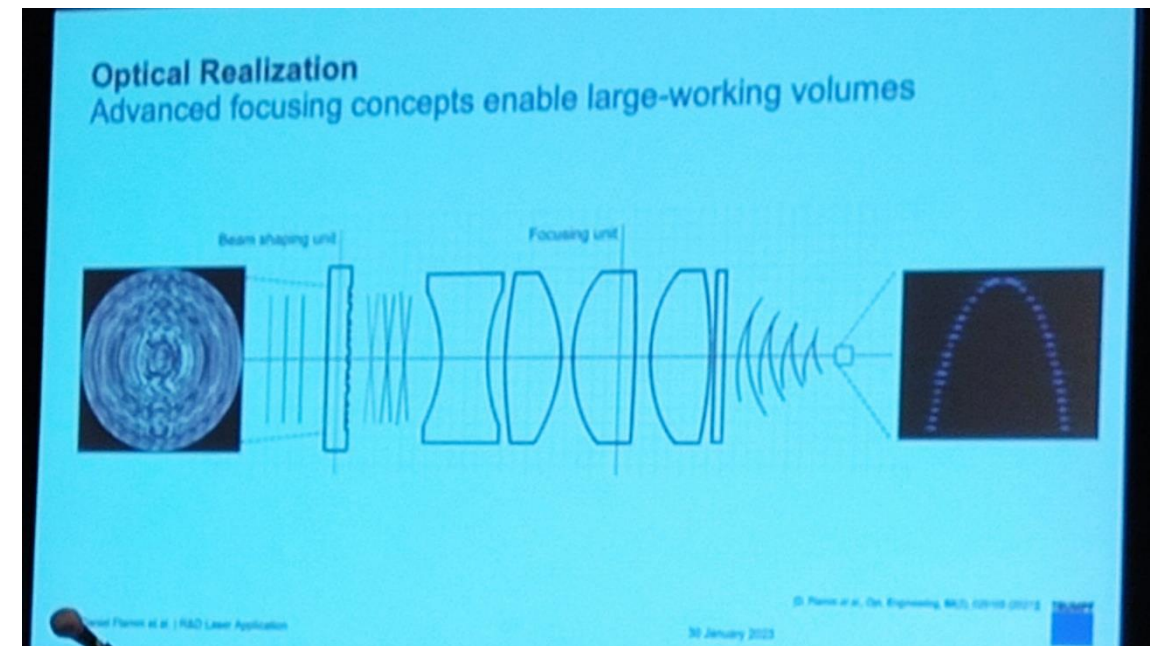
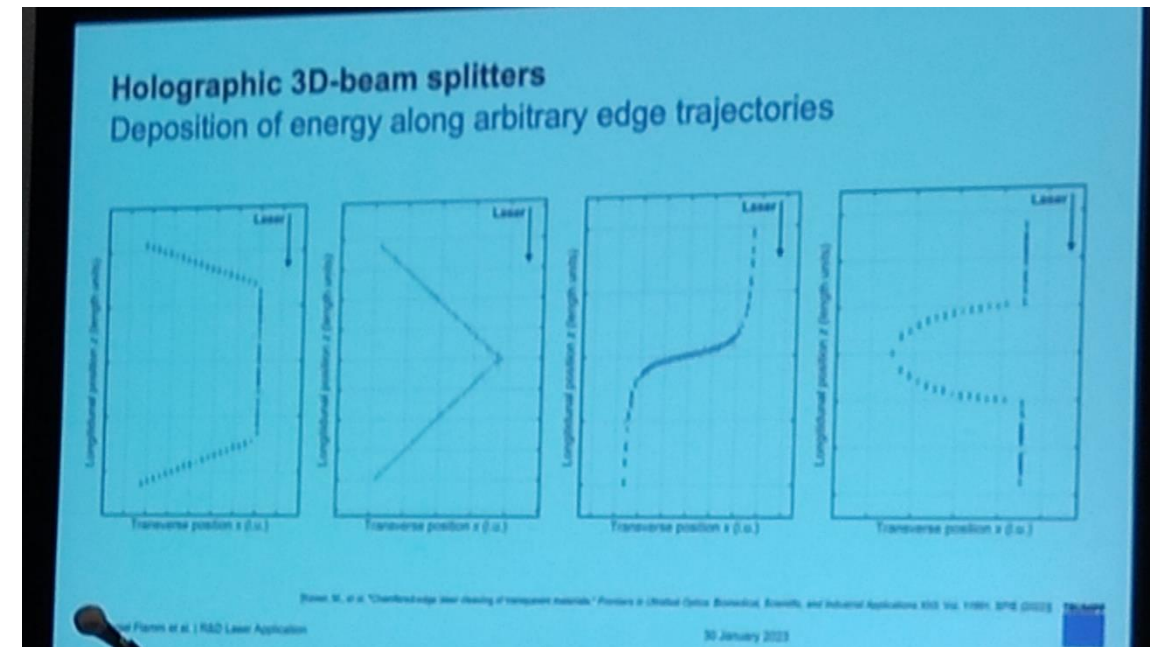
## Intérêts

- Multi point 3D dans la masse pour découpe de verre

## Informations clés

3 photos

- 8mm thickness Soda lime glass. Demo 10cm large in few seconds. 2 step process. 1 laser top cleave + CO2 laser
- Multipoint gaussian pour faire des courbes de découpe
- SLM first then DOE fabrication by 3D lithography in fused silica. Good DOE very small amount of zero order (~%)
- 200μJ Burst. NA 0.4, Single pass, rotation of workpiece during process
- Selective laser etching. CO2 laser aims at replacing chemical etching





30/01/2023

12411-32

## High power shaped femtosecond beams for riblets manufacturing

Auteur(s) Clemens Hönninger

Soc. / Lab. Amplitude (Fr)

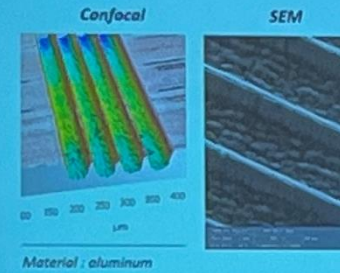
Intérêts • MEF Cailabs pour application aéro (riblets)

## Informations clés

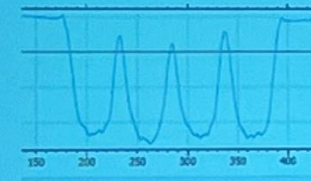
6 photos

- CHASSEUR Research project (french) : Cailabs / Onera / Alphanov / Amplitude
- Riblets : tens of microns grooves triangular shapes. Improves friction air flows aerodynamics
- 300W IR and 100W UV. Roadmap : 10mJ / 1kW laser
- Comparison Gaussian vs Beam Shaping : beam shaping more qualitative and time efficient
- Other laser : MultiPoint EU Project. 1kW laser

### Riblets manufacturing with gaussian beam



Material : aluminum



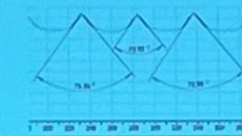
#### Standard Gaussian beam

- Beam diameter : 15  $\mu\text{m}$
- Number of lateral passes: 10

#### Process parameter

- Laser Fluence : 0.9 J/cm<sup>2</sup> @ 2 MHz
- Longitudinal pulse overlap : 70%
- Number of passes = 34

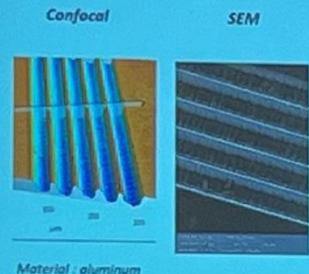
#### Results



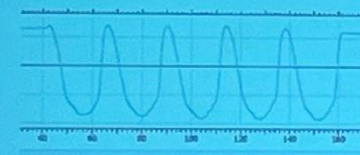
Too high →  $s = 52,4 \mu\text{m}$   
 $h = 15,2 \mu\text{m}$   
 $L = 18,3 \mu\text{m}$

Too high →  $\alpha = 74^\circ$

### Riblets manufacturing with square top hat beam



Material : aluminum



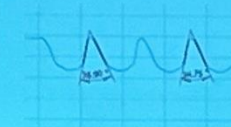
#### Square top hat beam

- Beam size : 15  $\mu\text{m}$
- Number of lateral passes: 1 (no lateral overlap)

#### Process parameter

- Laser Fluence : 0.9 J/cm<sup>2</sup> @ 2 MHz
- D = 24  $\mu\text{m}$
- Longitudinal pulse overlap: 70%
- Number of passes = 21 (Longitudinal overlap: 70%)

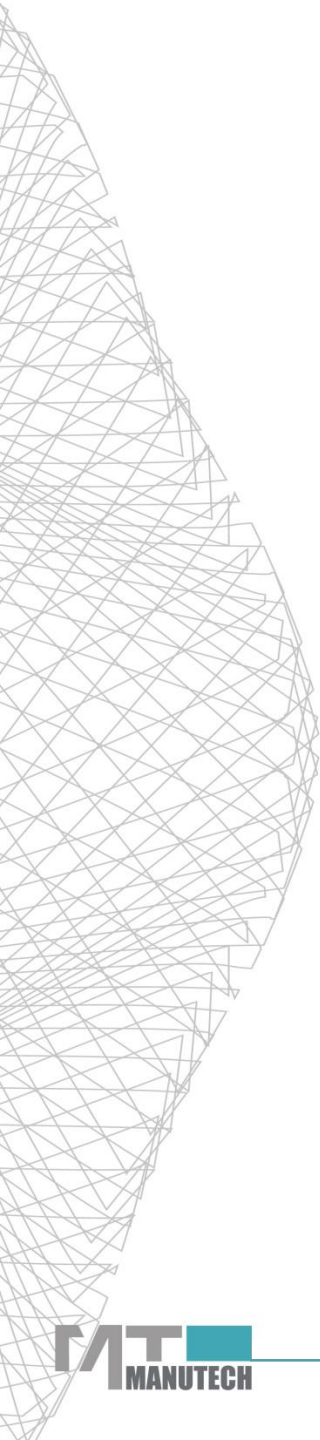
#### Results



$s = 24 \mu\text{m}$   
 $h = 15,3 \mu\text{m}$   
 $L = 13 \mu\text{m}$   
 $\alpha = 35^\circ$

Similar to  $\Phi 7 \mu\text{m}$  gaussian beam with 13 passes !





Mardi 31-01-2023

31/01/2023

12411-34

## Ultrashort pulse laser processing of silicon

Auteur(s) Stefan Nolte

Soc. / Lab. University of Jena (Autr.)

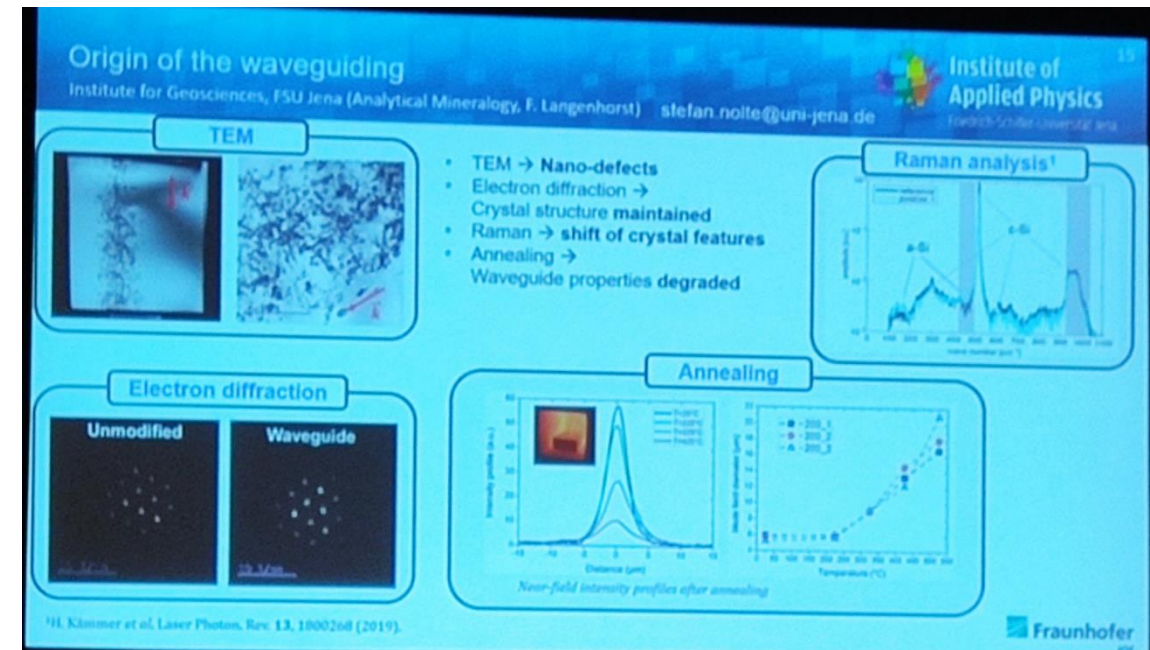
Intérêts

- Nouvelle longueur d'onde pour usinage dans la masse de silicium

## Informations clés

2 photos

- G. Matthaus Optics express 26 24089 (2018)
- 1.55 $\mu$ m, 800fs, 400kHz, 20 $\mu$ m/s, <200nJ for waveguide photoinscription inside Silicon
- Guiding @1.55 $\mu$ m
- Generation of nanodefects in the monocryst material observed by TEM / shift of crystalline structure by Raman / Annealing
- InGaAs camera observation
- Perspectives Metal/semicond. Welding





31/01/2023

12408-15

Laser micro-drilling of glass materials with high-speed laser modulation and real-time monitoring toward data-driven laser processing

Auteur(s)

Soc. / Lab.

National Institute of Advanced Industrial Science and Technology (Japan)

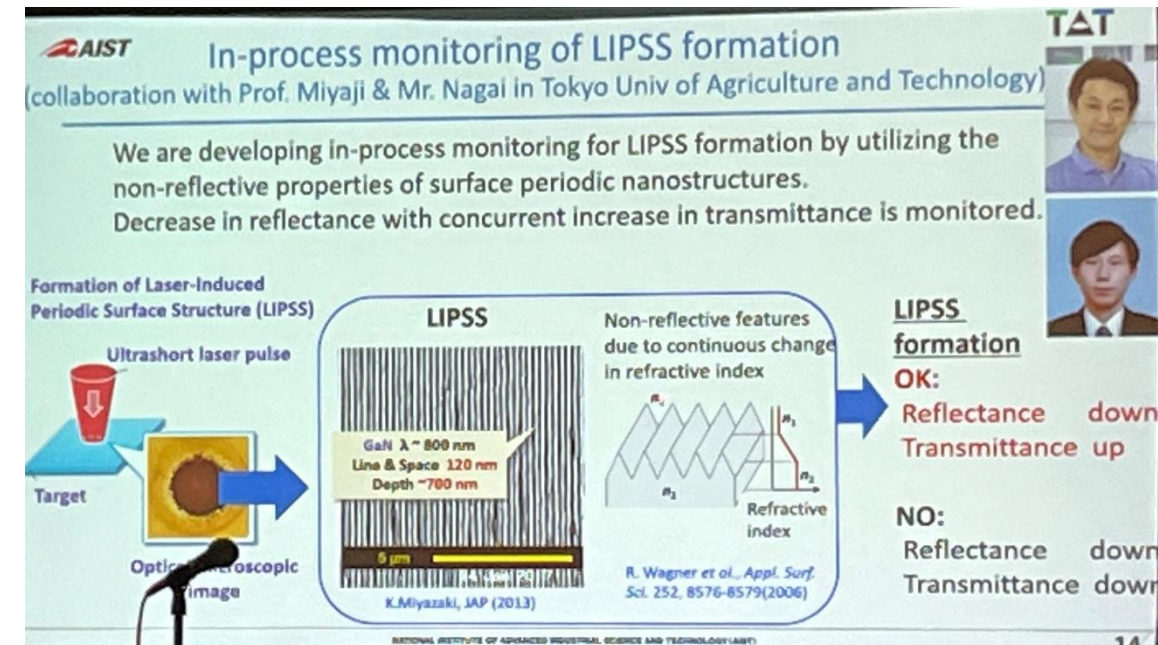
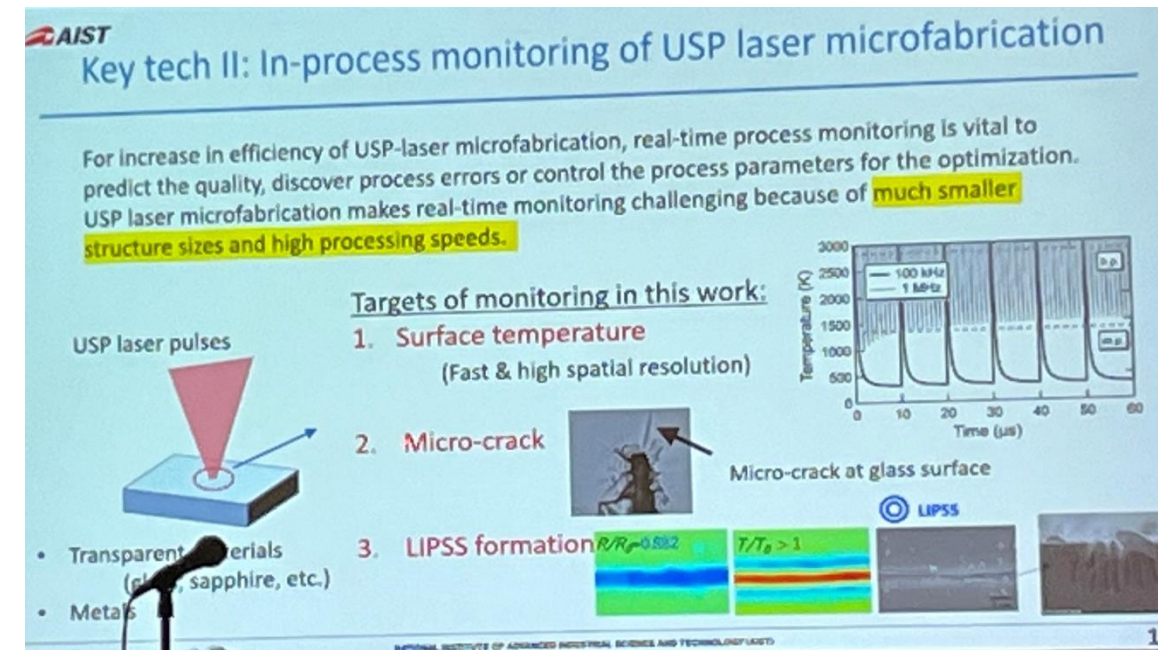
Intérêts

- Contrôle du Process en direct

Informations clés

2 photos

- Mesure de la température à la surface de la matière
- Différents modes de burst en MHz, avec énergies par pulse au sein du burst croissantes ou décroissantes
- Monitoring de la formation des LIPSS





31/01/2023

12408-14

Laser fabrication of length controlled sub  $\mu\text{m}$  periodic structures in the bulk of fused silica

Auteur(s) Nicolas Sanner

Soc. / Lab. LP3 (Fr.)

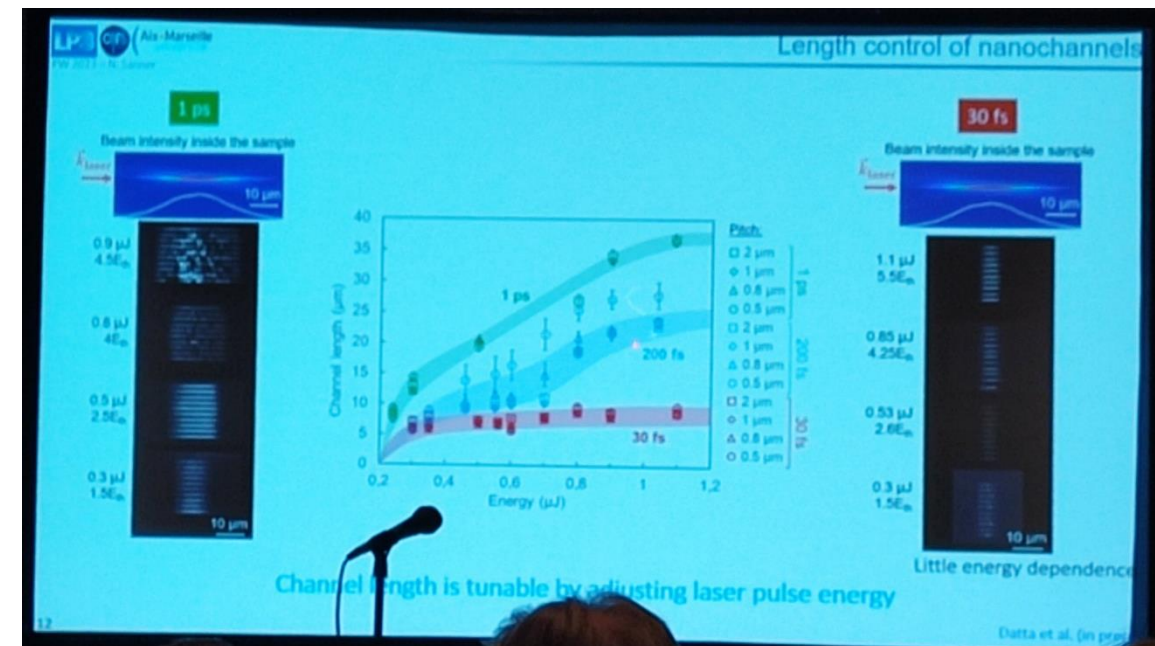
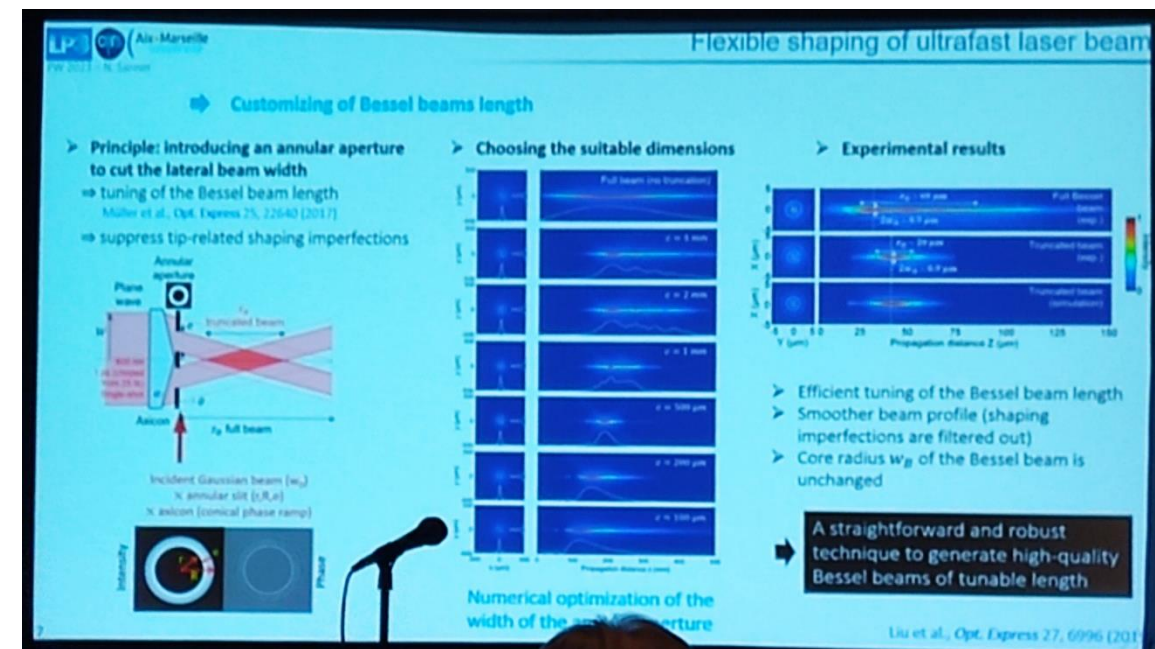
Intérêts

- Bessel dans la masse de verre

Informations clés

6 photos

- Fused silica
- Shaping customized bessel beams : principle introduction of a ring to filter just after the axicon : modify the length of the beam
- 1ps (longer interaction) / 200fs / 30fs. 1 channel = 1 shot
- $\mu\text{channel}$  inscription. Comparison of 1ps/300fs/30fs and nuancier Energy vs pitch between bessel engraved grooves
- Motivation : creation of metasurfaces / photonic crystals due to good spatial dimensions of inscription





31/01/2023

12408-15

Laser micro drilling of glass materials with high speed laser modulation and real time monitoring toward data driven laser processing

Auteur(s) Aiko Narazaki

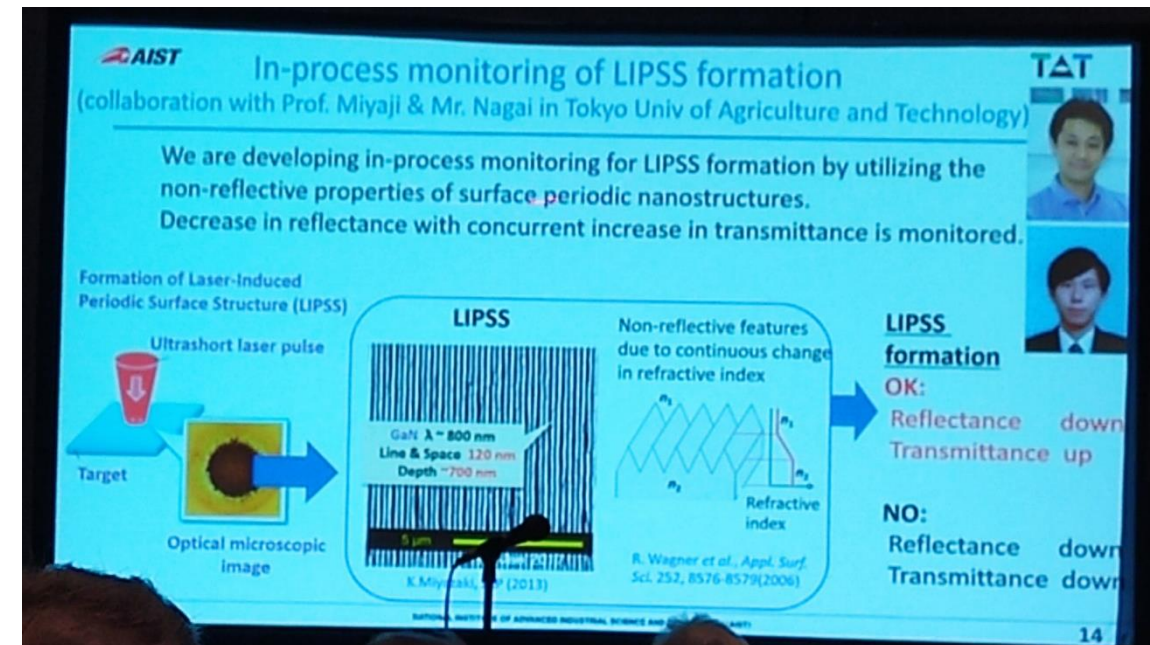
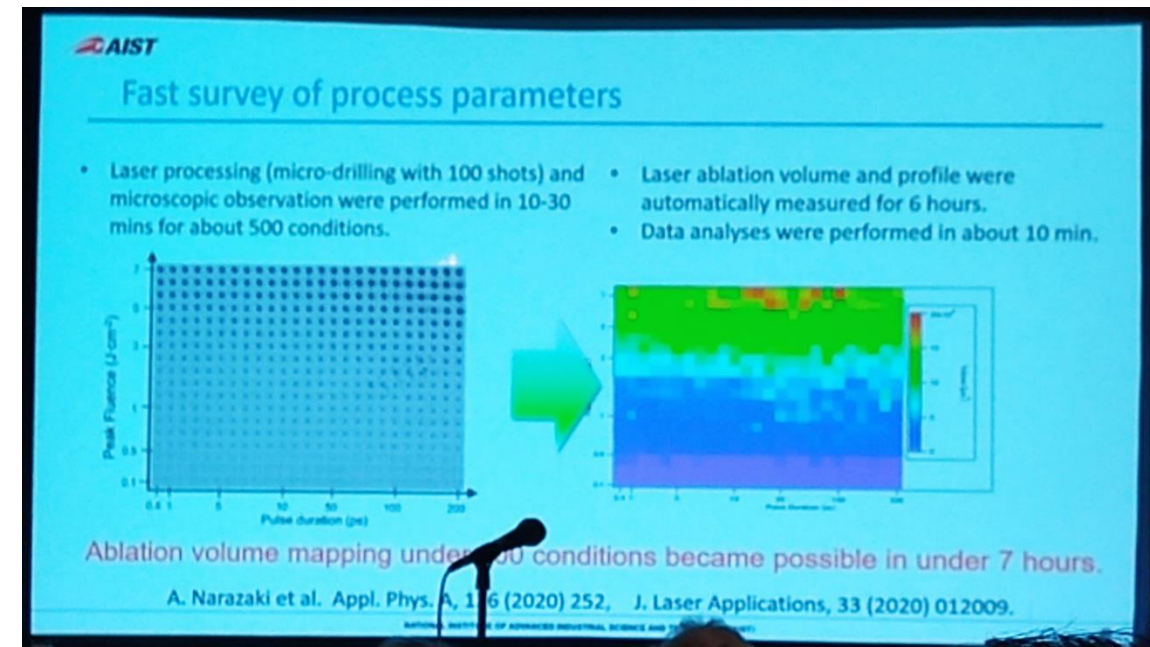
Soc. / Lab. AIST (Jap.)

Intérêts • Assistance à l'usinage de verre par BdD AI

## Informations clés

4 photos

- DDALP : data driven active laser processing : processing => real time monitoring => AI => parameter optimization
- Ex 1 glass : Cost effective, efficient, robust... but  $\mu$ cracks, brittle...
- Home made laser : 1 laser 400fs to 400ps. MHz...
- Nuancier => carac ablation volume & profile in 6h and data analysis in 1h.
- Applied to GHz burst. Ramp up / down 1MHz. Down more efficient on ablation <50 pulses
- Ex 2 LIPSS formation on glass: reflectance down / transmittance up if LIPSS formation => In process monitoring of LIPSS formation successful



31/01/2023

12408-16

## Fs GHz burst laser processing for percussion drilling applications

Auteur(s) Clemens Hönninger

Soc. / Lab. Amplitude (Fr.)

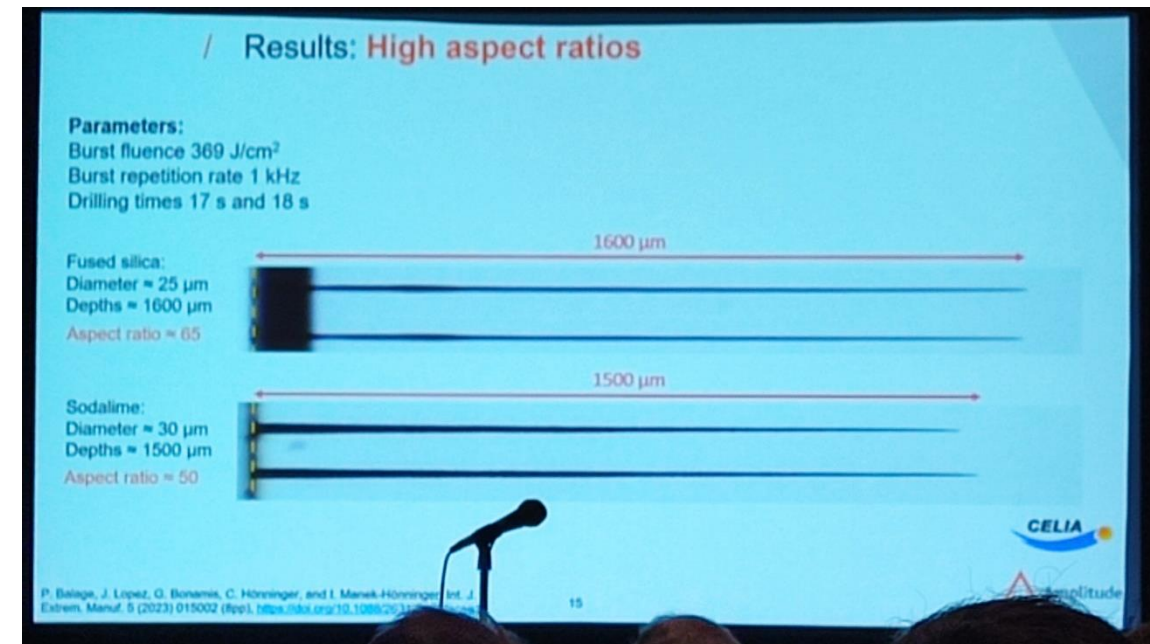
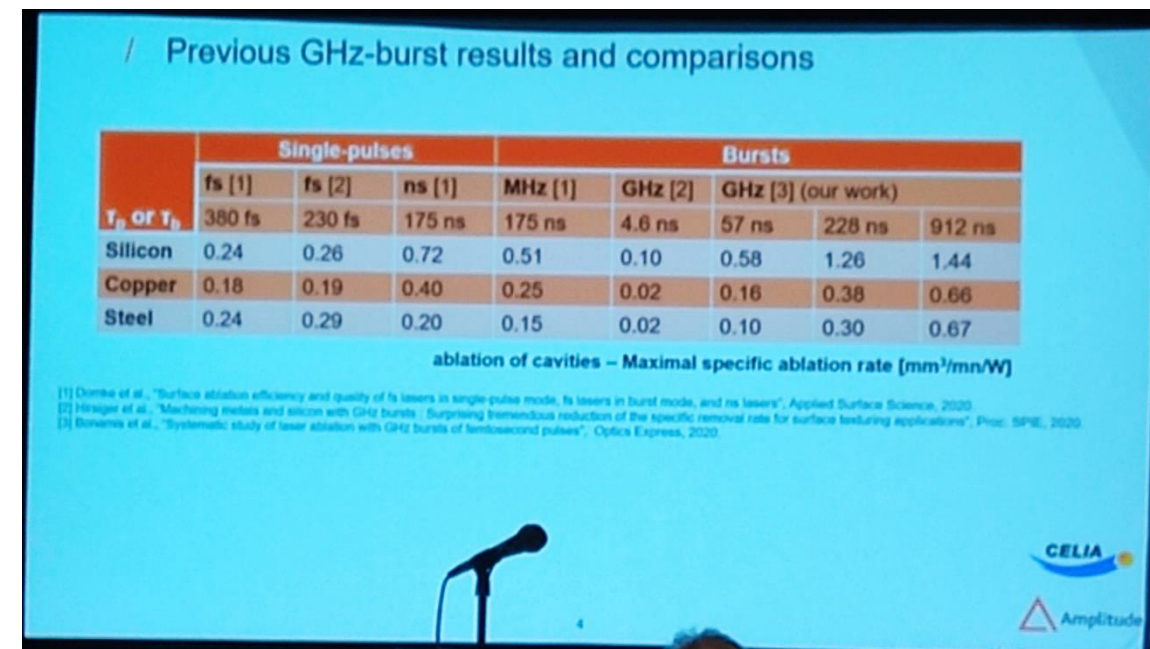
Intérêts

- Efficacité du burst sur verre

## Informations clés

9 photos

- Metals :
  - Shorter GHz bursts are less efficient than single fs shots
  - Inverted trend with longer bursts.
- High speed drilling up to 1mm deep with adapted GHz in glass
- 3 régimes : Surface ablation / Deep ablation / Saturation
- Observation of the number of burst per shot :





31/01/2023

12409-4

A study on the incubation effect during multi-shot fs laser ablation of quartz

Auteur(s)

Soc. / Lab. Univ degli Studi di Bari Aldo Moro (Italie)

Intérêts • Influence de la cadence

Informations clés

- Laser Pharos de Light Conversion
- F-théta de 100 mm
- Cadence 100 kHz
- Réalisation de nuanciers sur échantillon de Quartz

2 photos

## Incubation models

### 9 Three main incubation models proposed in literature

Power Law model by Jee et al (1988):

$$F_{th}(N) = F_{th}(1)N^{S-1}$$

Mod.Power Law model by Di Niso et al (2014):

$$F_{th}(N) = F_{th}(\infty) + [F_{th}(1) - F_{th}(\infty)]N^{S-1}$$

Exponential model by Ashkenasi et al (1999):

$$F_{th}(N) = F_{th}(\infty) + [F_{th}(1) - F_{th}(\infty)]e^{-k(N-1)}$$

Laser-induced damage on single-crystal metal surfaces

Yong Jee, Michael F. Becker, and Rodger M. Walser  
Center for Materials Science and Engineering, The University of Texas at Austin, Austin, Texas 78713-1084  
Received May 14, 1987; accepted October 6, 1987

Role of heat accumulation on the incubation effect in multi-shot laser ablation of stainless steel at high repetition rates

Francesca Di Niso,<sup>1,2</sup> Caterina Gaudioso,<sup>1,2</sup> Teresa Sibillano,<sup>1</sup> Francesco Paolo Mezzapesa,<sup>1,2</sup> Antonio Ancona,<sup>1,2</sup> and Pietro Mario Lugari<sup>1,2</sup>  
<sup>1</sup>Istituto di Fisica e Nanotecnologie (IFN-CNR) U.O.S. Bari, via Amendola 173, I-70126 Bari, Italy  
<sup>2</sup>Università degli Studi di Bari, Dipartimento Ingegneria di Fisica, via Amendola 173, I-70126 Bari, Italy

Surface damage threshold and structuring of dielectrics using femtosecond laser pulses: the role of incubation

D. Ashkenasi<sup>\*</sup>, M. Lorenz, R. Stoian, A. Rosenfeld  
Max-Born-Institut für Nichtlineare Optik und Kurzzeitspektroskopie, Rudower Chaussee 6, 12489 Berlin, Germany  
Received 15 February 1999; accepted 9 April 1999

## Influence of repetition rate f

| f [kHz] | $F_{th}(\infty)$ [J/cm <sup>2</sup> ] | $F_{th}(1)$ [J/cm <sup>2</sup> ] | k [-]         |
|---------|---------------------------------------|----------------------------------|---------------|
| 0.06    | 1.67 ± 0.05                           | 6.47 ± 0.05                      | 0.054 ± 0.004 |
| 6       | 1.68 ± 0.06                           | 6.02 ± 0.30                      | 0.051 ± 0.009 |
| 60      | 1.73 ± 0.05                           | 6.42 ± 0.32                      | 0.058 ± 0.007 |
| 200     | 1.71 ± 0.08                           | 6.23 ± 1.13                      | 0.063 ± 0.013 |

No repetition rate trend for both  $F_{th}$  and k



Average values:

$F_{th,av}(1) = 6.29 \pm 0.23 \text{ J/cm}^2$

$F_{th,av}(\infty) = 1.70 \pm 0.06 \text{ J/cm}^2$

$k_{av} = 0.058 \pm 0.006$

31/01/2023

12408-17

Advanced high res. Cylinder structuring with parallel Bessel beams under use of UV fs laser irradiation

Auteur(s) Martin Osbild

Soc. / Lab. Fraunhofer ILT (Ger.)

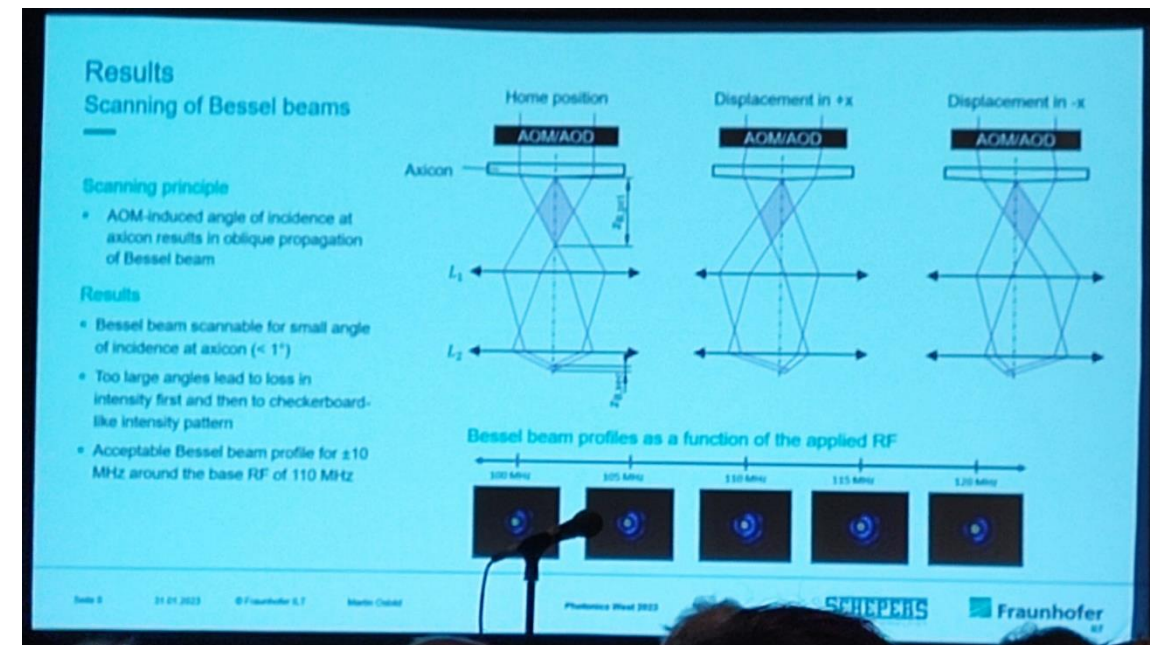
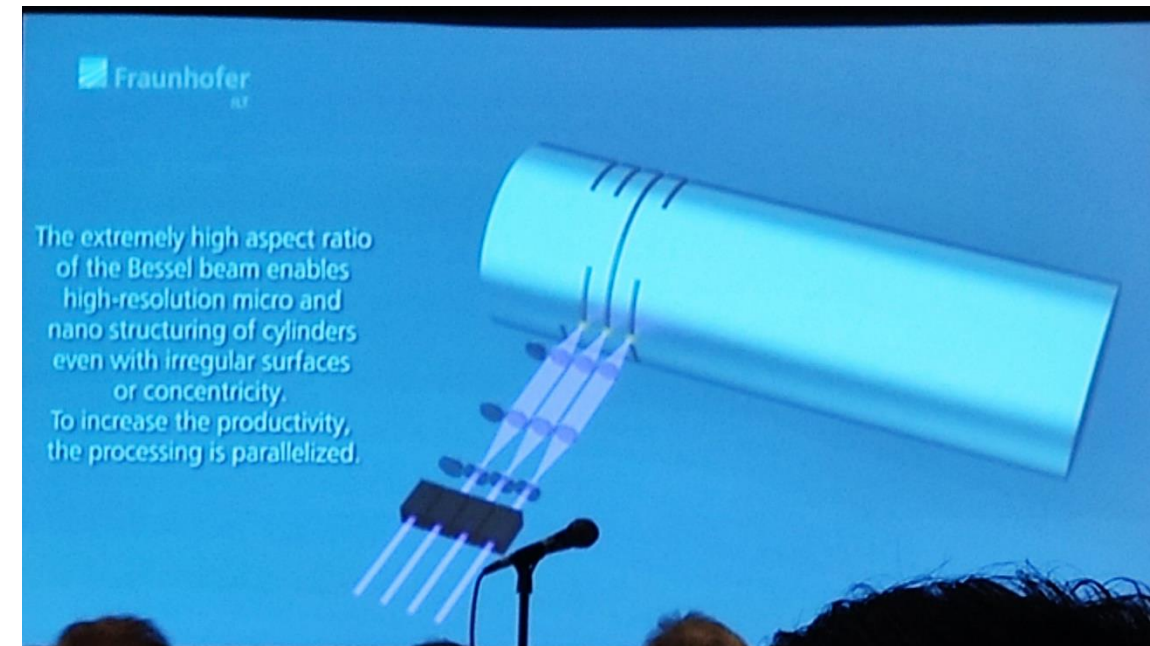
Intérêts

- Mise en forme haute vitesse de Bessel par AOM

## Informations clés

5 photos

- Green wavelength / Beam splitting with AOM
- Cylinder texturing as bone screws
- To avoid spiral misalignments during continuous rotation/translation of the processing, use of deflection high speed AOM to correct
- Upgrading with 1  $\mu\text{m}$  Bessel beam (hard to achieve with Gaussian with high tolerance) Axicon 170°, f75mm + 25mm asphere
- Bessel beam characterization : x20 microscope + f400mm+camera : Gaussian fit of the center => Formule calcul de fluence (PROCEEDING)
- Metamorphia project
- UKP Workshop (26-27 / 04 / 2023) & AKL 17-19 / 04 / 2024





31/01/2023

12408-18

## Ultrafast nanostructuring utilizing interference technics and plamonics effects

Auteur(s) Jürgen Ihlemann

Soc. / Lab. IFNANO (Institute for nanophotonik, Ger.)

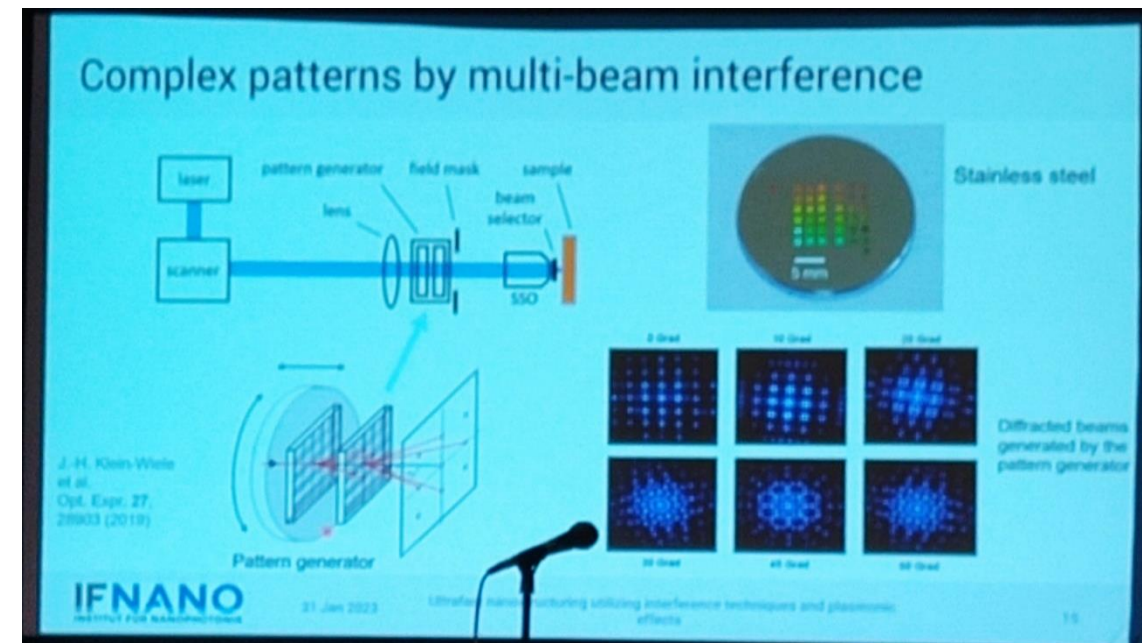
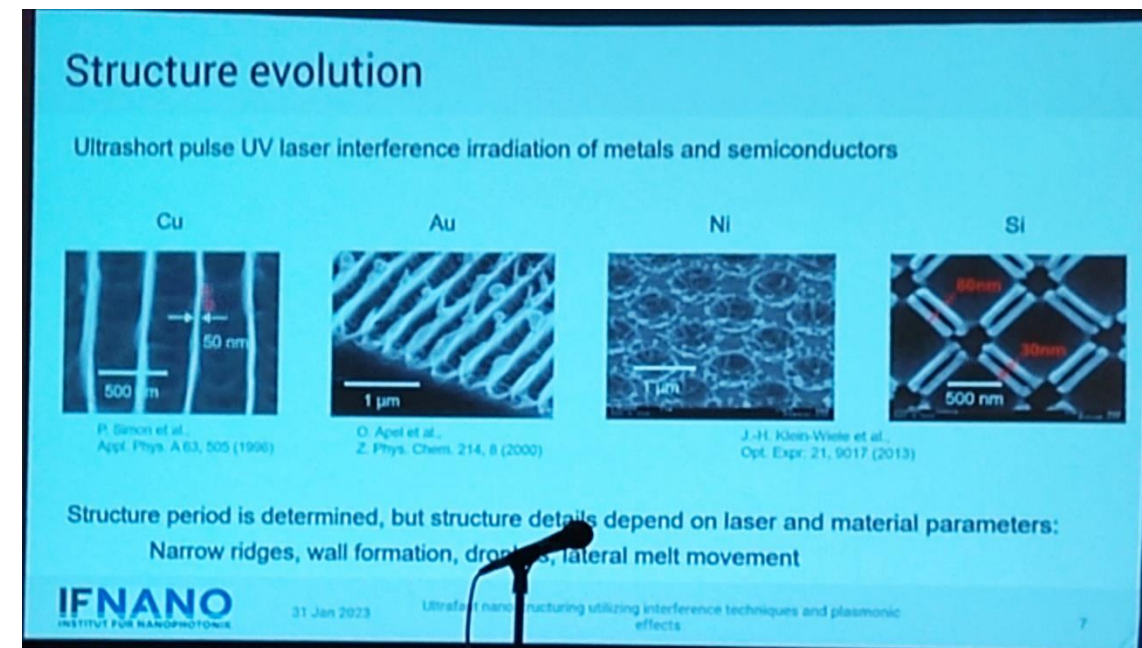
Intérêts

- DLIP UV
- Autre technique de génération DLIP par réseaux

## Informations clés

5 photos

- UV DLIP
  - 2 gratings : one for diffraction / one for recombination
  - Gold : sharp linear walls <100nm opened from a bump groove. With water, bump groove stays without bursting
  - Complex interference : Opt. Exp. 27, 28903 (2019)
- LIPSS theory : Interference with surface plasmon polariton (SPP) due to defects



## Ultrafast laser processing of flexible ultrathin glass

Auteur(s)

Soc. / Lab. Trumpf (filiale Chinoise)

Intérêts • Découpe du verre

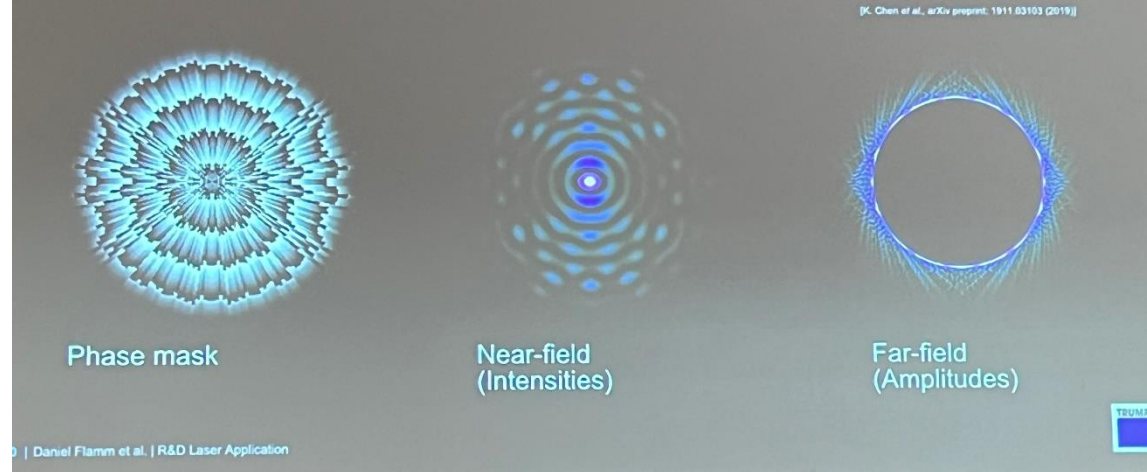
## Informations clés

- Il est important d'avoir un faisceau circulaire, l'astigmatisme favorise les cracks de matière
- Dans le cadre d'un faisceau ovale, il faut écarter les spots pour une meilleure qualité
- Axicon diffractif fabriqué via grey-tone en lithographie
- Création de faisceaux de Bessel par mise en forme, en jouant sur le masque de phase, ils obtiennent des profils différents, qui peuvent favoriser la propagation des cracks et donc du clivage. Un Bessel elliptique favorise la coupe et la qualité de la coupe du verre

5 photos

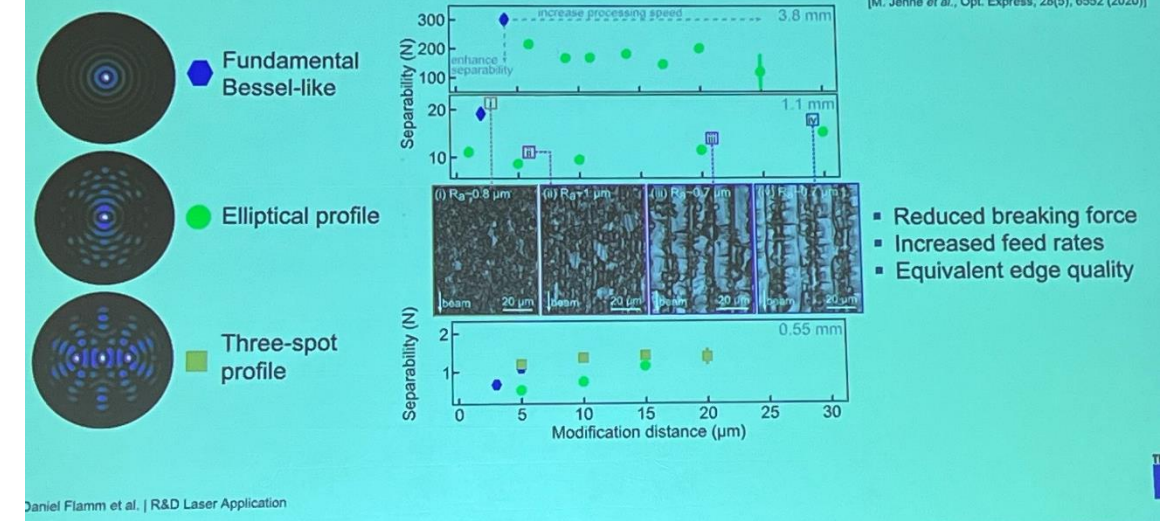
### Generalized Axicons

Disturbing the constructive on-axis interference



### Elliptical Modifications from Tailored Non-diffracting Beams

Facilitated glass separation





31/01/2023

12409-6

The formation of ultrafast laser-induced periodic nano- and micro-ripples on fused silica

Auteur(s)

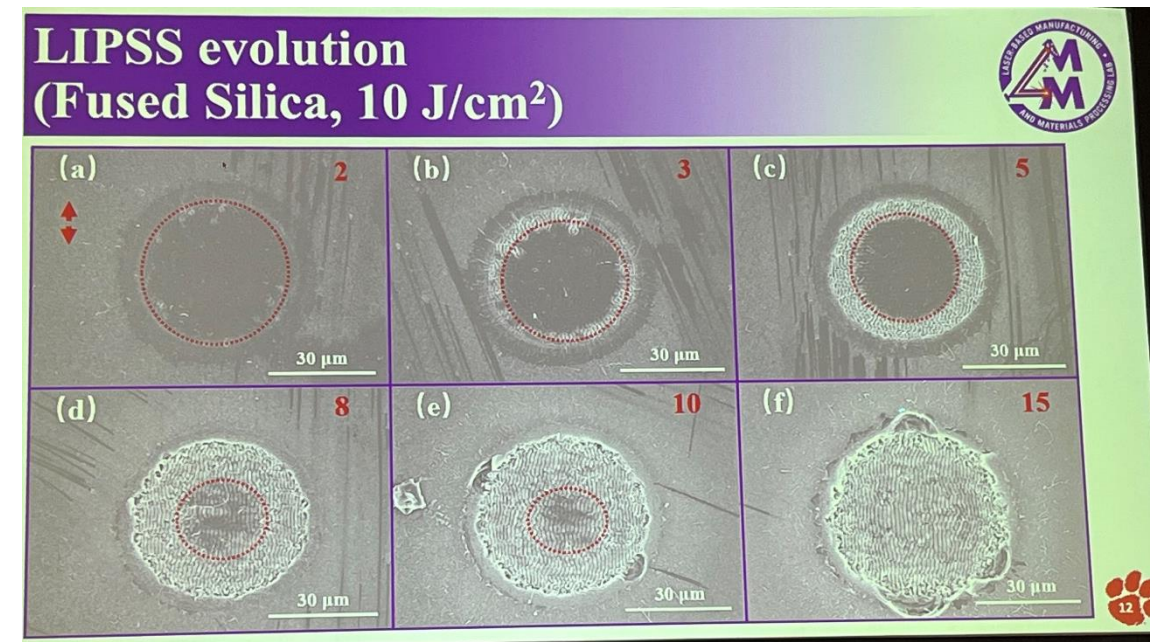
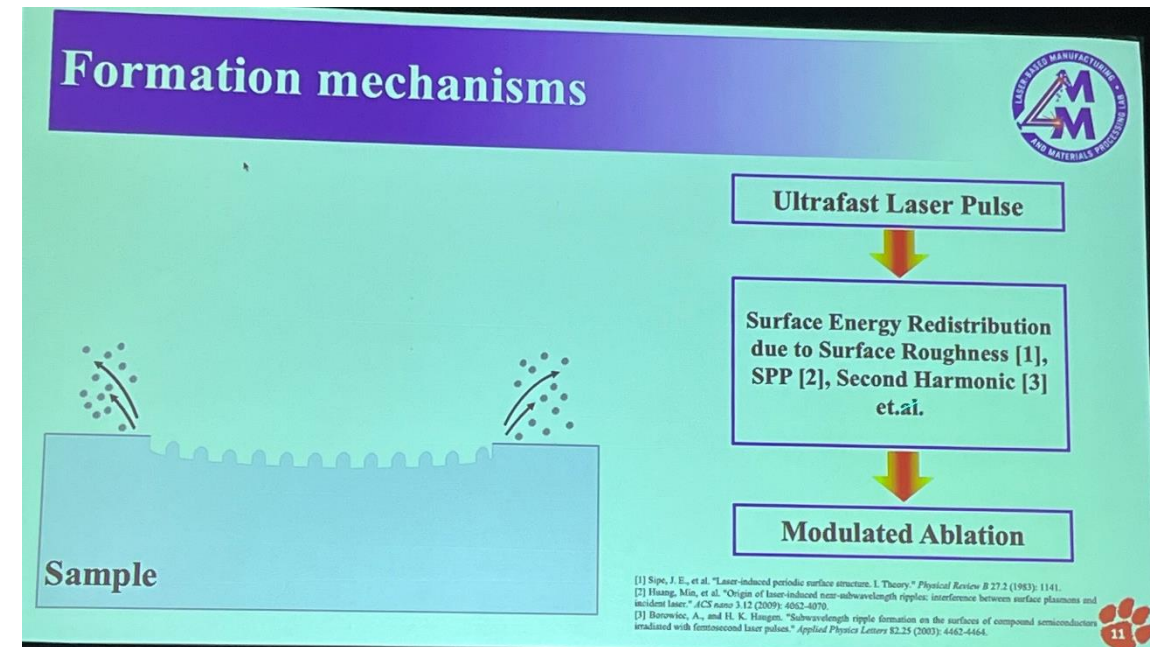
Soc. / Lab. Univ Clemson USA

Intérêts • LIPPS sur verre

Informations clés

3 photos

- Laser Pharos @ 1030 nm
- Sur le Fused Silica, les LIPSS sont parallèles à la polarisation
- Applications de mouillage sur du verre, hydrophile, super-hydrophile
- En rouge sur la photo, c'est le nombre d'impulsions qui évolue, on voit l'apparition des ripples. La zone centrale qui n'a pas de ripples est une zone fondue





31/01/2023

12411-41

Active and passive new optical fibers for laser development and beam delivery

Auteur(s) Eric Mottay

Soc. / Lab. Amplitude (Fr.)

- Intérêts
- Tenue au flux fibres femto
  - 2 axes fibres pleines (cavité) et creuses (transport)

Informations clés

3 photos

- Single mode polarisation maintaining fiber
- Fibrage Satsuma chez Alphanov avec bras robot, marquage de LIPSS en mouvement robot pour valider que la polarisation en sortie de fibre est stable
- High efficiency transmission
- 2 tests :
  - Non moving fiber : can handle 500μJ
  - Moving fiber : up to 50W

## / The 4F program



- > Part of French program "Investment for the future", aimed at fostering innovation and competitiveness
- > The 4F project aims to develop and manufacture a **new generation of optical fibers**, and **fiber lasers** suitable for the industrial manufacturing of tomorrow.
- > 4F consortium consists of fiber laboratories and technology centers, and industrial companies



## / Beam Delivering System

GLOphotonics

GLOphotonics

BOS HP-STB-PM

Unlocks the true potential of laser manufacturing with our

Polarization Maintaining

Beam Delivery System

NEW

Shake it, bend it, twist it... it still performs flawlessly

EXCEPTIONAL STABILITY WHILE CABLE IN MOTION

ULTRA HIGH PER

POWER STABILITY <3%

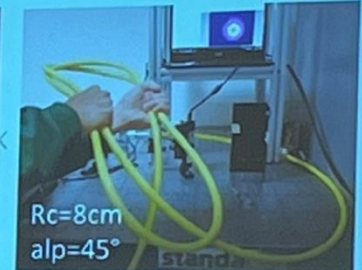
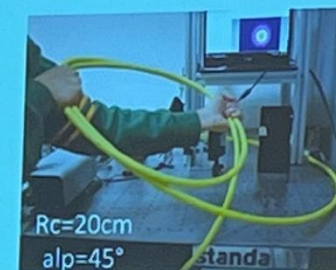
BEND-POINT STABILITY <1%

POLARIZATION STABILITY <1%

34dB

BOOTH 1056

- Non moving fiber : up to 500 μJ, 200 kHz
- Moving fiber : 51 W (transmission 90 %)





31/01/2023

12408-19

Surface functionalization of transparent materials : high throughput meet high resolutions

Auteur(s) Laura Gemini

Soc. / Lab. Alphanov (Fr.)

Intérêts • DLIP IR et UV sur du sapphire

## Informations clés

- DLIP IR 2 faisceaux : interplay LIPSS + DLIP
- DLIP uv 4 faisceaux on sapphire
- Constraint of a large focusing lens!

4 photos

DLIP // Stainless Steel

ALPhA NOV  
Optics & Lasers Technology Center

Duration = 10 ps  
Wavelength = 1064 nm  
Pulses = 2  
Pulse Rate = 30 kHz  
Pulse control ; scanning system

Max. beam distance at lens entrance = 24 mm

31/01/2023 11

DLIP // Stainless Steel

ALPhA NOV  
Optics & Lasers Technology Center

Intensity = 50 mJ/cm<sup>2</sup>

Conventional LIPSS  
Period: 830±90 nm

DLIP + 2 LIPSS

Homogeneous periodical structures on steel with period <500nm

Hierarchical structuring of DLIP and LIPSS is the result of the mutual interaction between these two distinct types of structures

| Pulse Energy (mJ) | Period (nm) | Angular Dispersion (°) | LIPSS Period (nm) | Reference |
|-------------------|-------------|------------------------|-------------------|-----------|
| 100               | 830 ± 90    | 15.2 ± 0.3             | 830 ± 90          | [1]       |
| 100               | 830 ± 90    | 15.2 ± 0.3             | 830 ± 90          | [2]       |
| 100               | 830 ± 90    | 15.2 ± 0.3             | 830 ± 90          | [3]       |

31/01/2023 12

31/01/2023

12408-20

## Novel surface nanostructuring by fs laser with GHz pulses

Auteur(s) Shota Kawabata

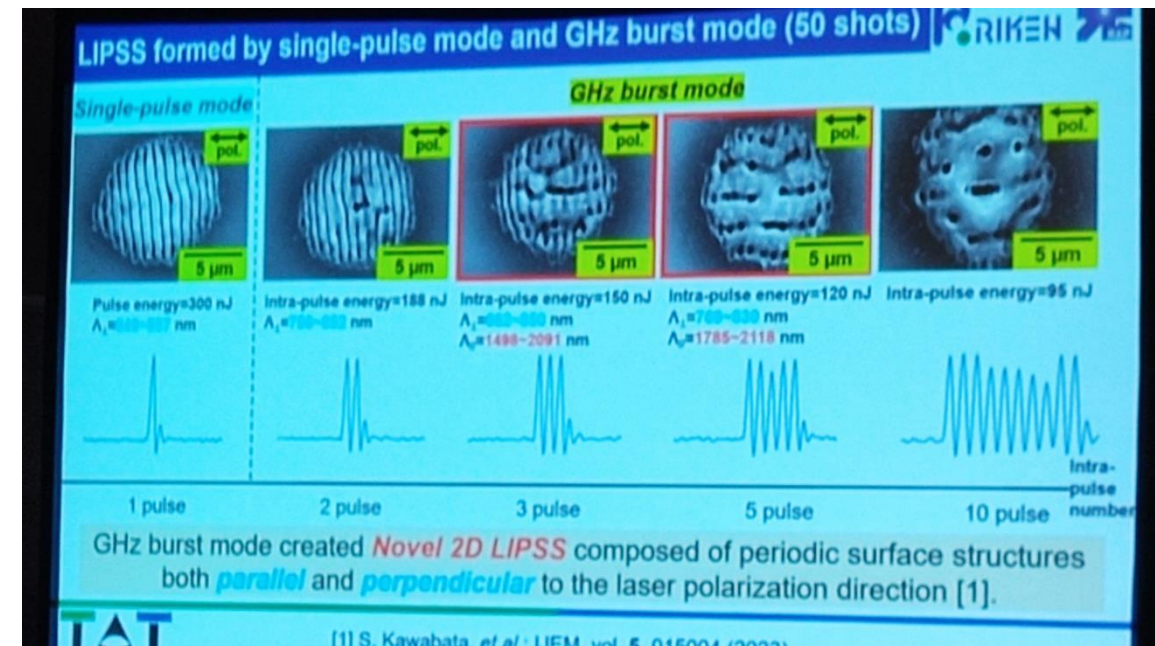
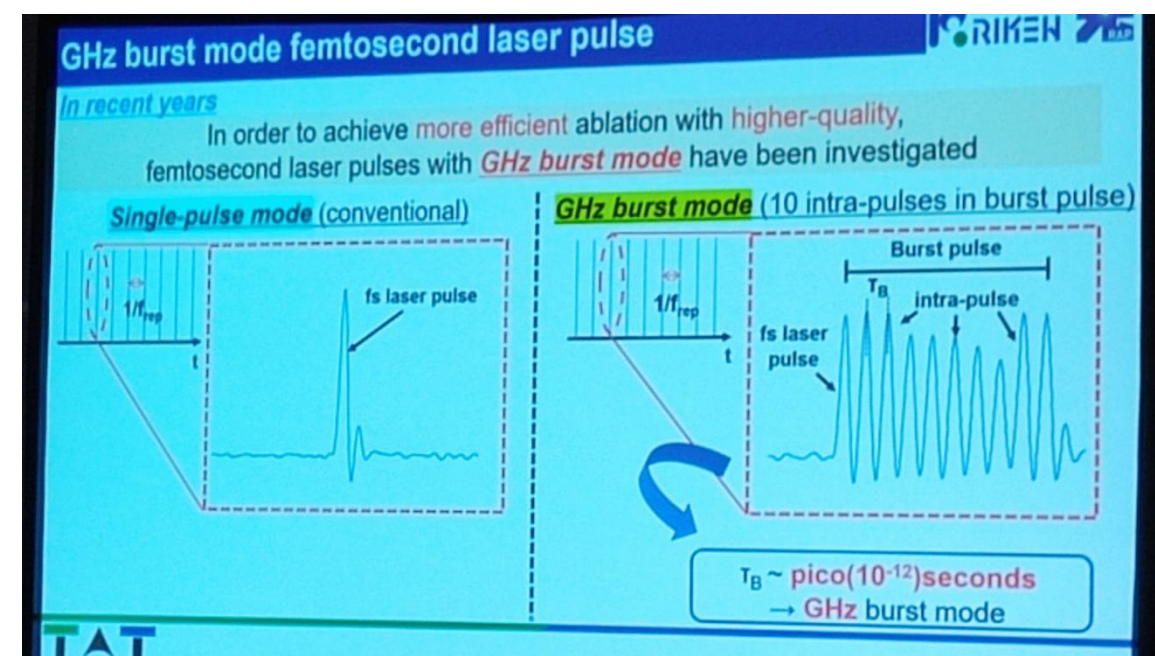
Soc. / Lab. Riken (Jap.)

Intérêts • Effet du burst

### Informations clés

- Not so much

2 photos





31/01/2023

12411-43

## Femtosecond UV laser for industrial applications : recent advances and challenges

Auteur(s) Aurimas Augus

Soc. / Lab. Light conversion (Lit.)

Intérêts

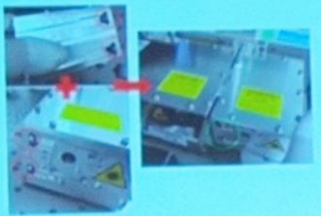
- Lasers UV de chez Light Conversion

## Informations clés

- Laser catalog in UV and deep UV
- 257nm square beam shaping
- 172nm

2 photos

Performance and maintenance



|                                          | 3H                         | CBM03-30W                  | CBM03-20W                  |
|------------------------------------------|----------------------------|----------------------------|----------------------------|
| Pulse duration                           | ~500 fs                    | ~200 fs                    | ~200 fs                    |
| Power                                    | >30W                       | >20W                       | >20W                       |
| Lifetime                                 | 10000h@200 kHz             | 10000h@200 kHz             | 10000h@200 kHz             |
| M2                                       | 1.5                        | 1.3                        | 1.3                        |
| Beam size (FWHM)                         | 2+/-0.5 mm                 | 2+/-0.5 mm                 | 2+/-0.5 mm                 |
| SH power                                 | >40W                       | >40W                       | >40W                       |
| Max IR energy                            | 400 uJ                     | 2 mJ                       | 2 mJ                       |
| Detachable UV section                    | YES                        | YES                        | YES                        |
| Dimensions                               | Identical                  |                            |                            |
| Polarization                             | <1%                        | <1%                        | <1%                        |
| Pulse to pulse stability (after warm-up) | >1% RMS deviation over 24h | >1% RMS deviation over 24h | >1% RMS deviation over 24h |
| Purge material                           | AIR                        | AIR                        | AIR                        |

LIGHT CONVERSION

© Light Conversion | Confidential

Outline

- Overview
- 343 nm (NUV) standard 30W products
- 343 nm (NUV) 50W towards productisation
- 257 nm (DUV) status and advantages
- 206 nm (DUV) achievements
- 172 nm generation
- Biburst and UV
- Beam shaping
- X-ray
- I-OPA
- Conclusions



LIGHT CONVERSION

31/01/2023

12411-44

300W femtosecond laser with USP compressed

Auteur(s) Clemens Hönninger

Soc. / Lab. Amplitude (Fr.)

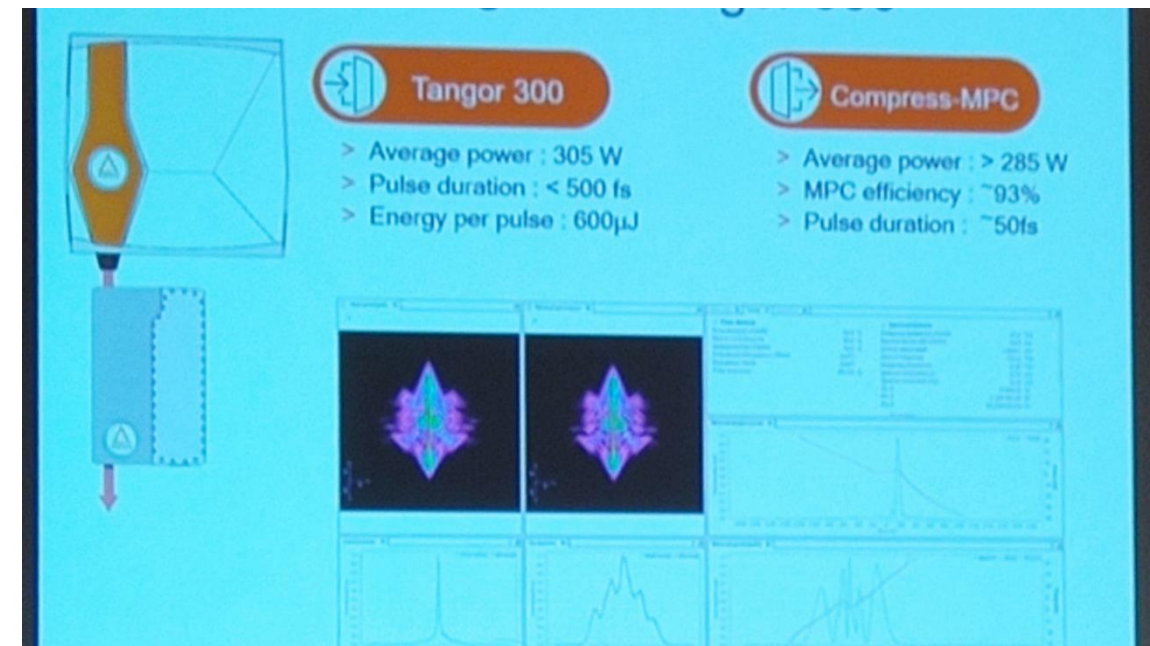
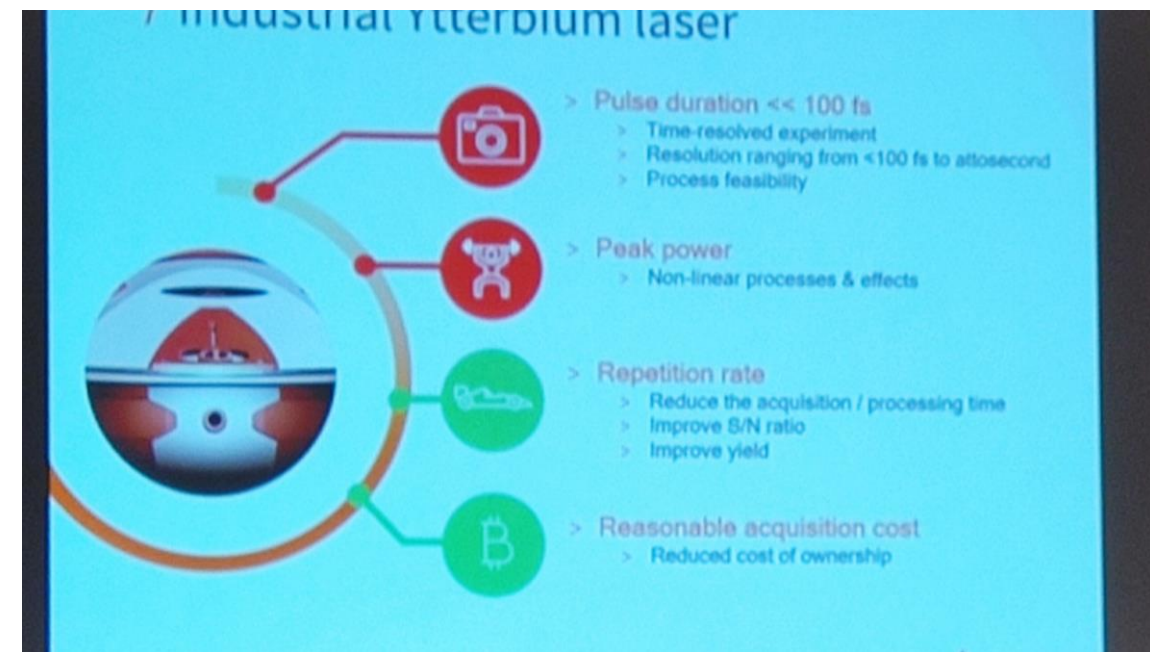
Intérêts

- Module de compression post laser des impulsions

Informations clés

3 photos

- Try to decrease pulse duration despite difficult with Ytterbium lasers => Development of a module for <50fs and >>100W
- Use of compress MPC (Multipass Cells) technology
- Demonstration with 300W station, 5days, 93% efficiency, 50fs, caustic a little bit degraded
- 100 W @ 343 nm





31/01/2023

12409-12

Towards mass production of functionalized plastic components via multi-beam nanostructuring of moulds

Auteur(s) Petr Hauschwitz

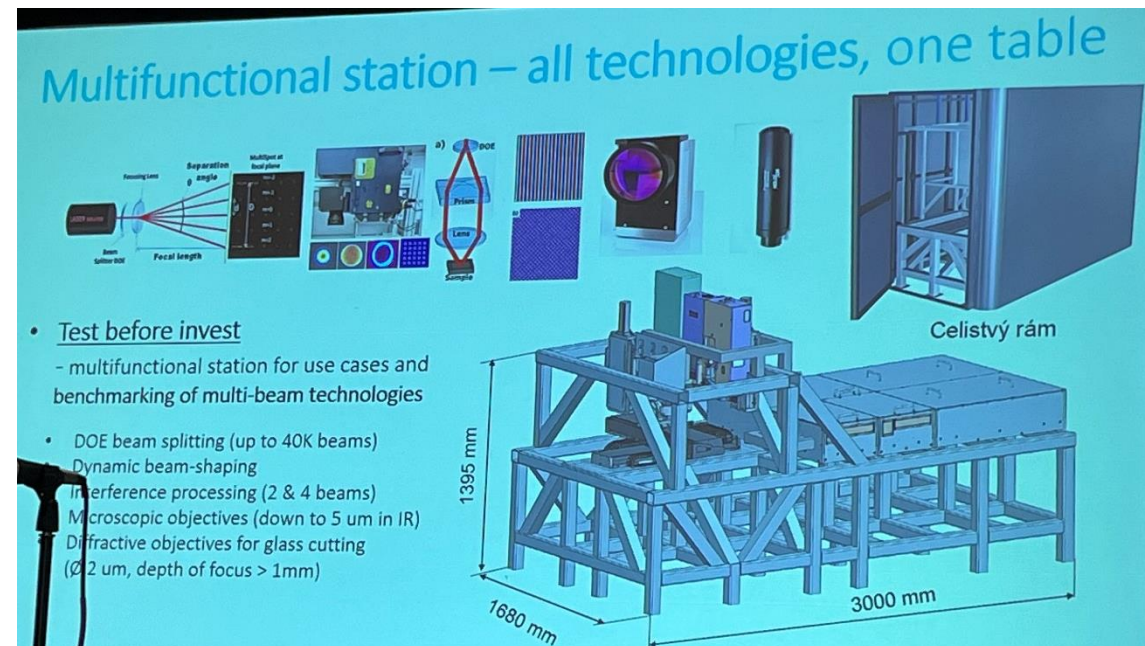
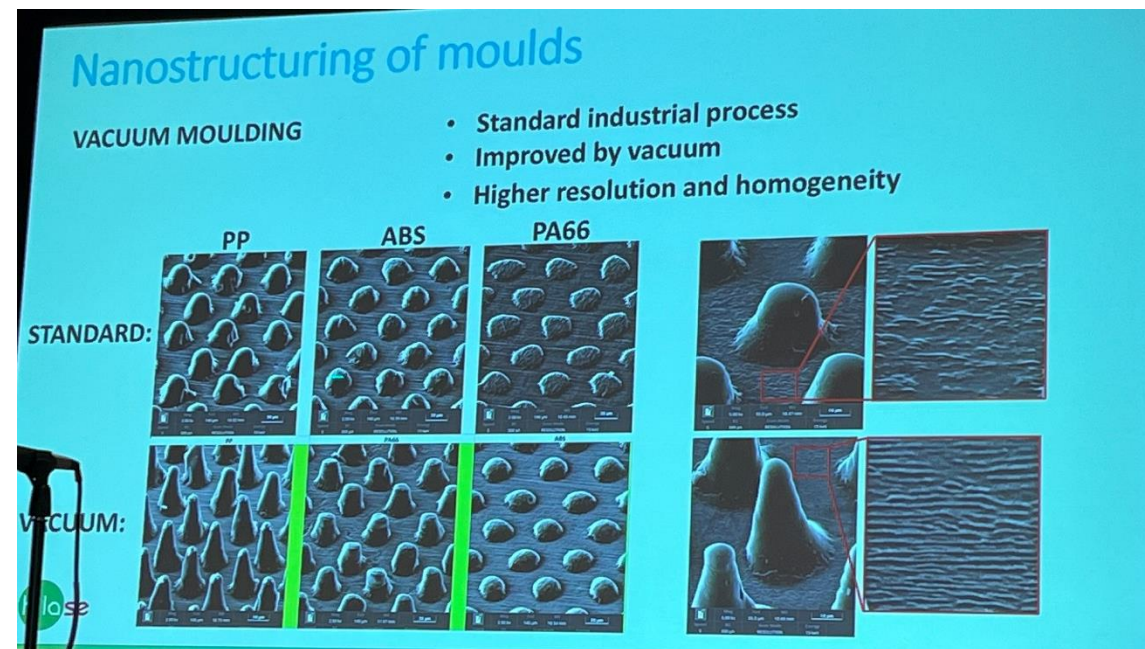
Soc. / Lab. Hilase (Rep. Tech.)

Intérêts

- Machine multi MEF
- Impact des conditions de démoulage

Informations clés *6 photos*

- Hydrophobic :micro pillars 30-40µm pitch
- Parallel processing : DOE splitter / Interf. / DLIP Pulsar
- 900cm<sup>2</sup>/min with SLM ripples texturing on large field
- PP vacuum better moulding following of the nanostructures
- Antibacterial properties / Enhancement of cells migration by mimicking the native morphology of human tissue
- Soft touch feel surfaces
- New machine that groups all beam shaping technics





31/01/2023

12409-13

High precision drilling with aspect ratios 1:40 from laser source to application

Auteur(s) Florian Lendner

Soc. / Lab. GFH laser micro machining (Ger.)

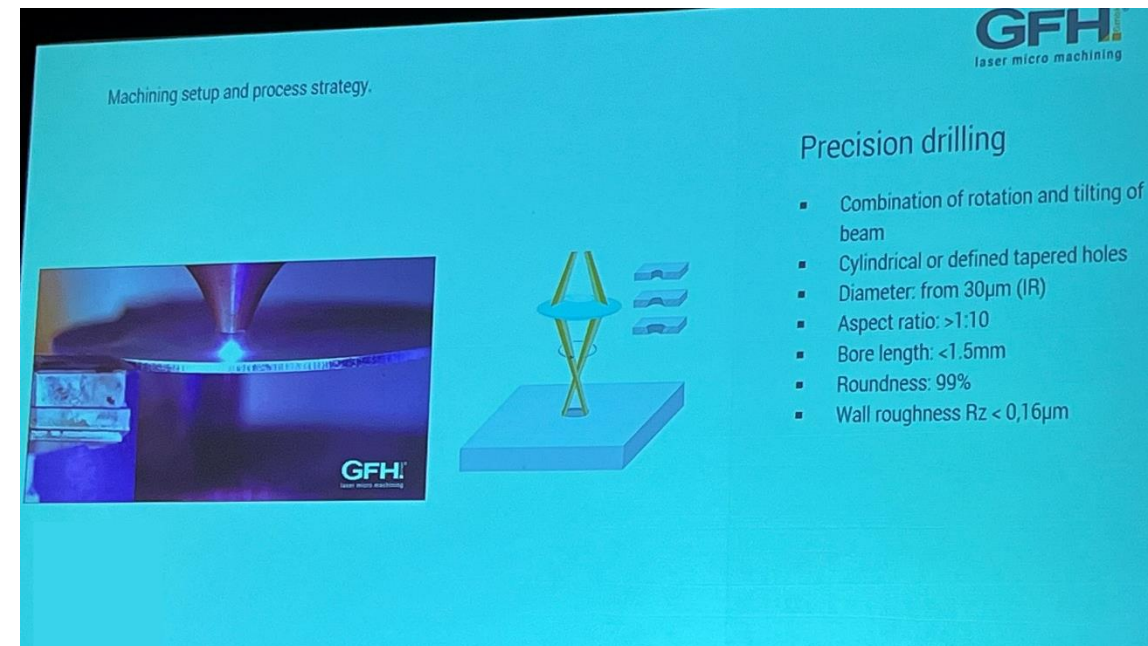
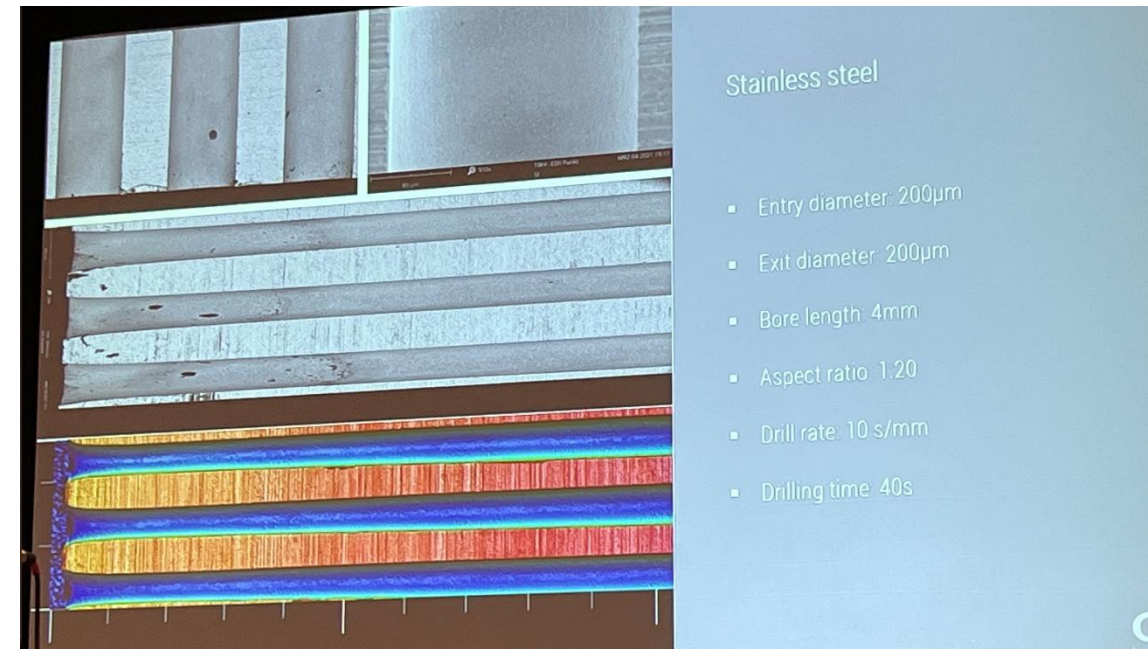
Intérêts

- Nouveau système de précession
- Vendue uniquement avec une machine...

## Informations clés

4 photos

- Système de trépanation GL Trepan system. 30krpm
- Up to now, limited on the thickness. Now working with longer focusing (75µm that enables much longer depth (f250)). Done now that energies are sufficient (2mJ, 200W to get 20-25J/cm<sup>2</sup>)
- GL Trepan handles tens of mJ
- Z shifting mandatory
- Examples at 3ps, 2mJ, up to 6mm, 8-15s per mm. Around 300µm diameter : 30s 2mm Al<sub>2</sub>O<sub>3</sub> ; Carbide 5mm 40s ;





31/01/2023

12409-14

Ultrashort pulse laser system for nanostructuring the inner copper surface of up to 15m long vacuum tubes

Auteur(s) Elena Bez

Soc. / Lab. CERN (Suisse) / Univ Leipzig

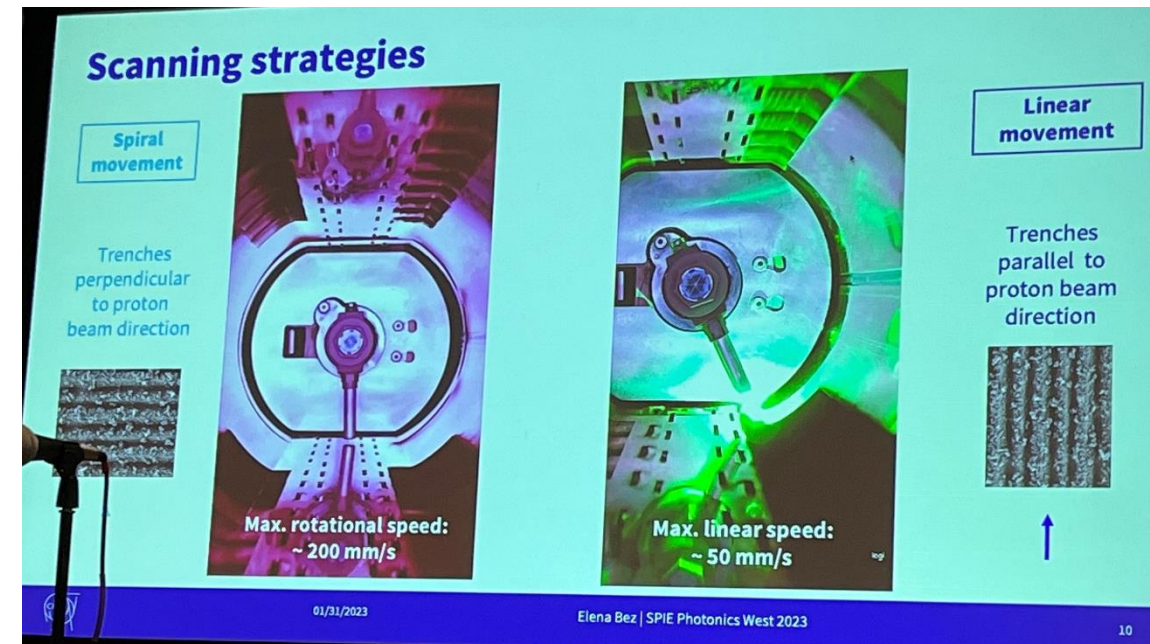
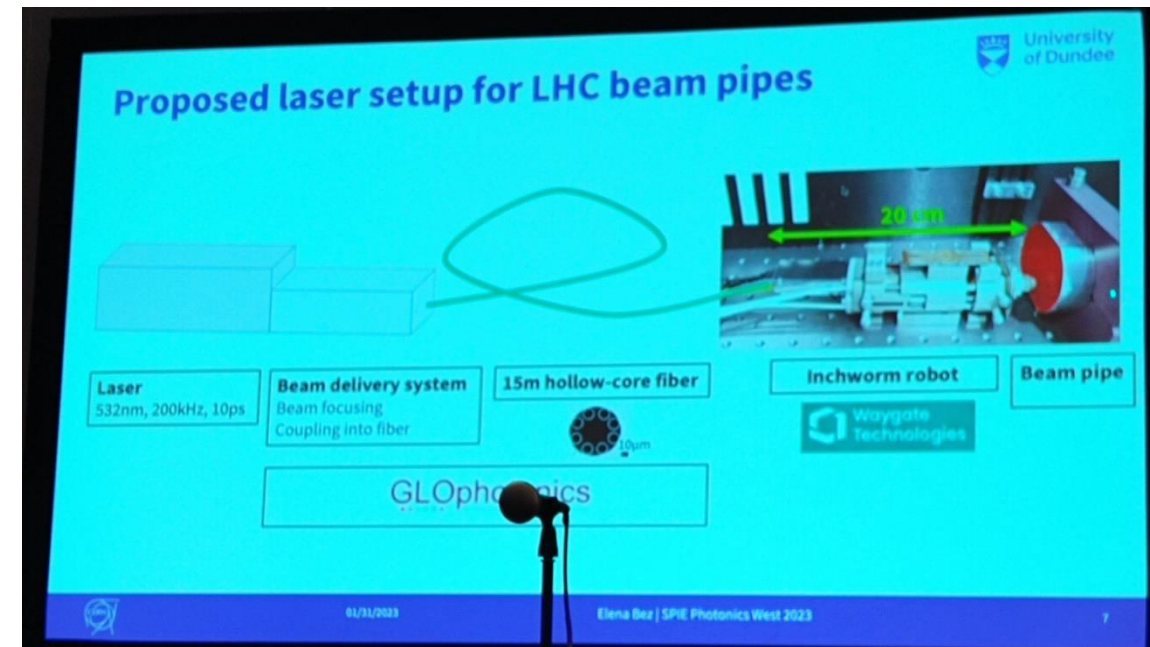
Intérêts

- Texturation ps intra-cylindre
- Fibrage laser

## Informations clés

6 photos

- Improve signal quality of vacuum Cu tubes of CERN where protons are accelerated at around the speed of light : future upgrade of LHC phase in 2026.
- Technical challenge : 46mm diameter in 15m long
- Laser ps vert injecté par fibre dans un robot qui focalise + translate + rotate en même temps.
- Usinage de rainures de 50µm de pitch, 5-30µm profond
- Processing time : Few days per m





31/01/2023

12408-25

## Stress control during USP laser for glass machining

Auteur(s) Hyungsik Kim

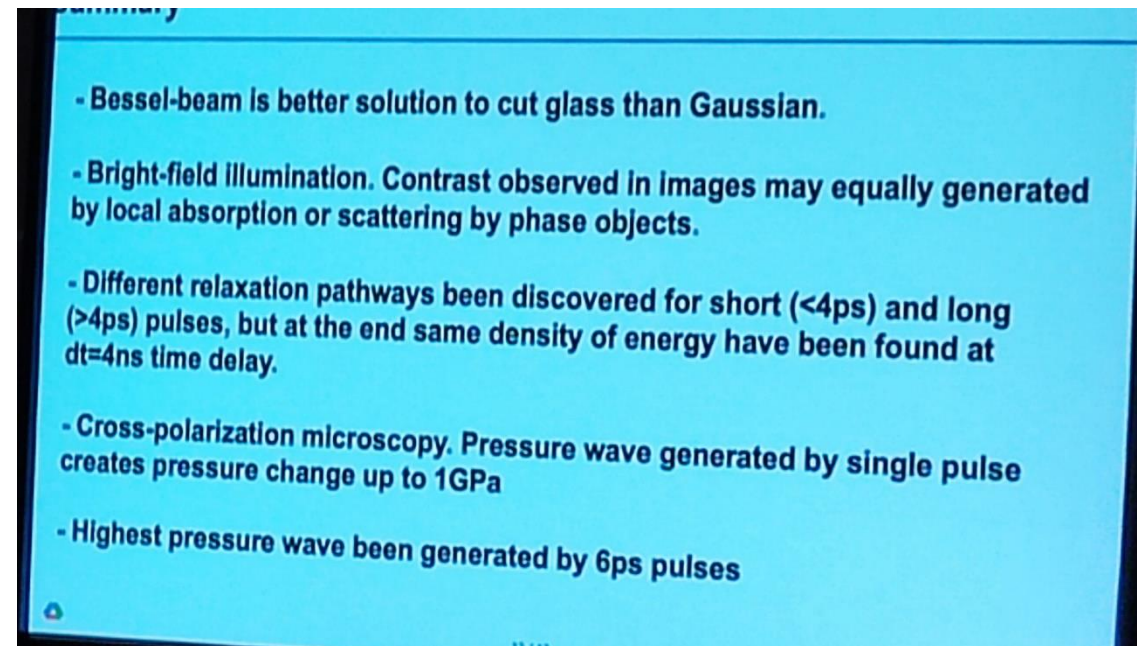
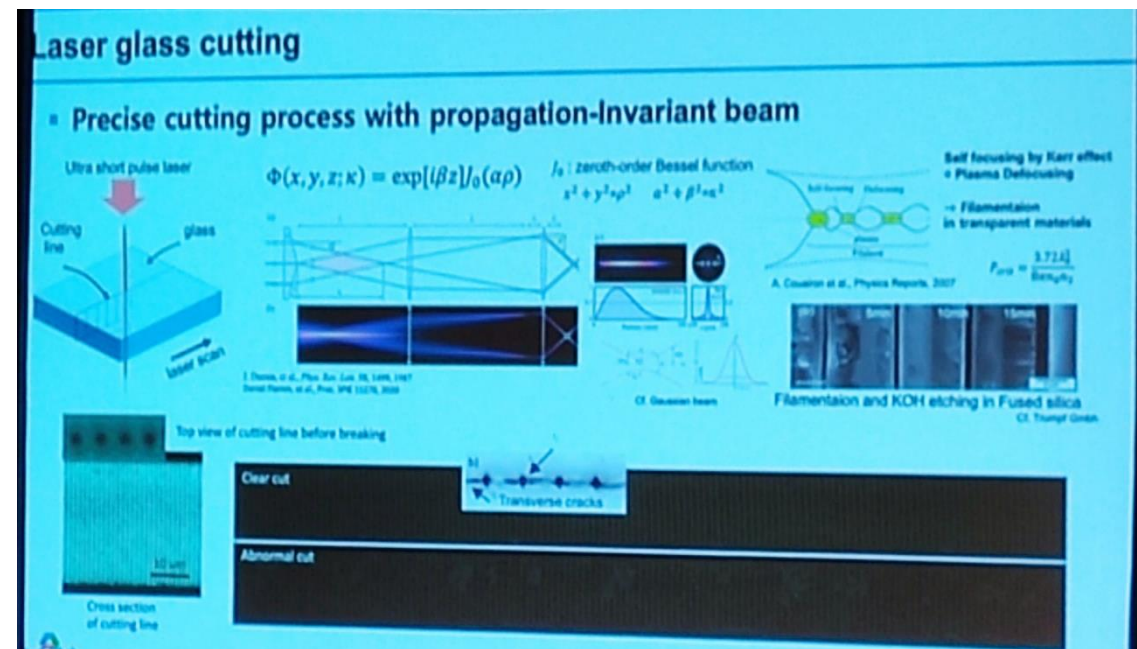
Soc. / Lab. Samsung Display (Cor.)

Intérêts

- Bessel Vert pour la découpe de verre
- Suite aux travaux de K. Mishchik

## Informations clés 3 photos

- Bessel par SLM + prod in green 20μJ 300fs=>5ps NA0.3
- Time resolved plasma generation observation at high speed
- Crossed polarized light : direct stress visualization





31/01/2023

12408-26

Tailored edge laser glass cleaving supported by thermal separation

Auteur(s) Daniel Flamm

Soc. / Lab. Trumpf (Ger.)

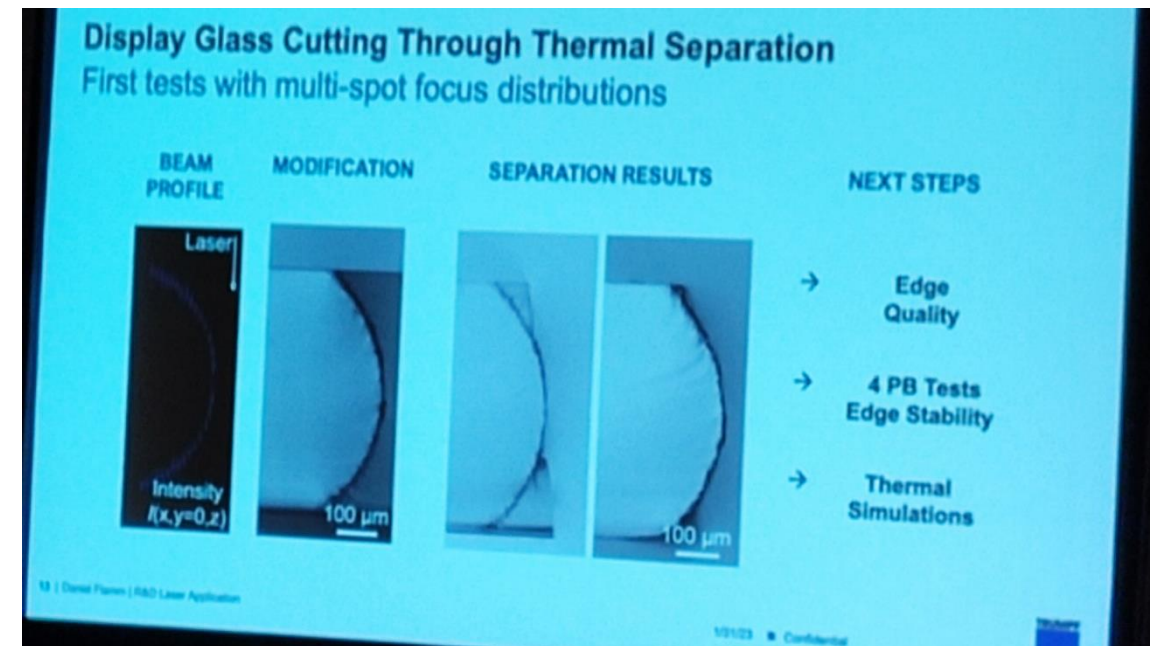
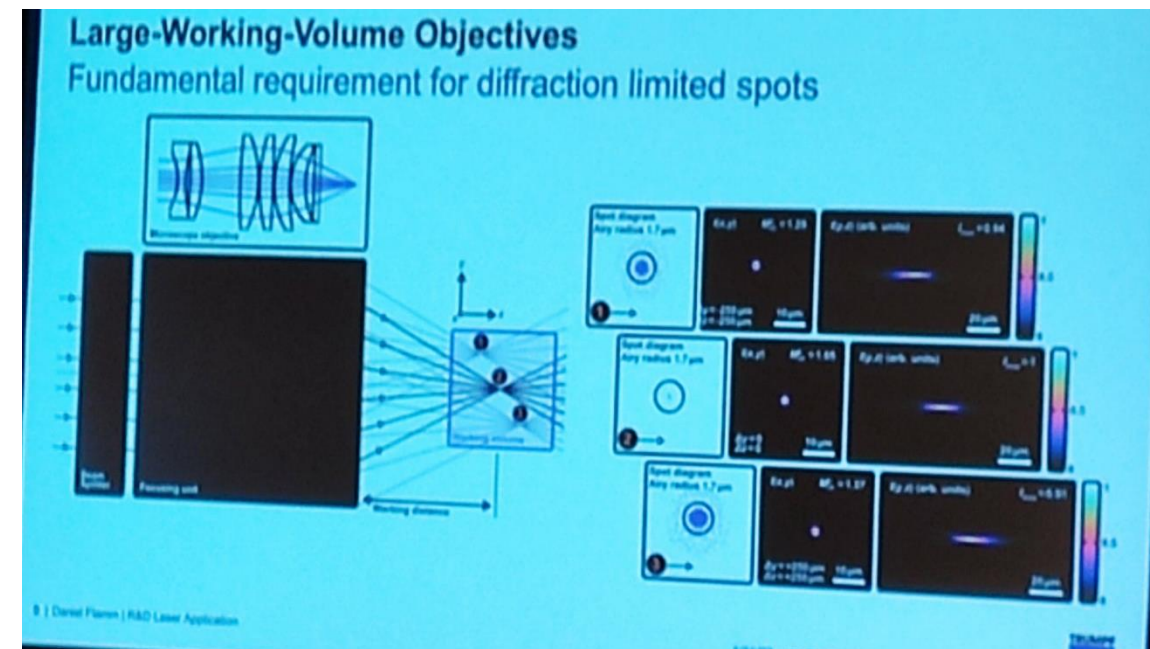
Intérêts

- Découpe de verre par multipoint 3D
- Clivage par thermique laser CO2

Informations clés

7 photos

- Multi foc dev en SLM puis DOE pour indus
- Faisceaux courbes non envisageables car requiert  $NA=1$  dans les cas utiles.
- Objectif de microscope de focalisation dev sur mesure (7 lentilles) pour compenser les défauts d'aberrations pour la MEF 3D
- Résultats cleavage par CO2 par encore parfait sur des formes courbes



31/01/2023

12409-56

Increasing the ablation efficiency of metals using femtosecond fiber laser

Auteur(s) Bogus Stepak

Soc. / Lab. Fluence technology (Pol.)

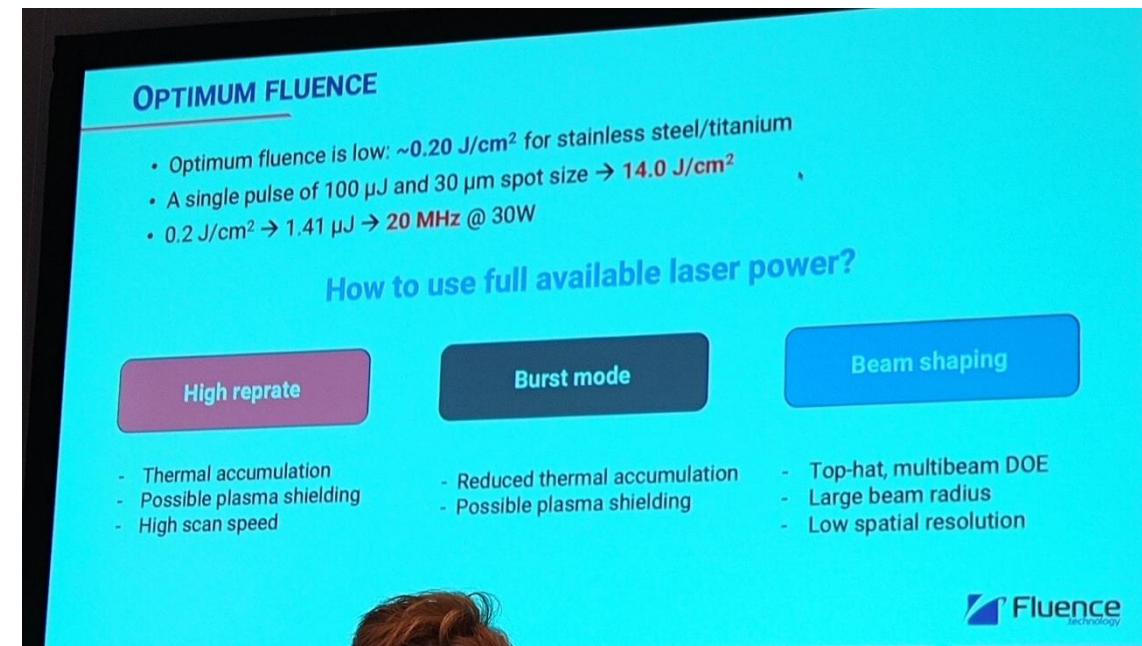
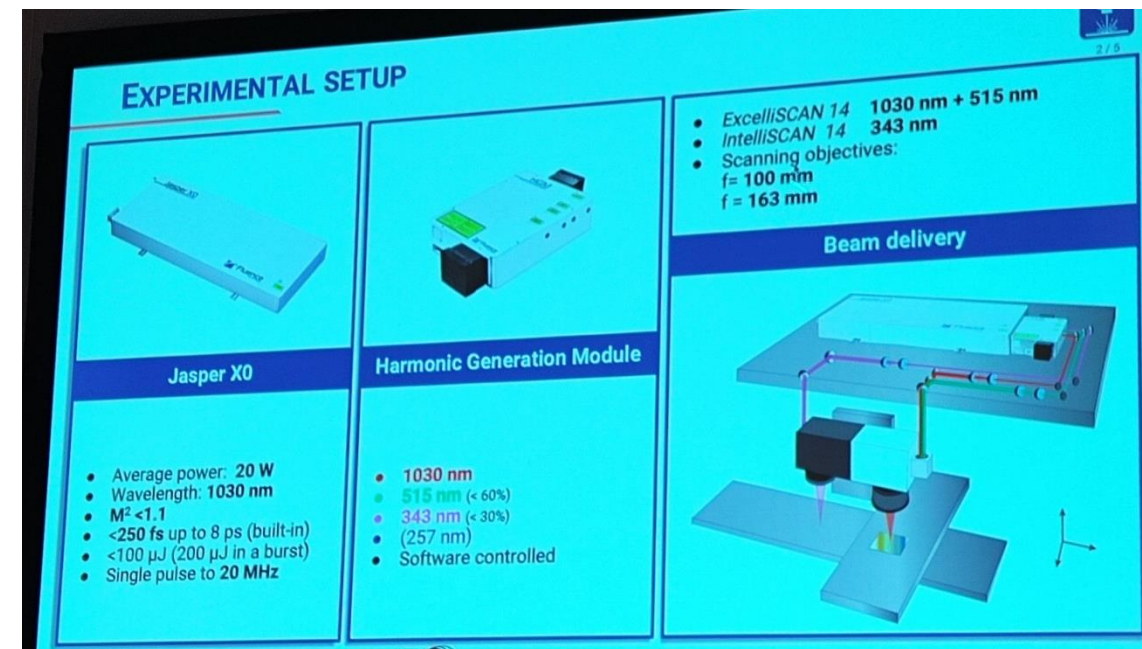
Intérêts

- Fournisseur laser non référencé

## Informations clés

2 photos

- Fluence technology company : laser & processing
- Steel milling : better ablation efficiency with 1spot rather than burst MHz (250fs)
- Ablation efficiency of steel (mm<sup>3</sup>/(W.min)) ref B. Neuenschwander





31/01/2023

Inc.

Directional broadband emissivity with fin-shaped microstructures produced via femtosecond laser surface processing

Auteur(s)

Soc. / Lab. CEFS Nebraska (US.)

Intérêts • Moyen de caractérisation sub surface

Informations clés

1 photos

- EDS : energy dispersive X ray spectroscopy (EDS) powerful to measure element composition of the textured surface with sub  $\mu\text{m}$  resolution

### Conclusion and Acknowledgements

**CEFS**  
Center for Electro-Optics & Functionalized Surfaces

**NASA EPSCoR Nebraska**

**NASA Nebraska Space Grant**

**Office of Naval Research**  
**ONR**  
Science & Technology

- FLSP applied at an angle produces microstructures at that angle.
- There is a corresponding shift in the peak directional emissivity to match the angle of the microstructures.
- The resulting emissivity is:
  - broadband, covering the mid-IR range of 7.5 to 14  $\mu\text{m}$ ,
  - independent of polarization, based on simulation.
- Simulations using finite element method software predict with reasonable accuracy the resulting emissivity of the laser processed surface.

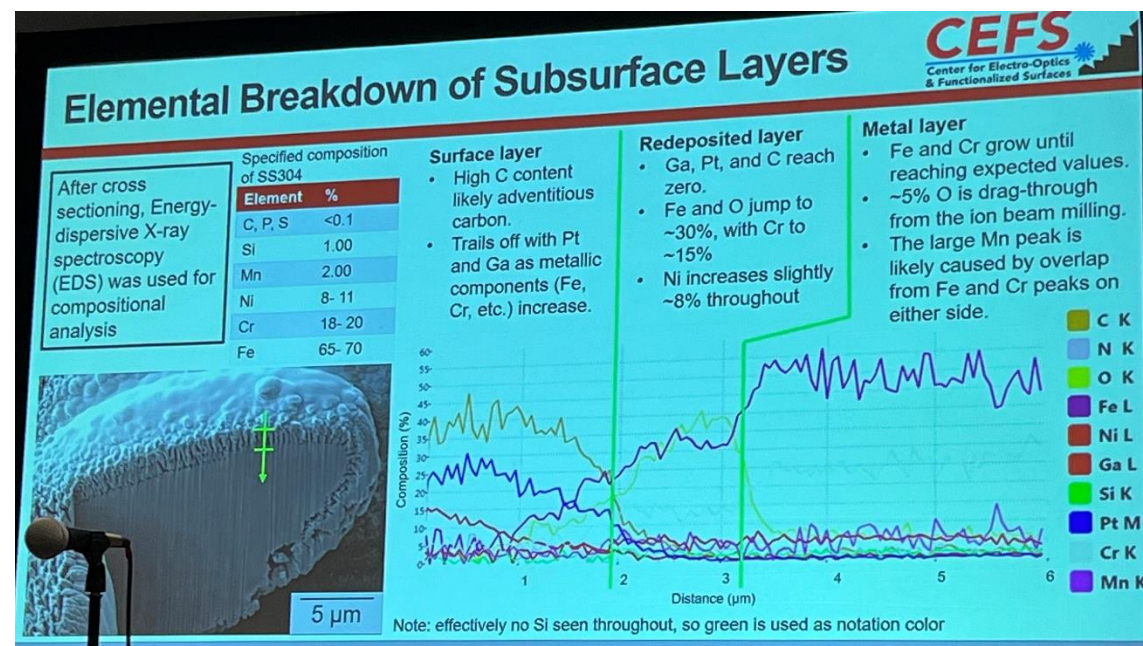
This work is supported by:

- **NASA Space Grant Consortium** FY 2015 - FY 2017 Grant # NNX15AI09H
- **Office of Naval Research Young Investigator Program (ONR-YIP)** Grant # N00014-19-1-2384
- **Office of Naval Research** Award Number N00014-20-1-2025

This work was performed at:

- **Center for Electro-optics and Functionalized Surfaces (CEFS)**
- **Nano-Engineering Research Core Facility (NERCF)**
- National Science Foundation under award no. ECCS: 1542182

University of Nebraska - Lincoln





31/01/2023

12409-56

Increasing the ablation efficiency of metals using femtosecond fiber laser

Auteur(s)

Soc. / Lab. Fluence Technology – Pologne

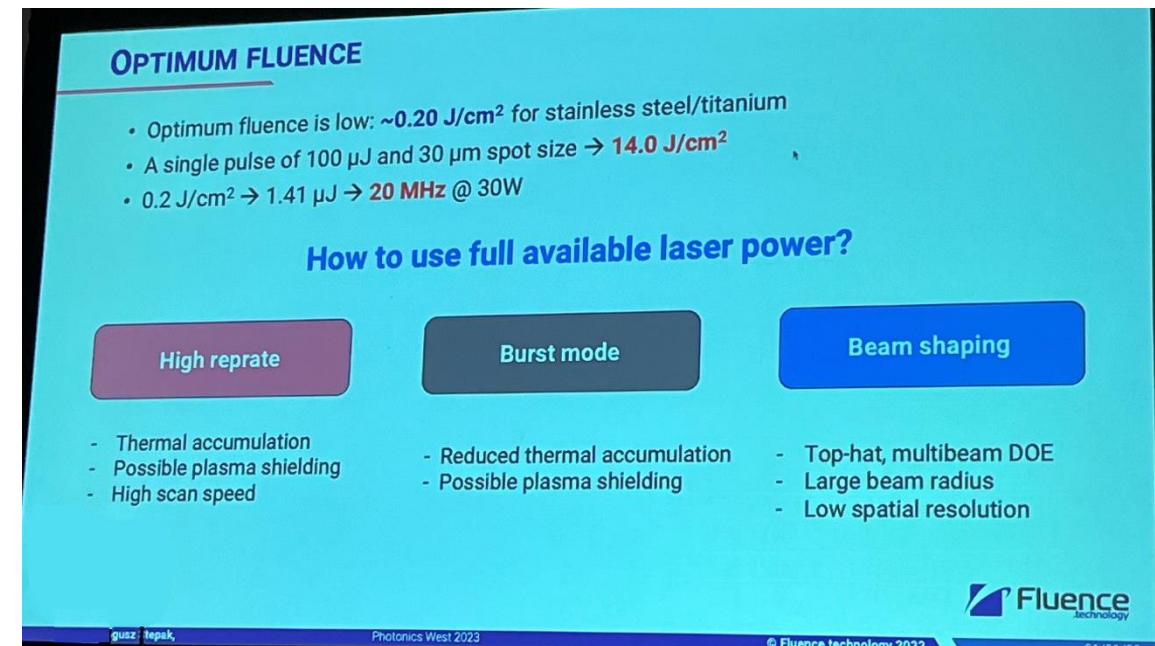
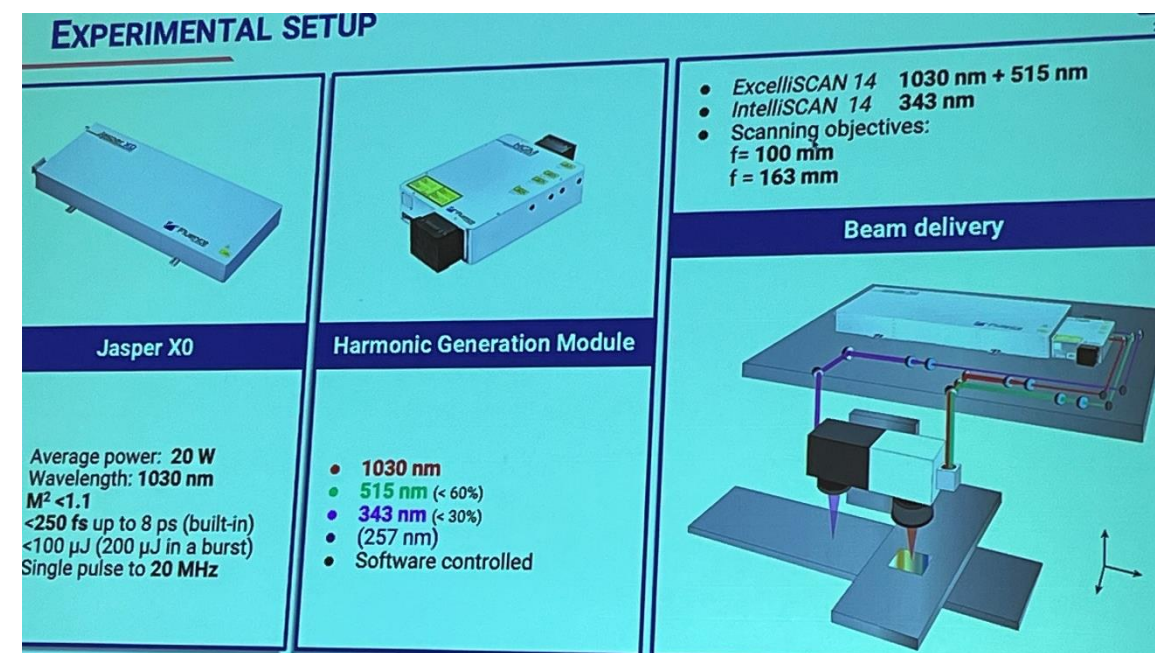
Intérêts

- Fabricants de lasers femtosecondes

Informations clés

2 photos

- Essais en burst 20 MHz (seeder). Ils partent du principe que pour l'inox on a besoin de  $0,2 \text{ J/cm}^2$  hors on peut avoir avec leur setup jusqu'à  $10 \text{ J/cm}^2$  donc ils passent en Burst Mhz pour gagner en efficacité et balayent entre 2 et 4 m/s.





31/01/2023

12408-28

## Metallic microdots patterning with laser induced forward transfer

Auteur(s) Haruki Kawaguchi

Soc. / Lab. Chiba Univ. (Jap.)

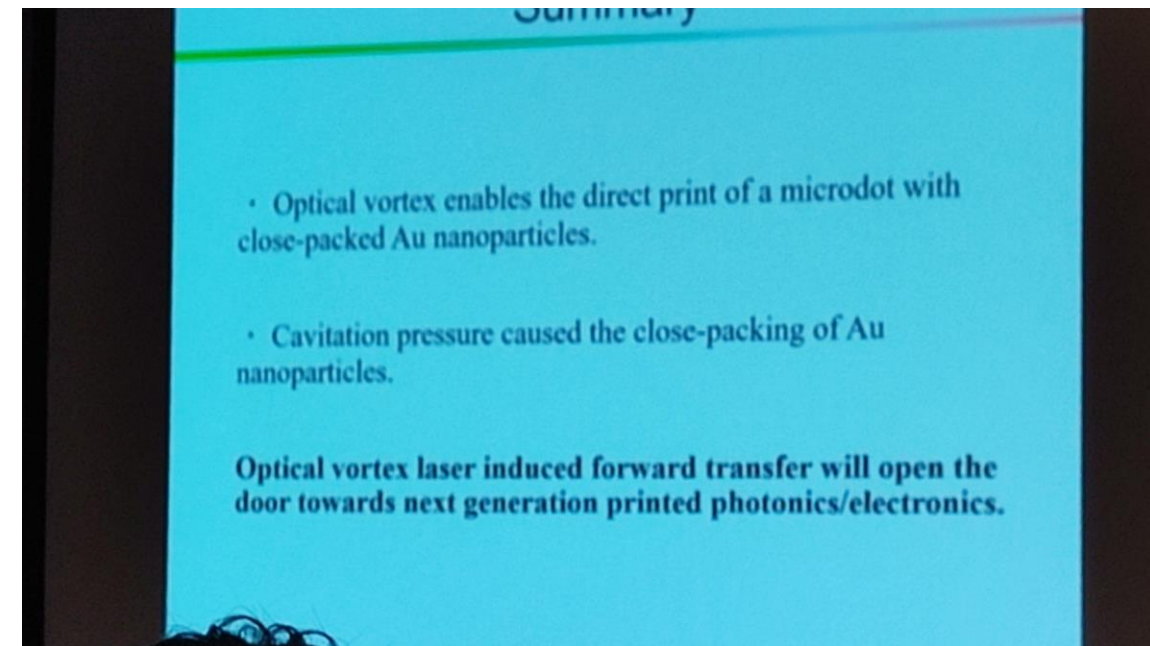
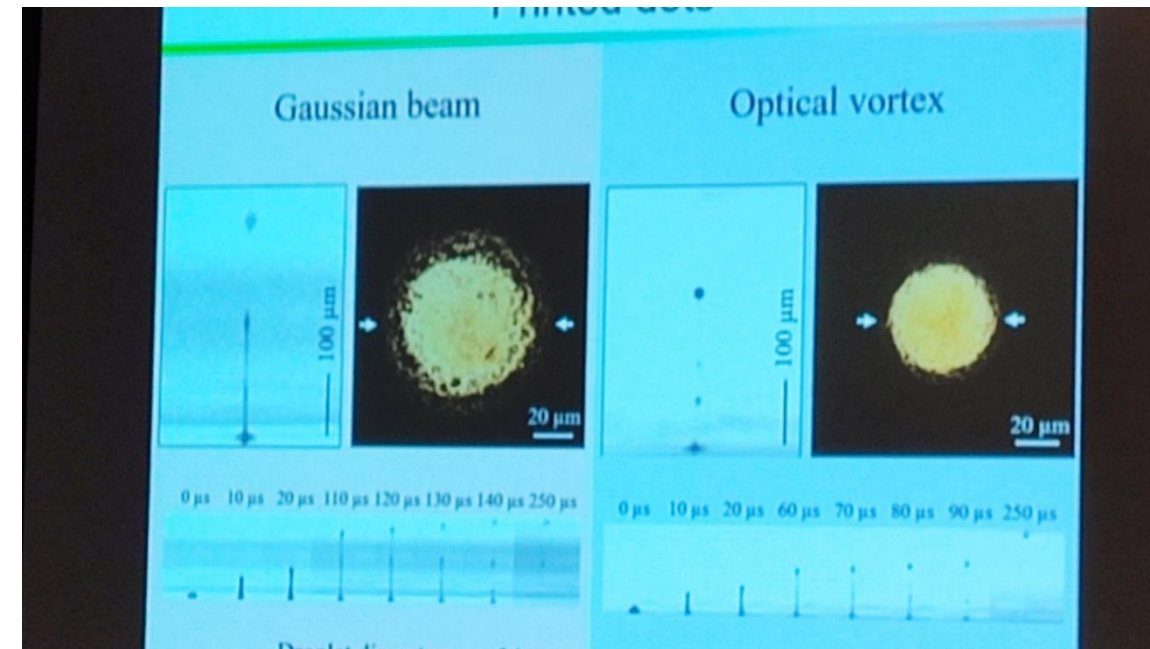
Intérêts

- LIFT technique
- Utilité du vortex

### Informations clés

2 photos

- LIFT technic. Depot de microdroplets (Laser Induced Forward Transfer). Tir laser dans le dos d'une cible. Ejection de matière et dépôt sur une seconde surface
- Vortex améliore la résolution de la bille vs gaussian => perspectives d'amélioration et de dépasser l'existant par de tels vortex



30/1/2023

12401-501

## First demonstration of fusion ignition at NIF

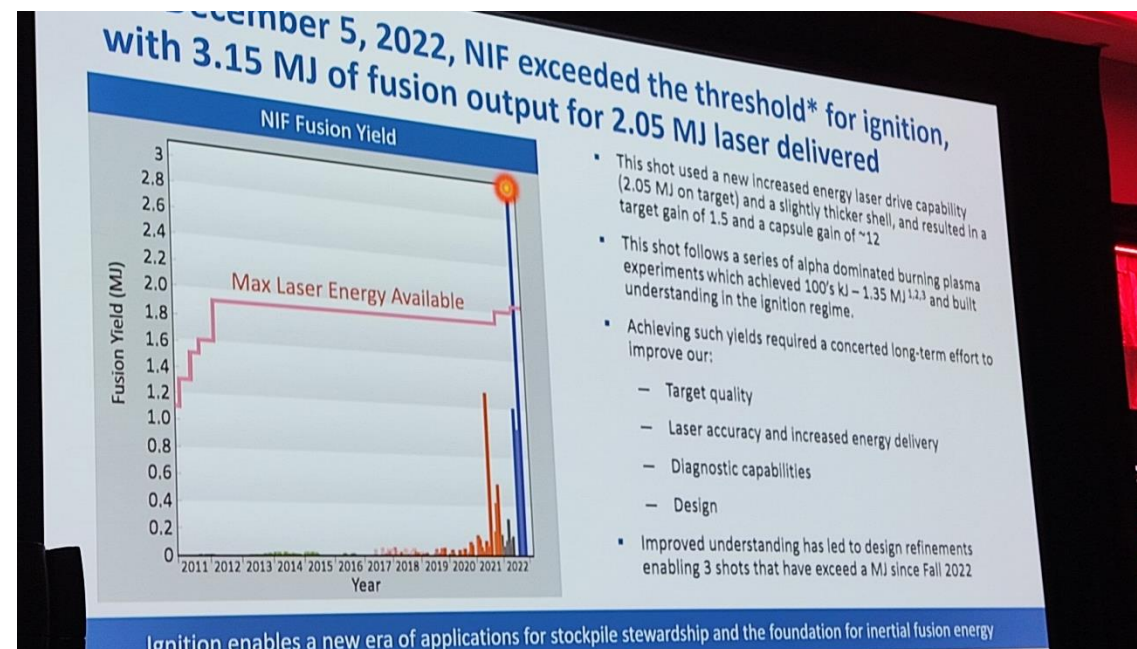
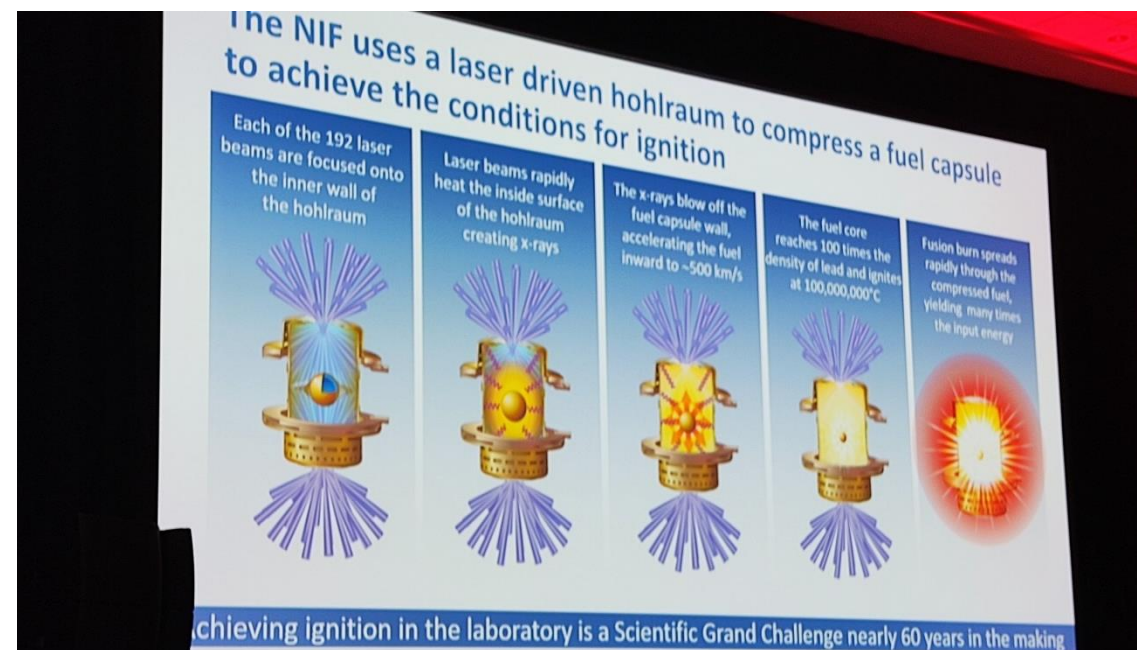
Auteur(s) Jean Michel Di Nicola

Soc. / Lab. NIF

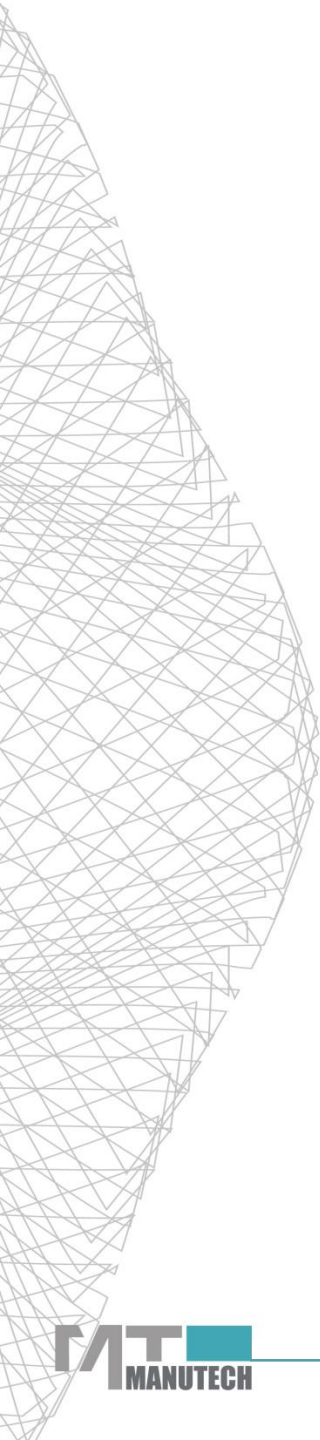
Intérêts • Derniers résultats de fusion nucléaire

Informations clés

10 photos







Mercredi 01-02-2023

01/02/2023

12401-1

## LMJ 2023 Facility status

Auteur(s) Vincent Denis

Soc. / Lab. IOGS (Fr.)

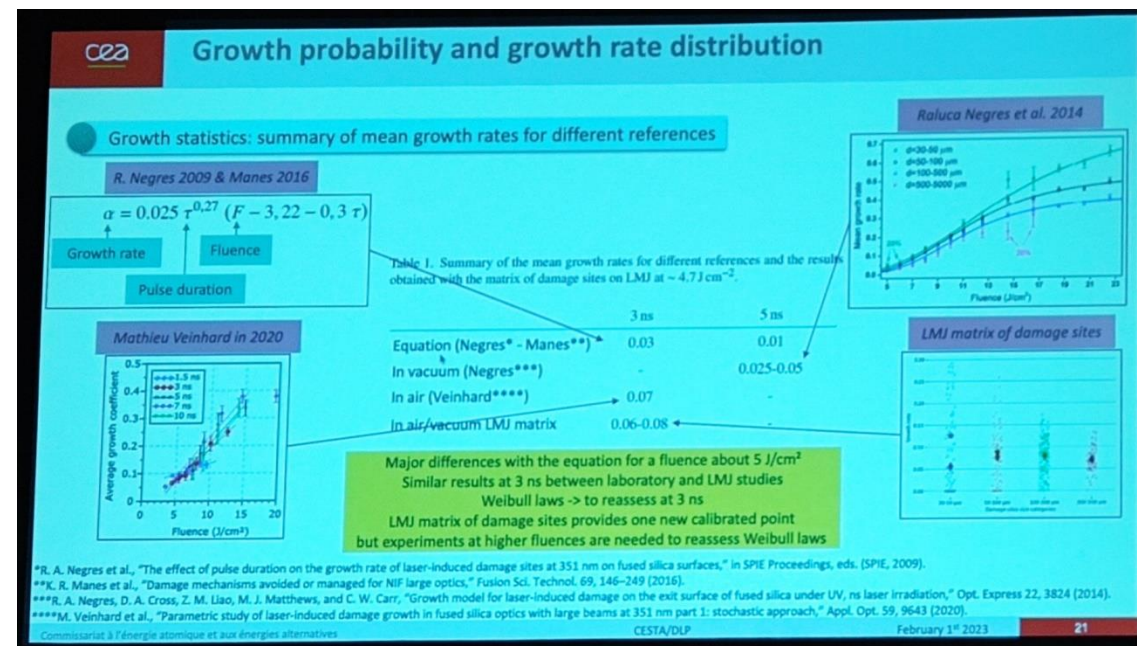
Intérêts

- Résultats d'avancement

## Informations clés

- Décevant

1 photos





## Optical vortex laser material processing technologies

Auteur(s) Takashige Omatsu

Soc. / Lab. Chiba University (Jap.)

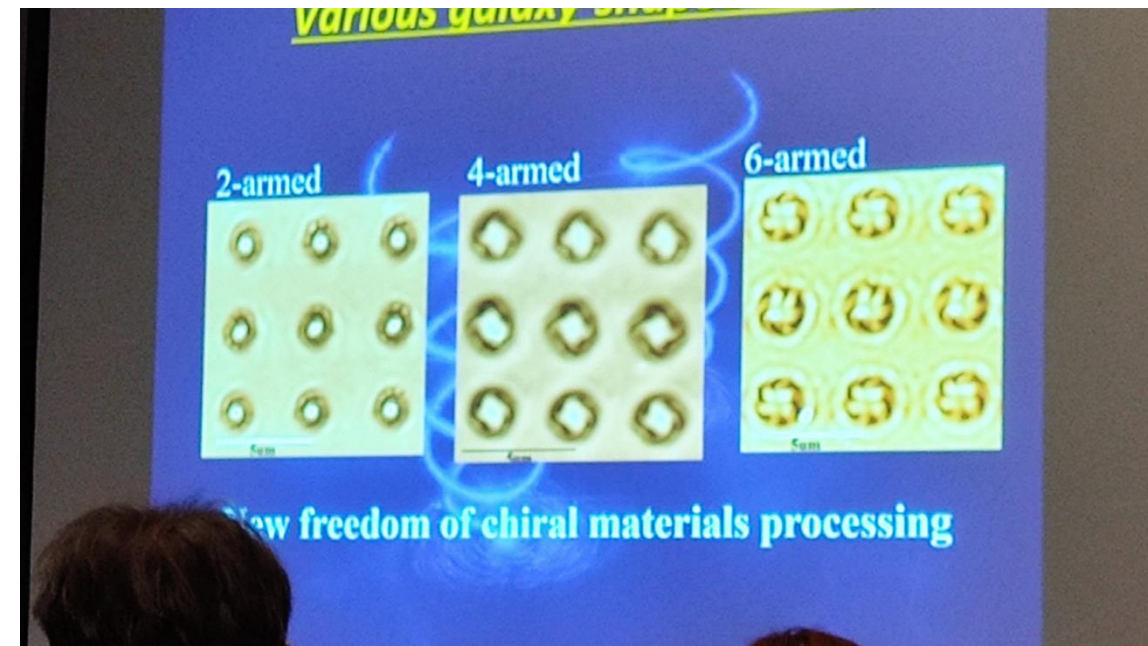
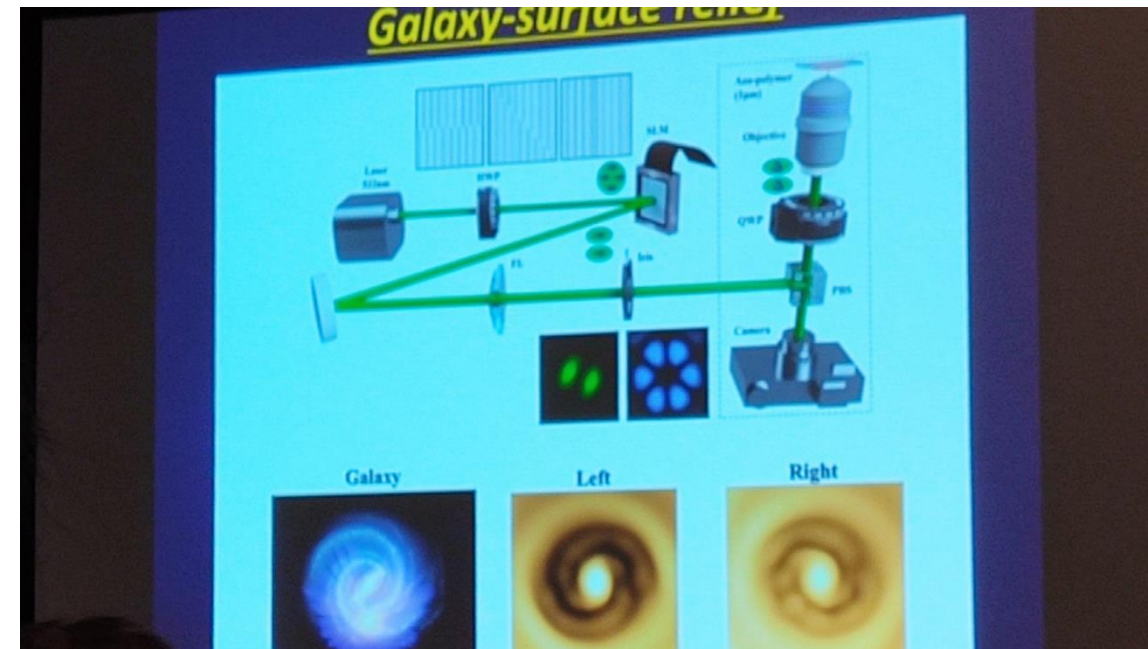
Intérêts

- Référence dans l'utilisation de faisceaux vortex

## Informations clés

6 photos

- Spiral wavefront
- Green light – hundreds of mW
- ! Linear polarized laser do not enable creating chiral structures
- Mainly biological applications : chiral crystallisation, trapping, achiral crystals. Also LIFT (cf conf precedente liée)
- LIFT : shoot a l'arrière d'une surface et recup de la particule sur une seconde surface.
- NA 0.05 => NA 0.35 : droplets of down to 7µm diameter
- Interested of collaborations with big JAPANESE project
- Question : what pulse duration to enable printing of chiral? Typical 5-10ps to have the time to imprint the chirality





01/02/2023

12408-32

## Creating efficient nanogratings buried in silicon through laser nano lithography

Auteur(s) Alperen Satik

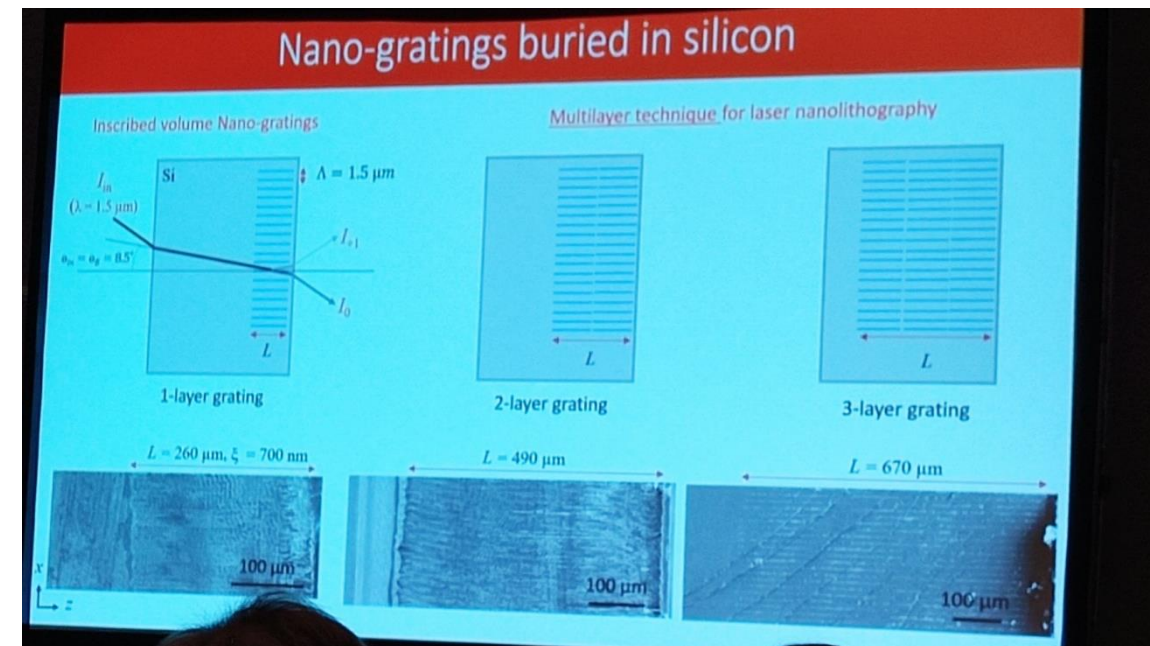
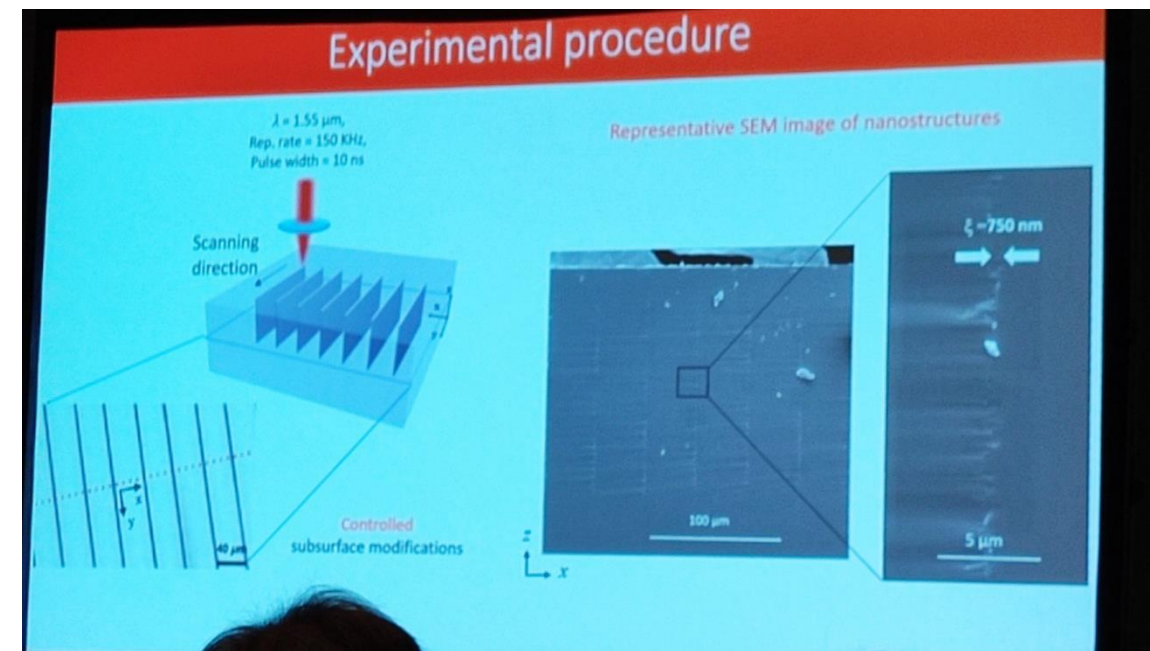
Soc. / Lab. Bilkent University, Turk

Intérêts • Bessel @1,55 $\mu$ m pour Silicium

### Informations clés

4 photos

- Use of SLM for a Bessel beam generation
- Inside marking of Silicon + Chem. Etching => 100nm large channels with high aspect ratios.
- Patent a nano-scale lithography method US 17840023 2022
- Periodicity of 7 $\mu$ m => grating a bragg diffractive pattern @1.55 $\mu$ m
- Periodicity of 1.5 $\mu$ m and 600 $\mu$ m deep => diffraction efficiency 82%





01/02/2023

12408-33

Tribological properties improvement of stainless steel and nickel samples at large scale thanks to beam splitting with a fs laser

Auteur(s) Gwenn Pallier

Soc. / Lab. CAILabs

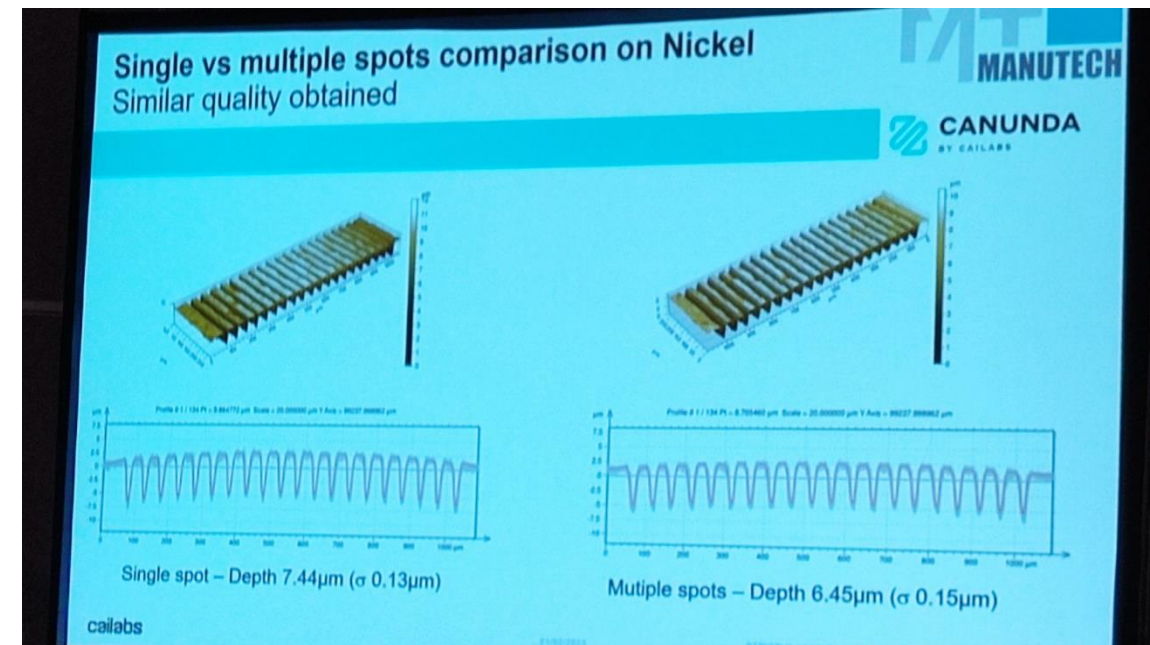
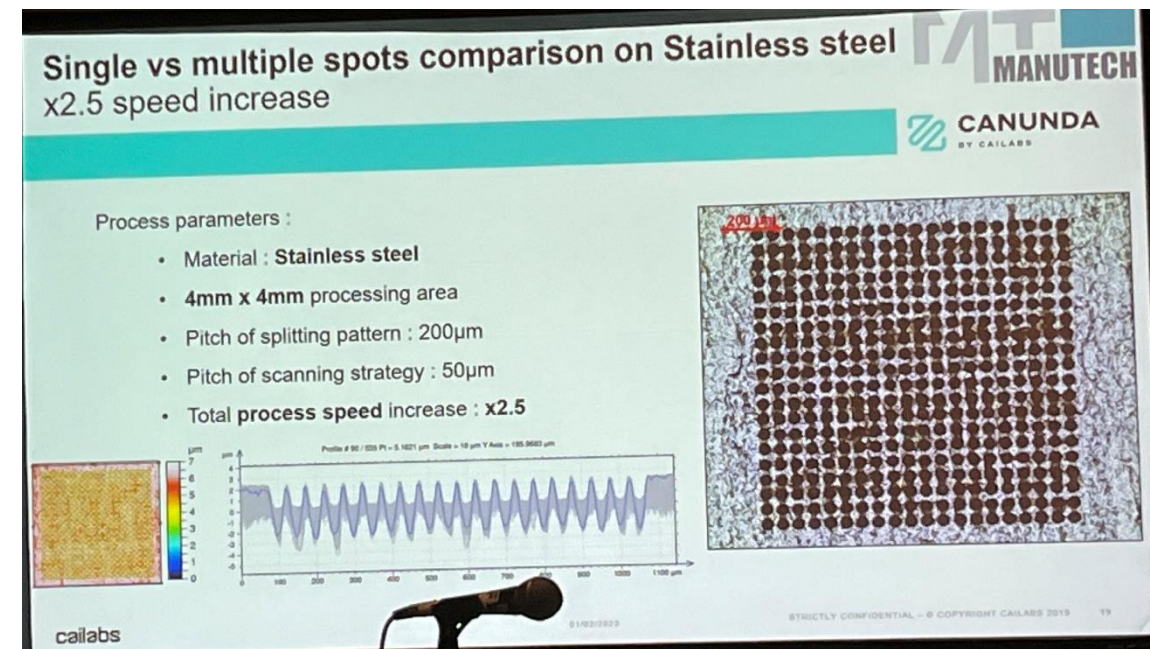
Intérêts

- Résultats Manutech Multipoint MPLC

Informations clés

- Question : pulse duration comparison to be tested

5 photos





01/02/2023

12408-34

Ultrafast laser platform providing dynamic peak and energy deposition control : from laser source to industrialisation

Auteur(s) Steffen Ruebling

Soc. / Lab. Trumpf (Ger.)

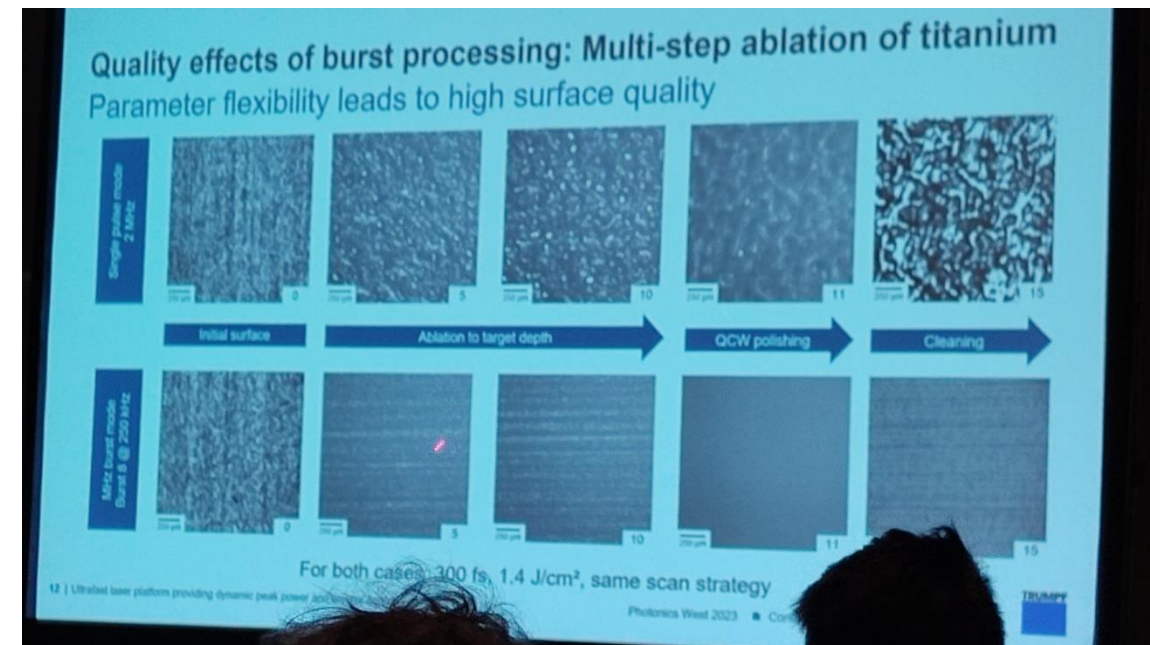
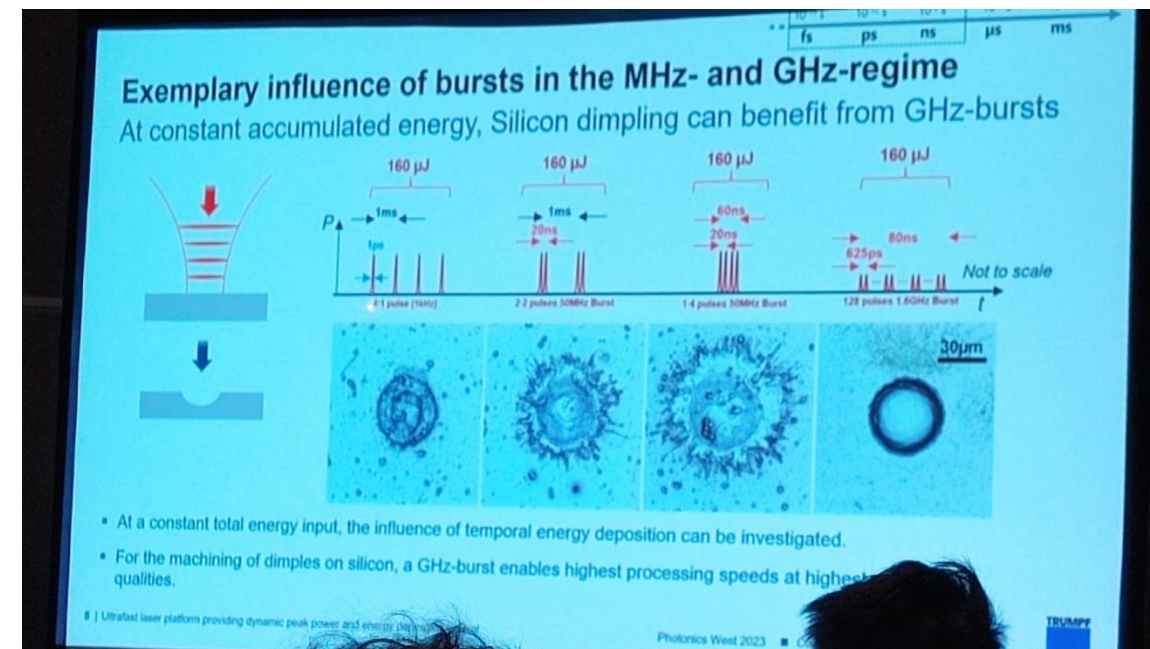
Intérêts

- GHz Burst pour le polissage

## Informations clés

3 photos

- Silicon : GHz burst regime better quality (160μJ) (<ns pulses)
- ! Depending on materials, GHz burst not far from ns pulse durations
- Titanium polishing more efficient with MHz/GHz bursts. (QCW polishing = high frequency) => Decrease of the roughness





01/02/2023

## Femtosecond GHz-burst laser processing for percu

Auteur(s)

Soc. / Lab. Trumpf

Intérêts • Burst / Taux d'ablation

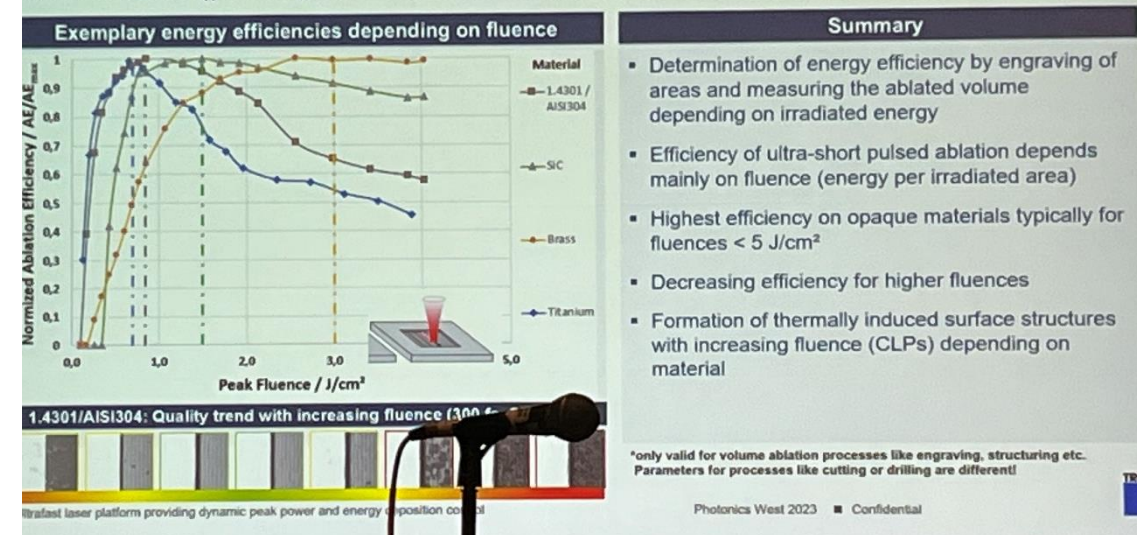
## Informations clés

- En fonction des matériaux, un gros impact de la durée d'impulsion. En Pico, on voit que 5 J/cm<sup>2</sup> c'est suffisant

5 photos

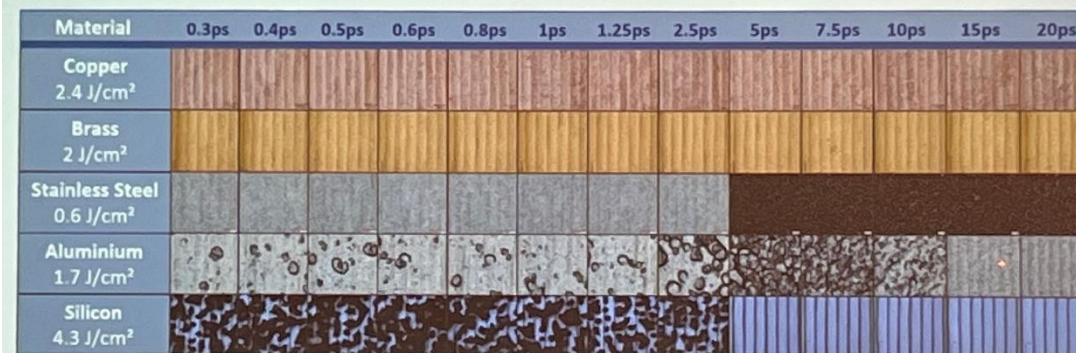
### Ablation efficiency depending on fluence

A moderate (peak-)fluence < 10 J/cm<sup>2</sup> leads to high efficiency\*



### Influence of pulse duration on surface quality (fs/ps timescale)

For some materials, the pulse duration has a strong effect on surface roughness



For each material: Constant energy input and scan strategy

Reference: Marc Sauer, Florian Jansen, Axel Fehrenbacher, Ulf Quenert, Florian Knaul, Raphael Seidel, Holger Dierker, Chong Yin, Jessica Gries, Patricia Spreng, Benjamin Fuhrer, Christian Ehmhardt, Dirk H. Sutter, and Alessandro Budracco "Microstructuring flexibility by tunable ultrashort pulse duration, pulse-on-demand, and hybrid processing from single pulse to GHz burst with TruArc® Surtec" RE 11267, Laser Applications in Microelectronic and Optoelectronic Manufacturing (LAMBOM) XIV, 112670V (2 March 2022)

7 | Ultrafast laser platform providing dynamic peak power and energy deposition control

Photonics West 2023 ■ Confidential



01/02/2023

12408-35

## Microstructuring in metals using a UV laser microspot scanning system

Auteur(s) Astrid Sassmannshausen

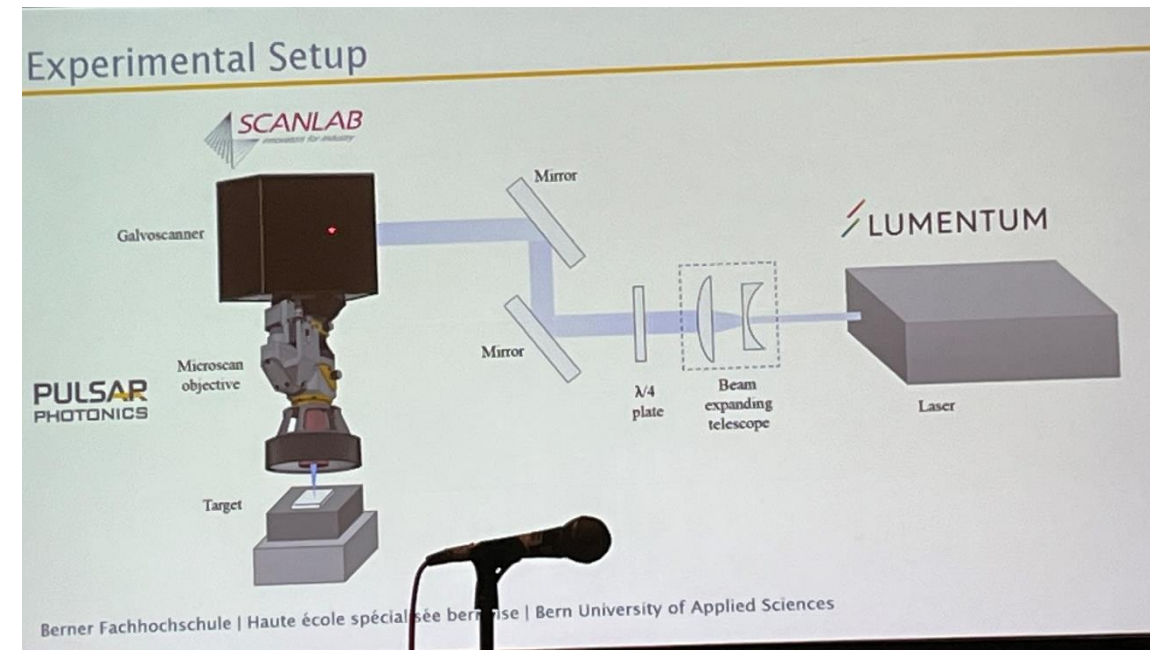
Soc. / Lab. RWTH Aachen (Ger.)

Intérêts • Taille d'impact min pour usinage

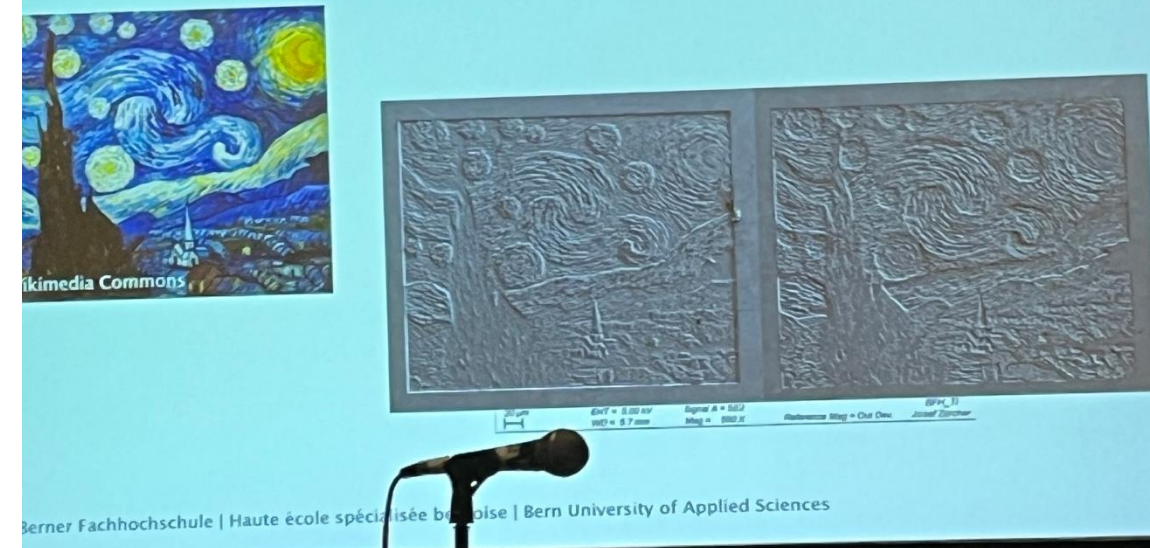
## Informations clés

6 photos

- How small can we reach with single spot ablation
- Laser Lumentum + Microscan 10mm objective UV (Pulsar Photonics)
- Focal spot radius of  $0.78\mu\text{m}$ !
- 1MHz – 40Layers –  $4.4\text{J}/\text{cm}^2$  Switzerland  $400\mu\text{m}$  large
- Percussion drilling  $<1.6\mu\text{m}$  in  $10\mu\text{m}$  foils
- Field microscan :  $500\times 500\mu\text{m}$
- B. Neuenschwander, Physics Procedia 41, 787-794, 2011



## Examples





01/02/2023

12409-24

Laser structuring of electrodes in roll to roll environment using multibeam processing : process upscaling and its perspectives

Auteur(s) Alexandra Meyer

Soc. / Lab. KIT Karlsruhe Institute of Technology (Ger.)

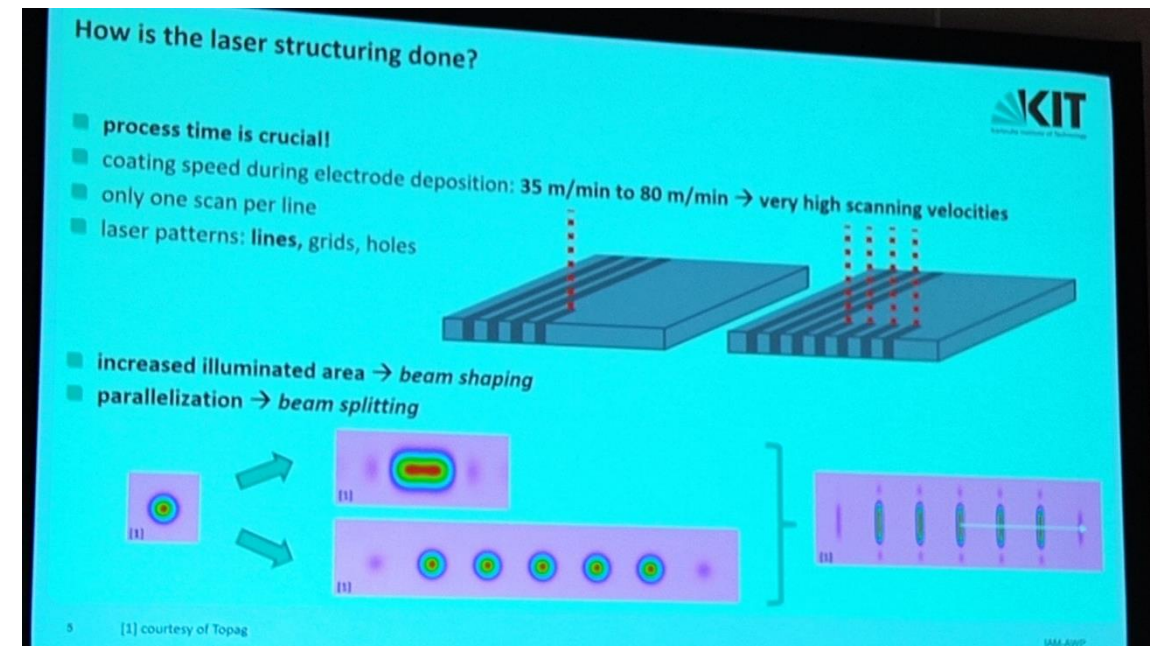
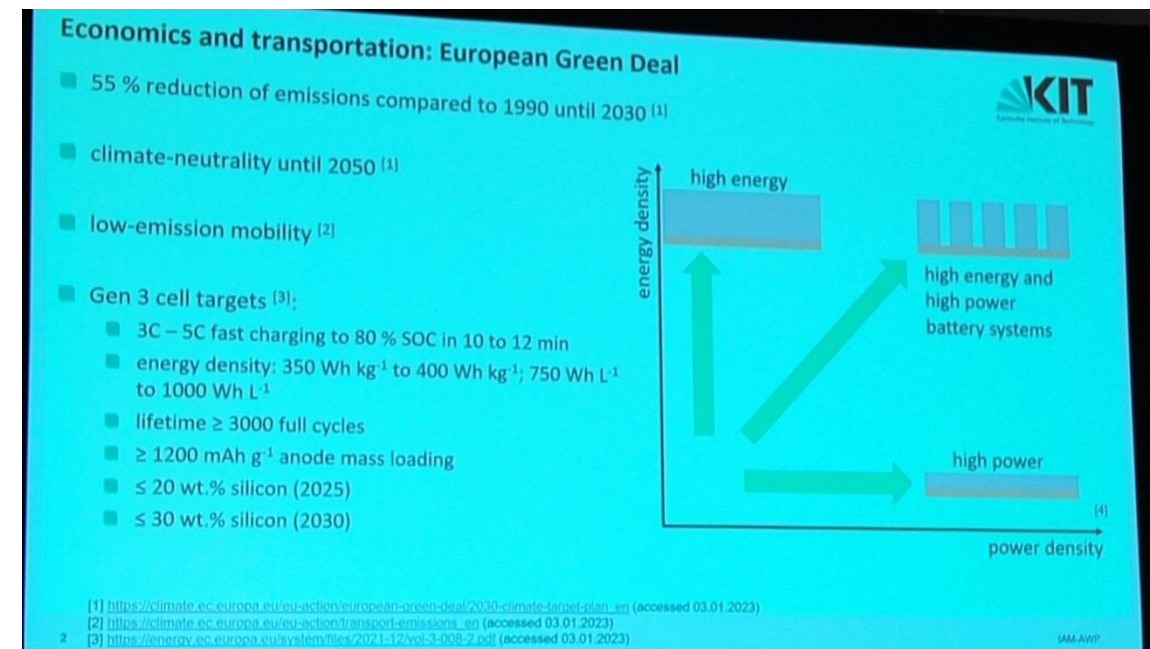
Intérêts

- Thématique batteries
- Upscaling par MEF

Informations clés

- 3 batt next gen project
- USP to PS range to limit thermal effects
- Edgewave FX600 600fs 300W  $M^2 < 1.1$  f420mm 3mm output beam
- 2 setups : one single spot (S1) ; 2 beam shaped (S2 small line ; S3 : same but with beam splitting)
- Several graphs of ablation depths / aspect ratio vs rep.rate & power
- S4 : ps test ; S5 : ns Ghz bursts

8 photos



021/02/2023

Surface functionalisation of transparent materials by selective laser etching

Auteur(s)

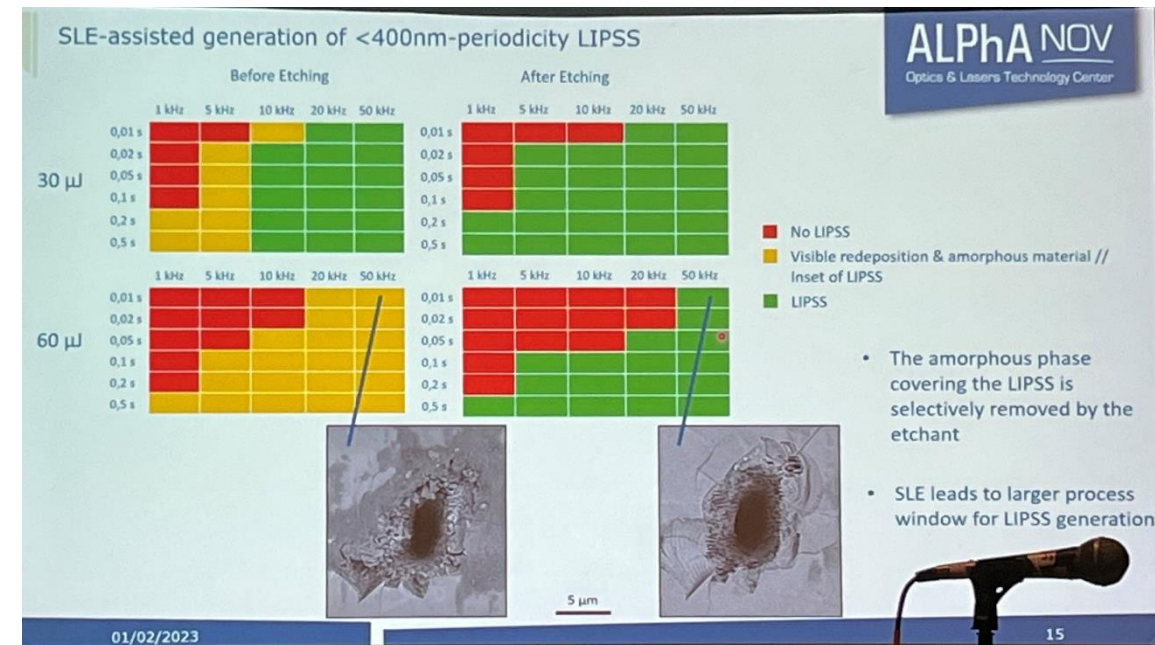
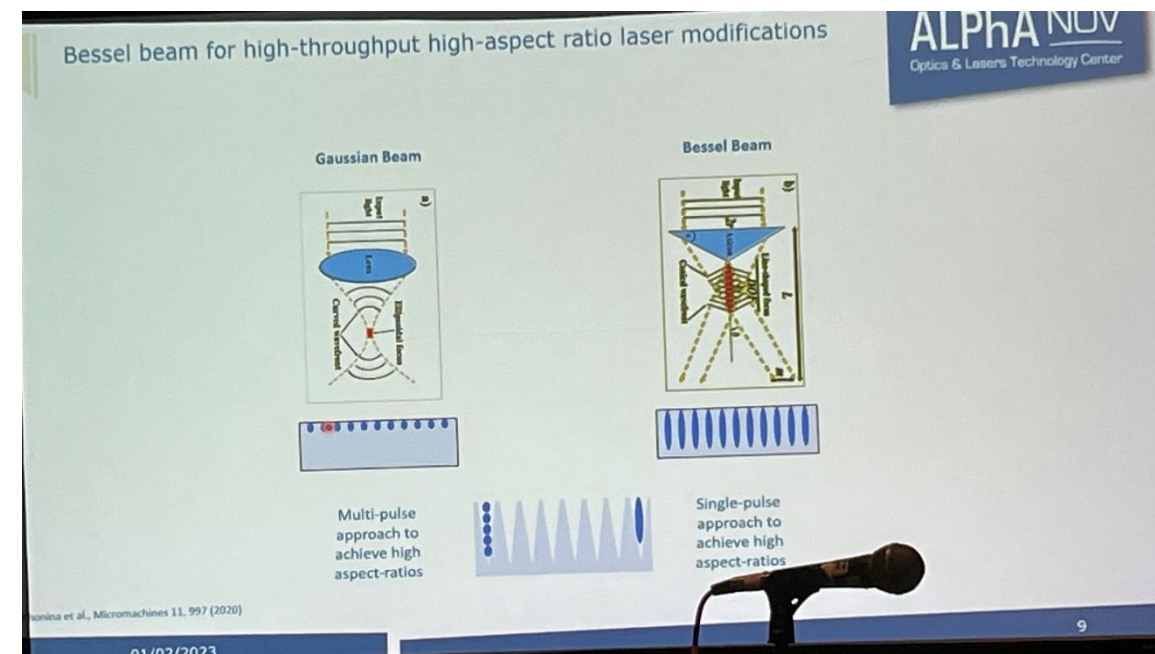
Soc. / Lab. Alphanov

Intérêts • Faisceau de Bessel

Informations clés

5 photos

- Gravure sur saphire à base de faisceaux de Bessel en IR, avec un Yuja.
- Les premières gravures sont plus longues à réaliser que les suivantes.
- Apparition de ripples dans des configurations particulières.
- Process assez long qui ne permet pas de traiter de grandes surfaces





01/02/2023

12409-25

# Laser patterning and electrochemical characterization of thick cathodes for lithium ion batterie

Auteur(s) Penghui Zhu

Soc. / Lab. KIT (Ger.)

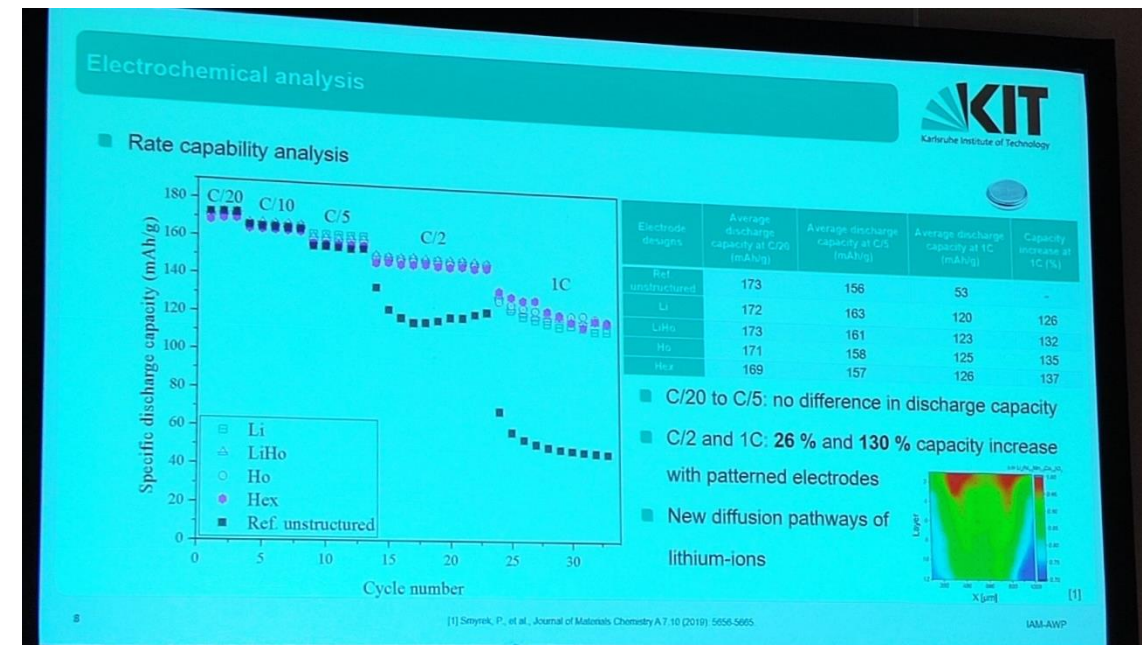
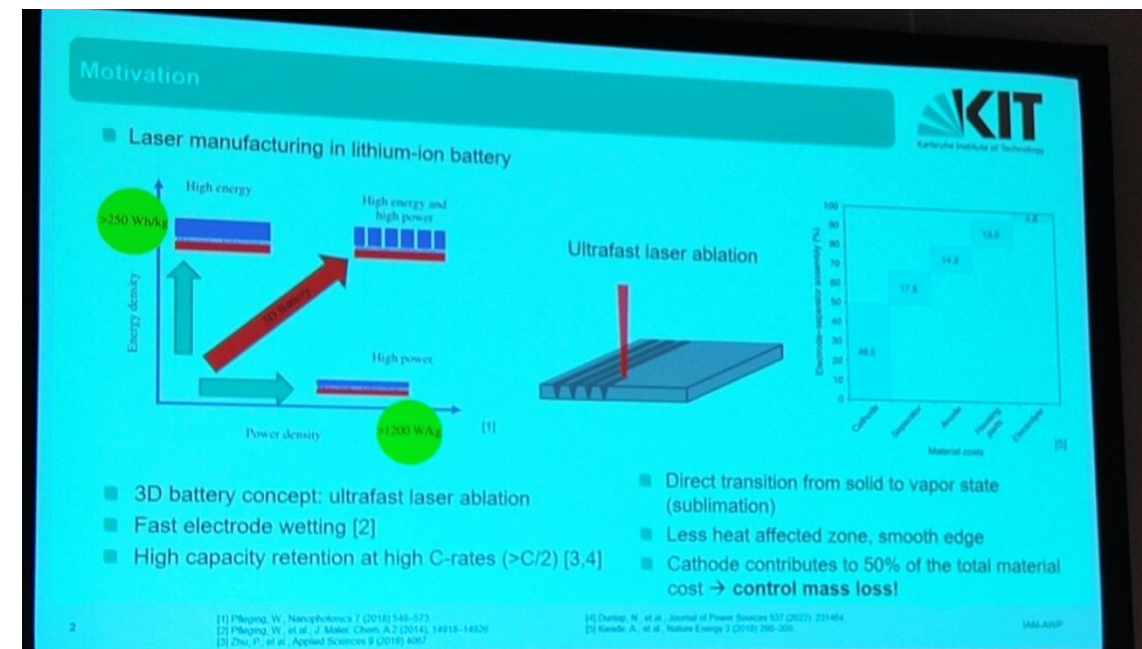
Intérêts

- Thématique batteries
- Impact de l'usinage laser sur l'efficacité

## Informations clés

5 photos

- 3D shaped LI Ion batteries to improve efficiency but be carefull of material loss due to /12 cost of the all battery cost
- NMC 622 cathode thickness state of the art of 40-70 $\mu\text{m}$ . Here 157 $\mu\text{m}$
- Different textures grooves, holes, grooves + holes + hexagones. For grooves : 155 $\mu\text{m}$  deep with around 20 $\mu\text{m}$  large
- Cycling stability tests : no obvious differences with textures but 26% to 130% capacity increase after >15 cycles compared to no texturing. Final grooves + Holes more efficient after more cycles (>100)
- Smyrek et al. Journal of materials A 7 10 2019 5656 5665
- New project Bat-Wo-Man



01/02/2023

12409-27

## High throughput battery foil cutting : a comparison of different pulse laser approaches

Auteur(s) Daniel Murillo

Soc. / Lab. Trumpf (Ger.)

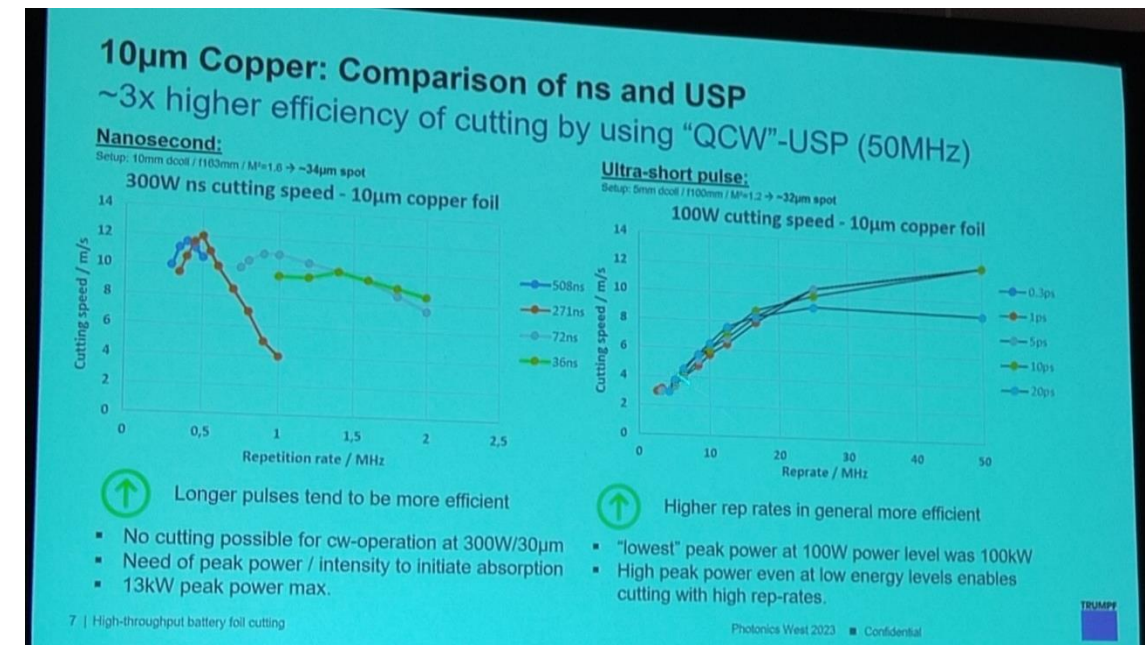
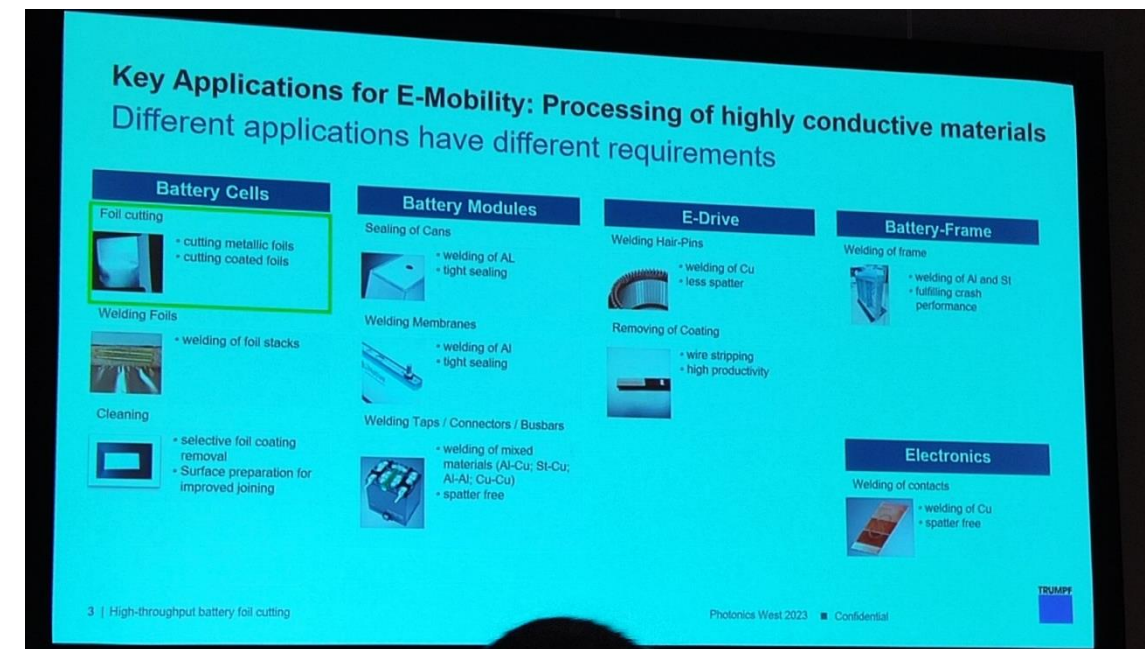
Intérêts

- Foil cutting for batteries

### Informations clés

4 photos

- Laser cutting of foils : ns vs fs vs ps vs burst
- 10 $\mu$ m copper foils : 3x higher efficiency with « QCW » mode USP (50MHz), <10ps, 32 $\mu$ m spot ; 8 to 50MHz, better qualitative appearance
- For copper + graphite anode : ns cut faster (3m/s) high rep rate USP do not provide high quality but recast / melting
- Aluminium + LFP cathode : 3ps faster vs ns ; better quality at 50kHz





01/02/2023

12409-29

Extending the 3D battery concept large area USP  
structuring of multilayered electrode coatings

Auteur(s) Yannic Sterzl

Soc. / Lab. KIT (Ger.)

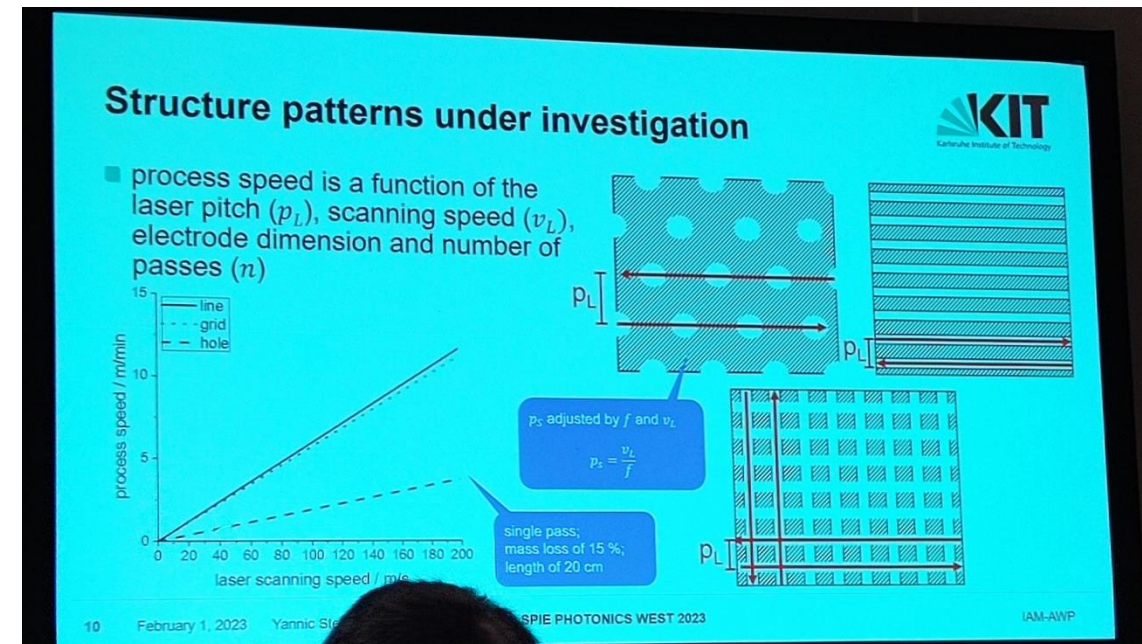
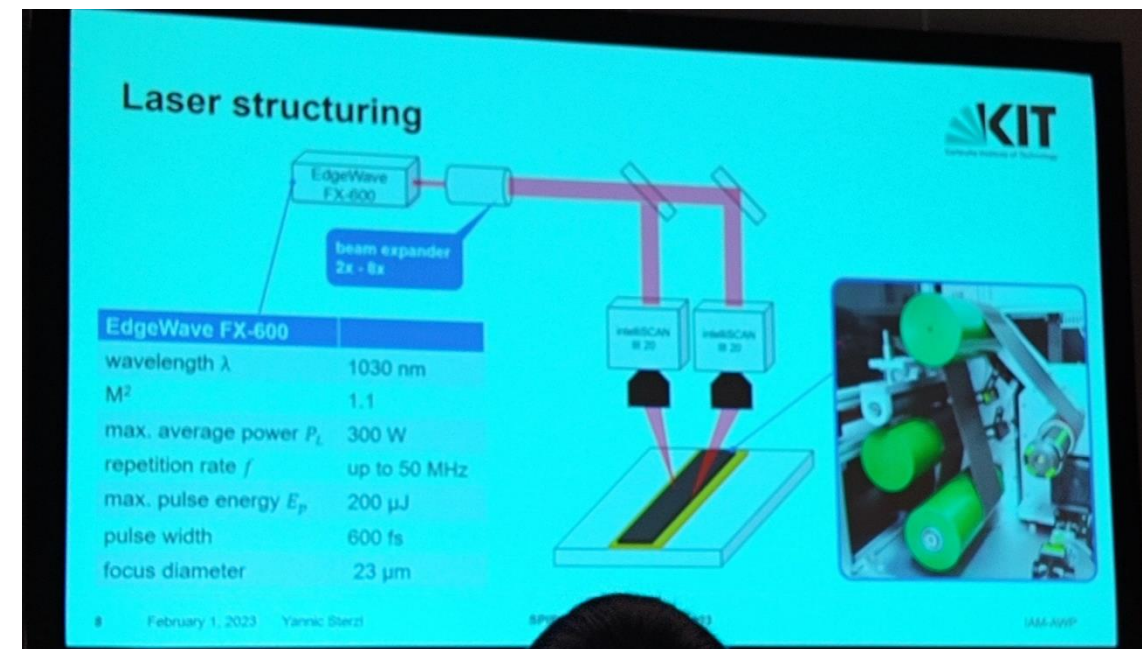
Intérêts

- Application batteries
- Roll to roll high speed x2 tête

Informations clés

6 photos

- LIB : Lithion Ion Battery
- Laser Texturing of électrodes to enable multiple material composites
- EdgeWave FX600, roll to roll. 2 parallel scanners
- Compromise : texturing type / matter loss / speed



01/02/2023

12408-38

## Precision Figuring and Finishing of Glass Using Femtosecond Lasers

Auteur(s)

Soc. / Lab. Rochester Institute of Technology (US)

Intérêts • Polissage

### Informations clés

1 photos

- 2 types d'usinage pour faire du polissage, ablation ou soudure. Ils essayent par le calcul de trouver les limites de taux d'ablation, ainsi que la température associée aux process, afin de déterminer la meilleure paramétrie pour enlever le plus délicatement de la matière, et du coup diminuer le Ra.

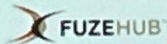
**QIAO LAB**

**Contributions**



- Demonstrated, for the first time, simultaneous femtosecond laser figuring and polishing of glass, achieving sub-nanometer surface quality
- Established a dynamic pulse propagation model to predict ablation and temperature evolution
- Identified energy density as a metric to scale up the process

**The demonstration of simultaneous figuring and finishing of the glass is opening the path for fabricating freeform and complex optics using ultrafast lasers**



**NSF IIP-1822049 and IIP-1822026**

**JIE QIAO: jxqpci@rit.edu**

14



01/02/2023

12409-31

Direct laser interference patterning of cemented tools

Auteur(s)

Soc. / Lab.

Intérêts

Informations clés

*photos*

01/02/2023

12414-2

High energy ultrafast surface texturing with variable multispot pattern

Auteur(s) Daniel Flamm

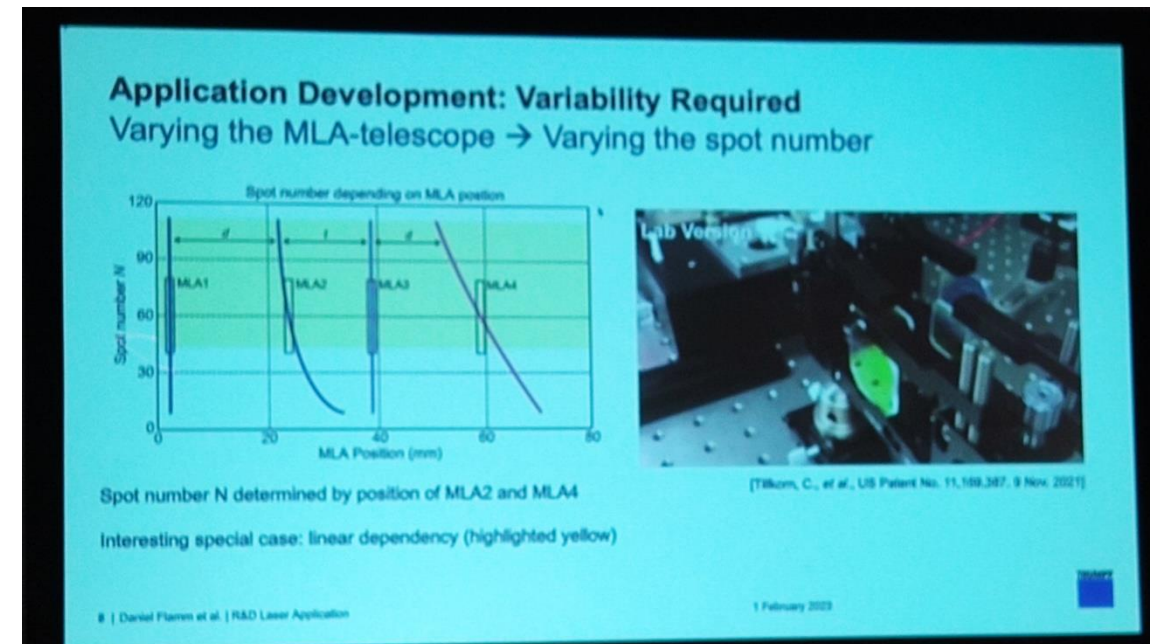
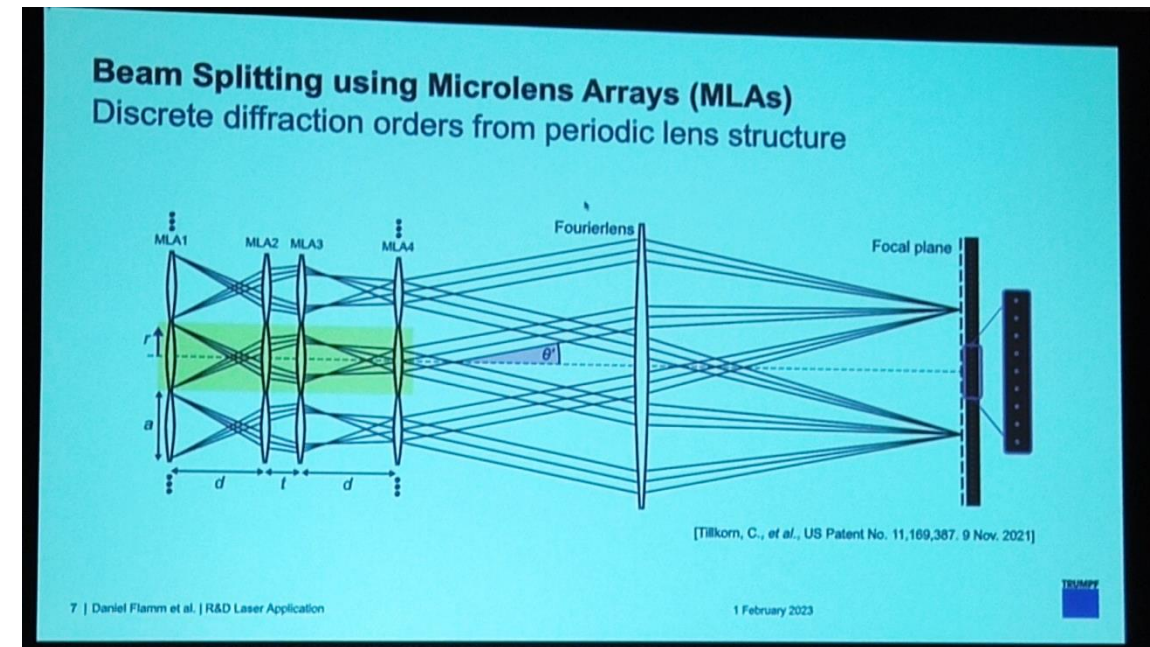
Soc. / Lab. Trumpf (Ger.)

Intérêts • Nouvelle technique de beam splitting

## Informations clés

4 photos

- Opt Engineering 60 2 025105 2021
- MLA microlens arrays used generally as homogeneizers for UV lasers can be used as multispot.
- Coupling of 4 MLAs with relative movements + fourrier lens gives the possibility to play with the number of dots visible (up to a hundred)
- Add of a birefringent cristal to add spot inbetween existing. Crossed polarized to avoid interferences.





01/02/2023

12409-30

GHz burst mode processing: ablation, LIPSS, TPP, LIPAA

Auteur(s)

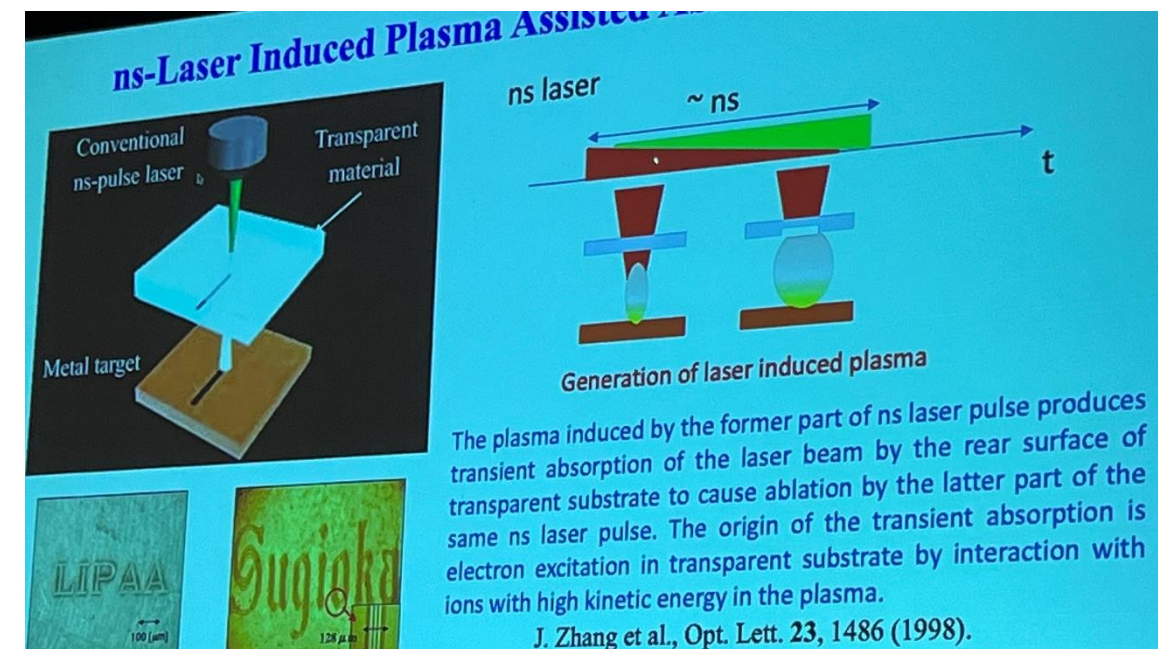
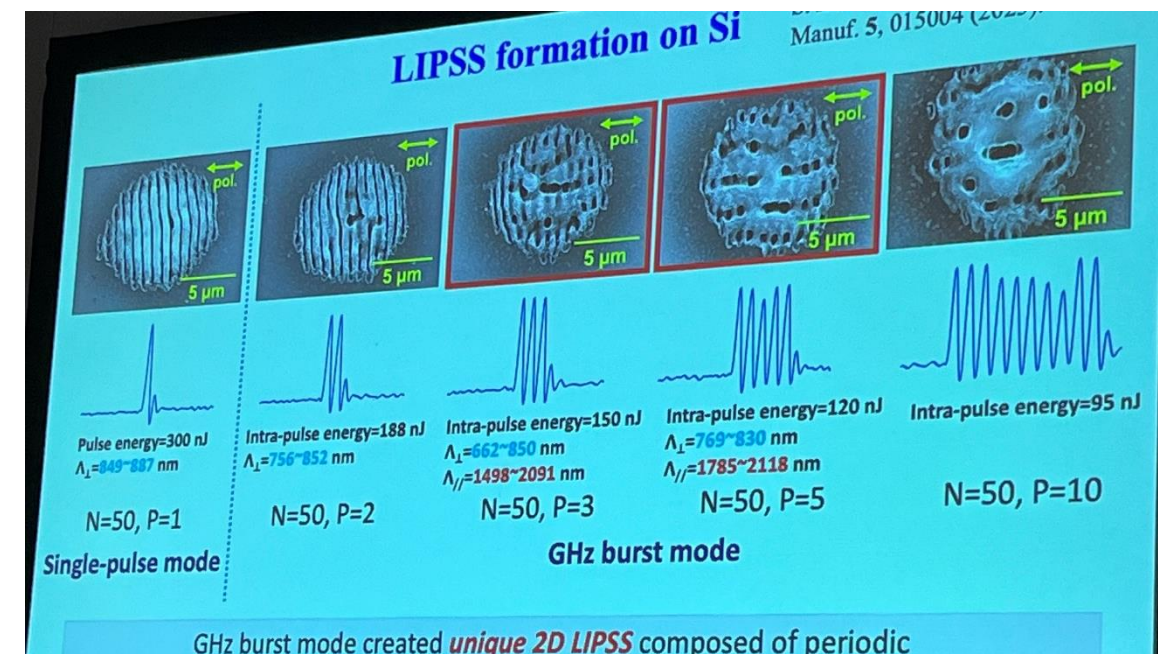
Soc. / Lab. RIKEN Ctr (Japon)

- Intérêts
- GHz Burst
  - LIPSS

Informations clés

- Amélioration du taux d'ablation en Burst GHz, el LIPAA Laser Induced Plasma Assisted Ablation

3 photos





## Laser structured électrodes for battery production

Auteur(s) Beat Neuenschwander

Soc. / Lab. Bern university (Ger.)

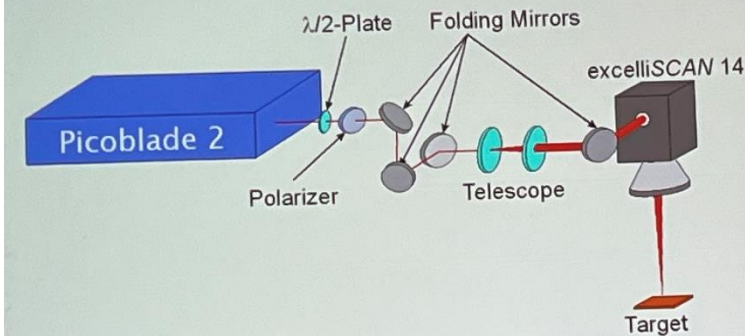
Intérêts • Usinage classique

## Informations clés

- Plusieurs texturations : trous, trous rapprochés, rainures
- Espacements 60µm et 30µm et largeurs d'usinage /2.
- Laser IR et Vert, ps
- structuration de lignes est le plus performant dans le cadre de recharges lentes

11 photos

## Experimental Set-Up

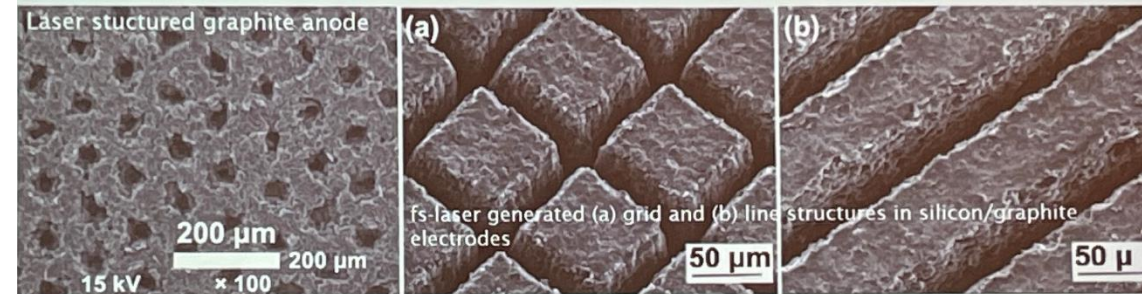


- Picoblade 2 / FUEGO
  - $\Delta\tau = 10\text{ ps}$
  - $P_{av} = 40\text{ W}$
  - $f_r = 200\text{ kHz} - 8\text{ MHz}$
- $\lambda = 1064\text{ nm}$ 
  - excelliSCAN14
  - $f_{obj} = 160\text{ mm}$
  - $w_0 = 16.0\text{ }\mu\text{m}$ ,  $M^2 = 1.4$
- $\lambda = 532\text{ nm}$ 
  - intelliSCAN14se
  - $f_{obj} = 160\text{ mm}$
  - $w_0 = 11.0\text{ }\mu\text{m}$ ,  $M^2 = 1.5$

Bern University of Applied Sciences | ALPS | I3S

SPIE. PHOTOWEST

## Laser Structured Electrodes



W. Pfleging, "Recent progress in laser texturing of battery materials: a review of tuning electrochemical performances, related material development and prospects for large-scale manufacturing", Int. J. Extrem. Manuf., 3, (2021), 012002

- W. Pfleging at KIT demonstrated that the specific discharge capacity can significantly be improved by laser structuring of the electrodes.
- Perform own tests to evaluate this technology.

Bern University of Applied Sciences | ALPS | I3S

SPIE. PHOTOWEST



## Forming of metal sheets textured by LIPSS

Auteur(s) Girolamo Mincuzzi

Soc. / Lab. Alphanov (Fr.)

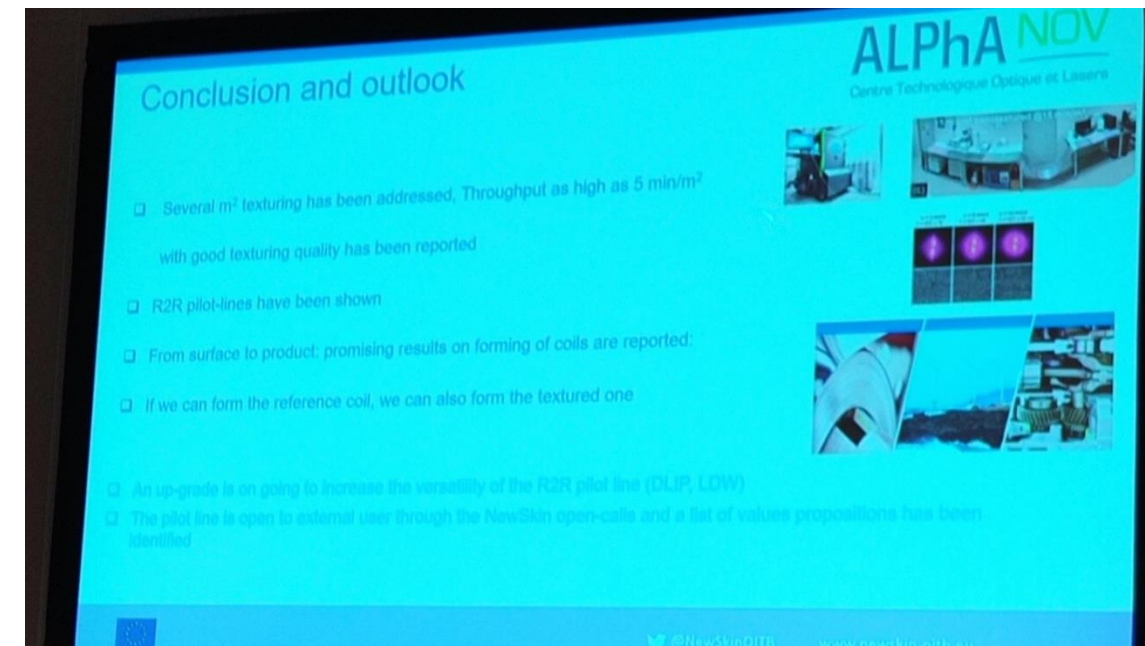
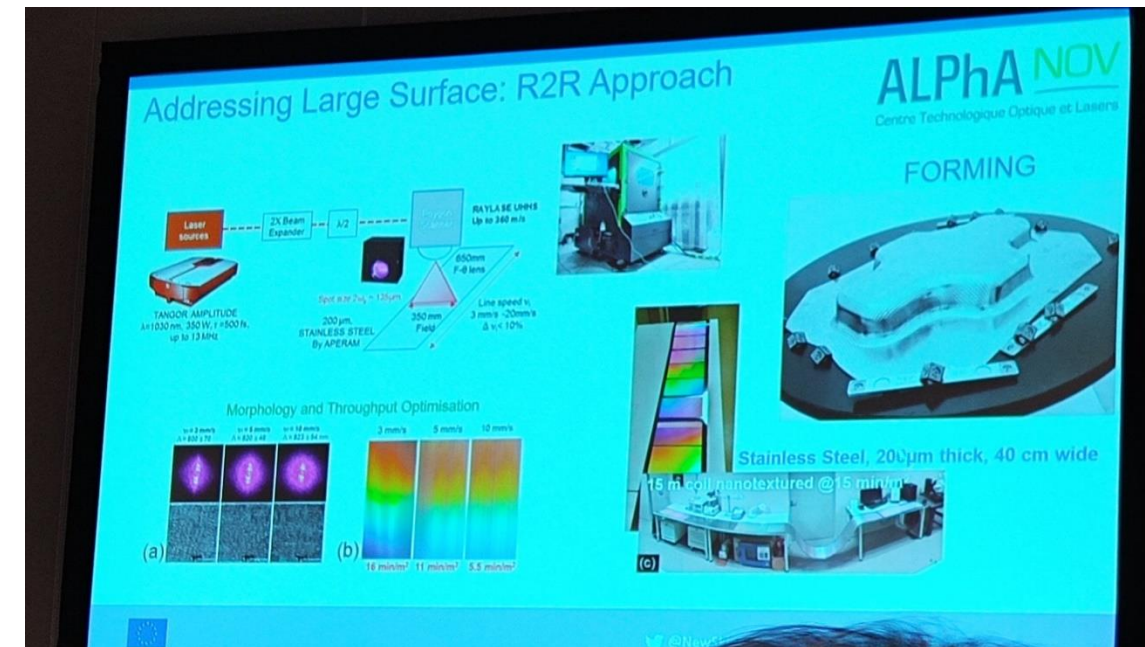
Intérêts

- Texturation Ripples par polygone & Roll to Roll

## Informations clés

3 photos

- Par rapport à l'année dernière, ajout de l'étude des ripples sur la mécanique des foils 250µm d'épais.
- Tests de traction / fatigue des échantillons texturés. Impact de l'orientation des ripples en fonction du sens de l'étirement. Pas de différence significative notée.





01/02/2023

12408-53

Radial scanning strategies leading to substantial improvements in processing time

Auteur(s) Dominic Von Bergen

Soc. / Lab. Berner Fachhochschule Tech. & Info. (Suisse)

Intérêts

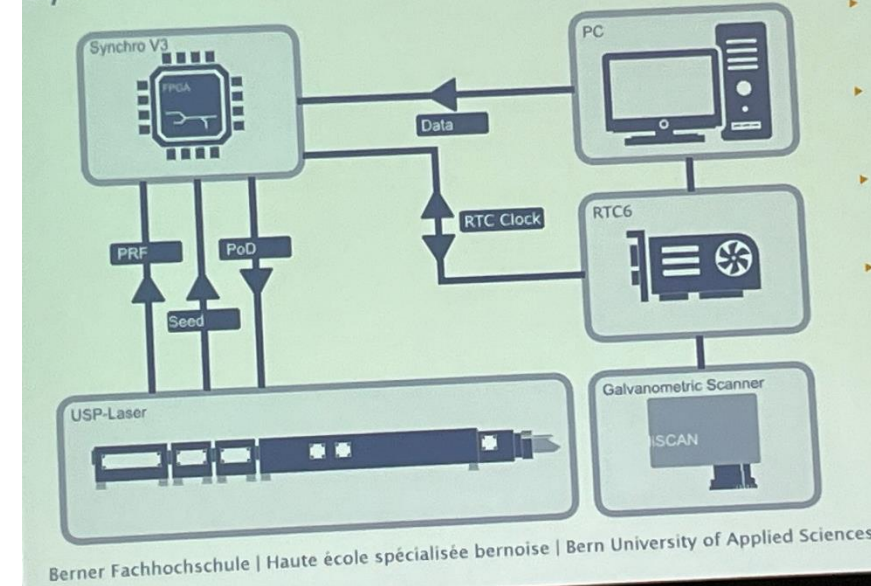
- Synchro laser et nouvelle méthode d'usinage

## Informations clés

8 photos

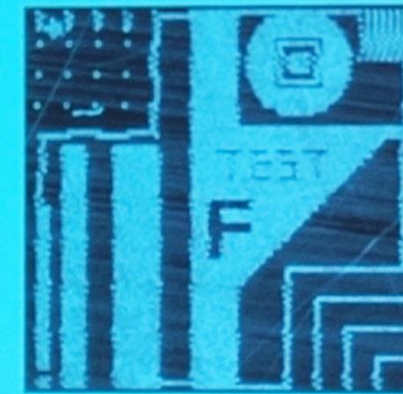
- Dev d'une carte de pilotage en interne pour la synchro mais manque d'efficacité a cause des temps mort de va et vient sur une trajectoire scanner
- Nouveau concept de pilotage par cercles concentriques ou spirale. Fait suite aux pertes de temps lors d'une trajectoire scanner
- Défauts notables : cercle minimum (res scanner), gestion de la position des pixels, vitesse de rotation accessible vs RR utilisé, trajectoire de redémarrage après chaque cercle, répartition uniforme des points en s'éloignant du centre d'une spirale...

## System Overview - Synchronization

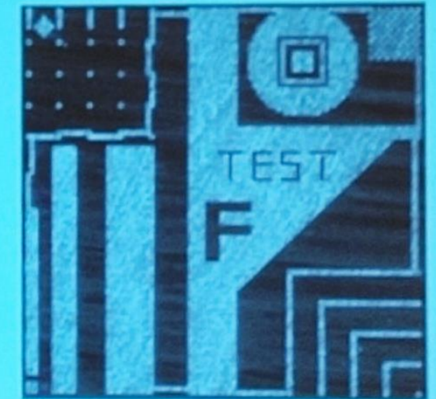


- ▶ Synchro V3:
  - ▶ Clocked with the laser clock
  - ▶ Generates the clock for the RTC-Card (Movement)
  - ▶ Synchronizes the laser pulses to the movement
  - ▶ Controls the laser

## Synchronization



Without synchronization



With synchronization

Berner Fachhochschule | Haute école spécialisée bernoise | Bern University of Applied Sciences

5



01/02/2023

12409-34

## Initial surface roughness influence on the generation of LIPSS on Ti and SS and their effect on Cell/bacteria viability

Auteur(s) Lamborghini Sotelo

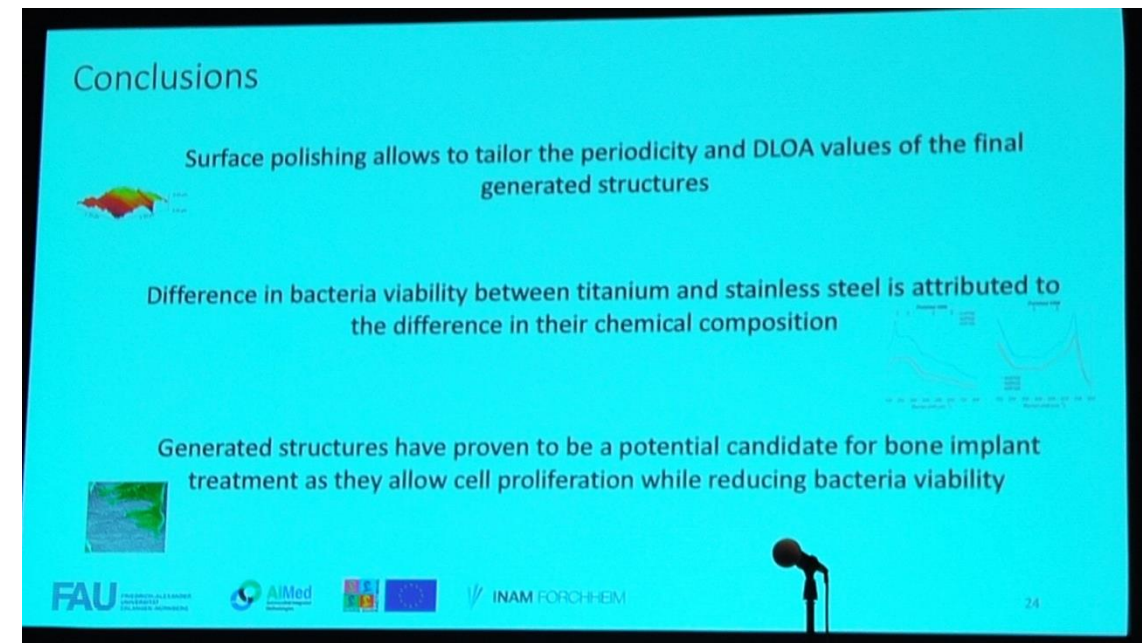
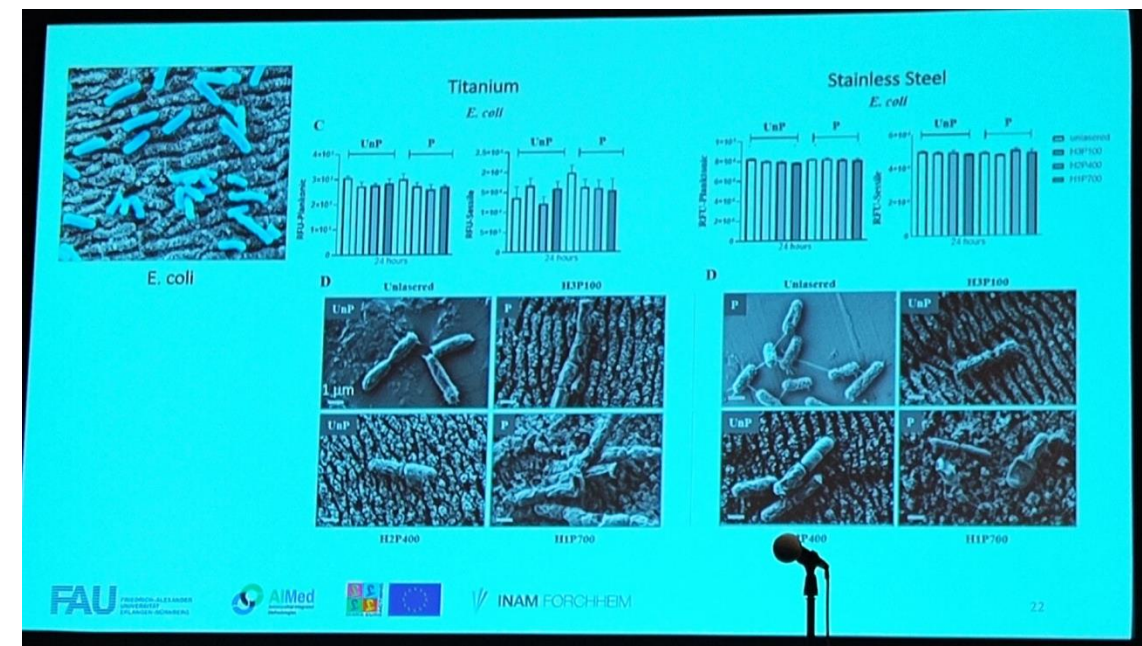
Soc. / Lab. AIMED (Ger.)

Intérêts • Impact des textures ripples sur les bactéries

### Informations clés

2 photos

- Impact of polishing/RA on wettability / lipss formation on Ti and SS. No clear effect
- On cells : impact
- Question : Blood rather than water for wettability tests in the context of medical applications?





01/02/2023

12409-35

Vizualisation of LIPSS beyond optical resolution by non invasive optical method

Auteur(s) Jose Alberto Aguilar Mora

Soc. / Lab. XLIM (Fr.)

Intérêts • Participation de Manutech

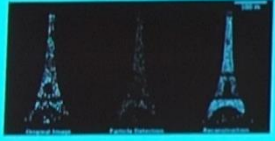
## Informations clés

5 photos

- New technic based on confocal microscopy
- Resolution below 100nm, interesting for LIPSS observation
- Demo with NA 1.37
- Use as a standard microscope, so implemenable with other microscopic technics.
- More adapted to reflective materials

### Super resolution for LIPSS

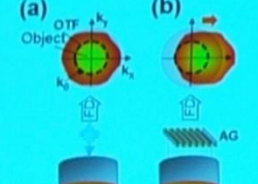
#### Super-resolution microscopy



STED or STORM can reach up to 40 nm

They need to modify the sample with fluorophores

#### Structure illumination microscopy



Resolution down to 170 nm

Aguilar, A et al In-situ high-resolution visualization of laser-induced periodic nanostructures driven by optical feedback. Scientific Reports, 7(1), 1-10.

### Conclusion

- An increment of x2 is obtained in the lateral resolution
  - Up to 96 nm resolution @  $\lambda=450$  nm
- Label-free super-resolution
  - Biological samples
  - Metallic samples
  - In-vivo imaging
- Acquisition speed is limited only by the scanner
- Possibility of in-situ analysis for feedback

Thank you for your attention !



**Alberto Aguilar**  
Jose-alberto.Aguilar-mora@cnr.fr  
Paper in revision

Aguilar, A., Abou Khalil, A., Aldeiturriaga, D. P., Sedao, X., Maclair, C., & Bon, P. (2023). Nondestructive inspection of surface nanostructuring using label-free optical super-resolution imaging.



## Dynamics of development of LIPSS on Ti alloys

Auteur(s) Hans Hamler

Soc. / Lab. Photon Energy (Ger.)

Intérêts

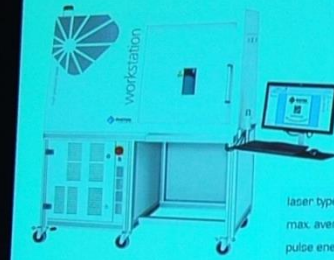
- Nouveau laser femto non référencé
- Spikes et Lipss paramétrage

## Informations clés

- Analysis of parameter windows at 12ps on Ti Alloys
- CEO Photon Energy

7 photos

### Ultrashort pulse laser – Cepheus



**Parameters of laser light**

|                                      |                                               |
|--------------------------------------|-----------------------------------------------|
| laser type                           | modelocked, pulse pickad Nd: YVO <sub>4</sub> |
| max. average power (with burst mode) | 16W @ 500kHz                                  |
| pulse energy (single pulse)          | 120μJ @ 100kHz                                |
| pulse duration                       | < 15ps                                        |
| frequency range (internal control)   | 20kHz ... 500kHz                              |
| frequency range (external control)   | single shot – 500kHz                          |
| beam quality                         | TEM <sub>00</sub> (M <sup>2</sup> < 1.5) **   |
| cooling                              | air-cooled                                    |
| dimensions laser head (L x W x H)    | 480mm x 302mm x 200mm                         |

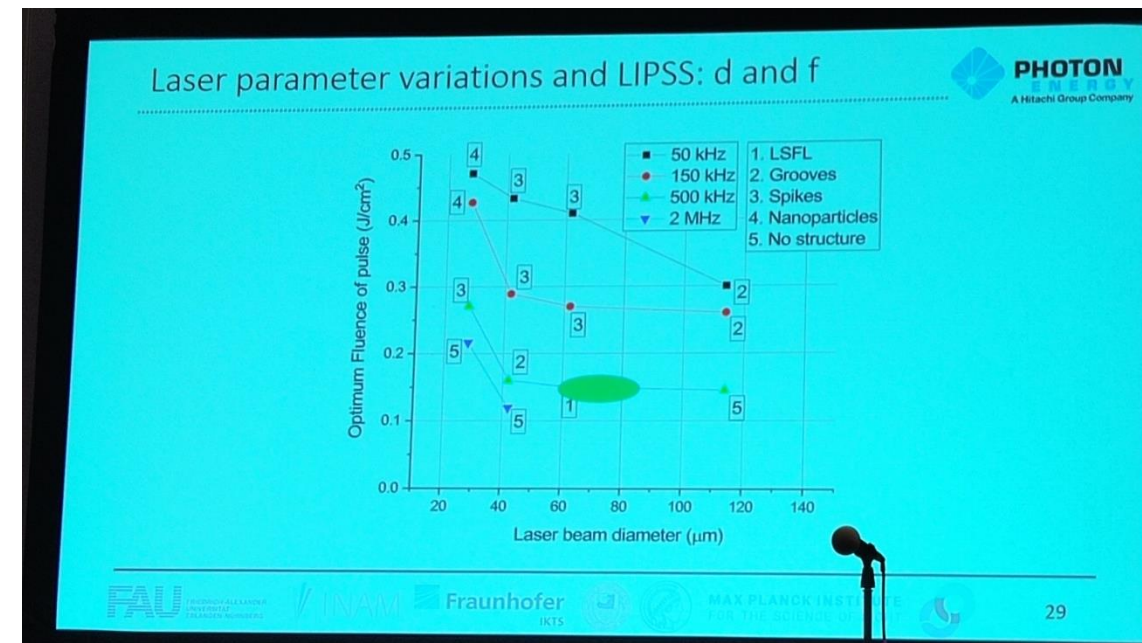
All data are typical values. \*\* typically M<sup>2</sup> < 1.3

**TAURUS**

Pulse energy: > 10mJ (bis 1MHz)  
Puls duration: < 750fs – 10ps (einstellbar)  
Puls frequency: – 3MHz  
Wavelength: 1030nm

- high single pulse energy up to 300μJ @ 20 kHz
- optional:
- high burst energy up to 450μJ
- frequency range up to 1000kHz
- SHG, THG
- safety shutter

FAU FRIEDRICH-ALEXANDER UNIVERSITÄT ERLANGEN-NÜRNBERG INAM Fraunhofer IKTS MAX PLANCK INSTITUTE FOR THE SCIENCE OF LIGHT





01/02/2023

12408-54

Ultrafast ablation dynamics of Cu by single pulse and GHz fs laser

Auteur(s)

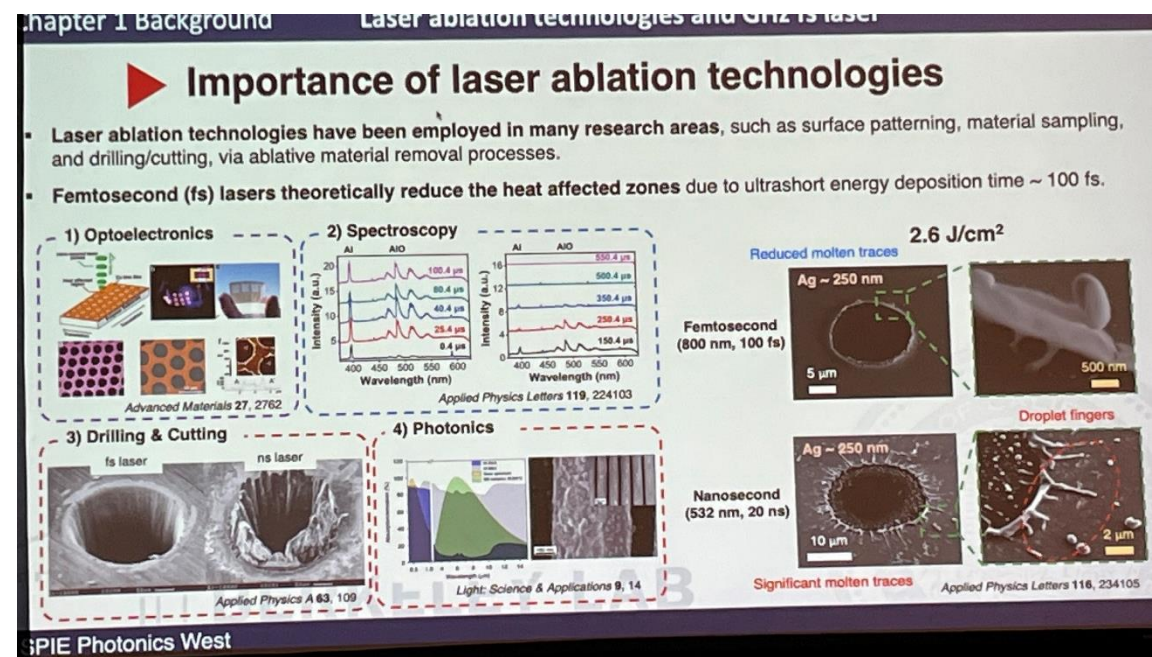
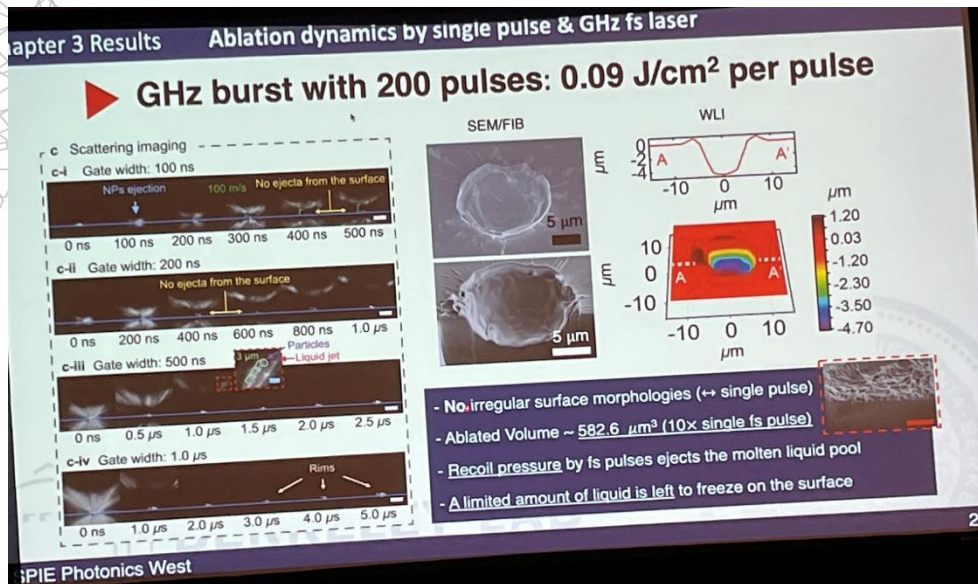
Soc. / Lab. Lawrence Berkeley National Lab

Intérêts

- GHz Burst

Informations clés

10 photos





01/02/2023

12414-10

Real time holo 3D beam manipulation for USP processing

Auteur(s) Bastian Kaiser

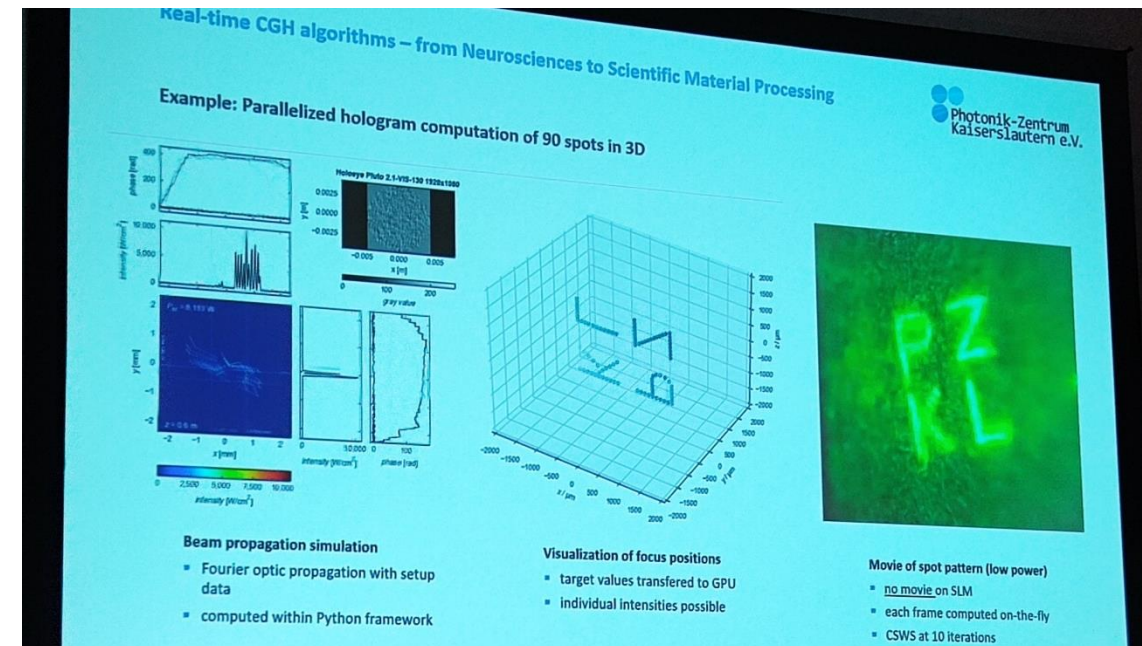
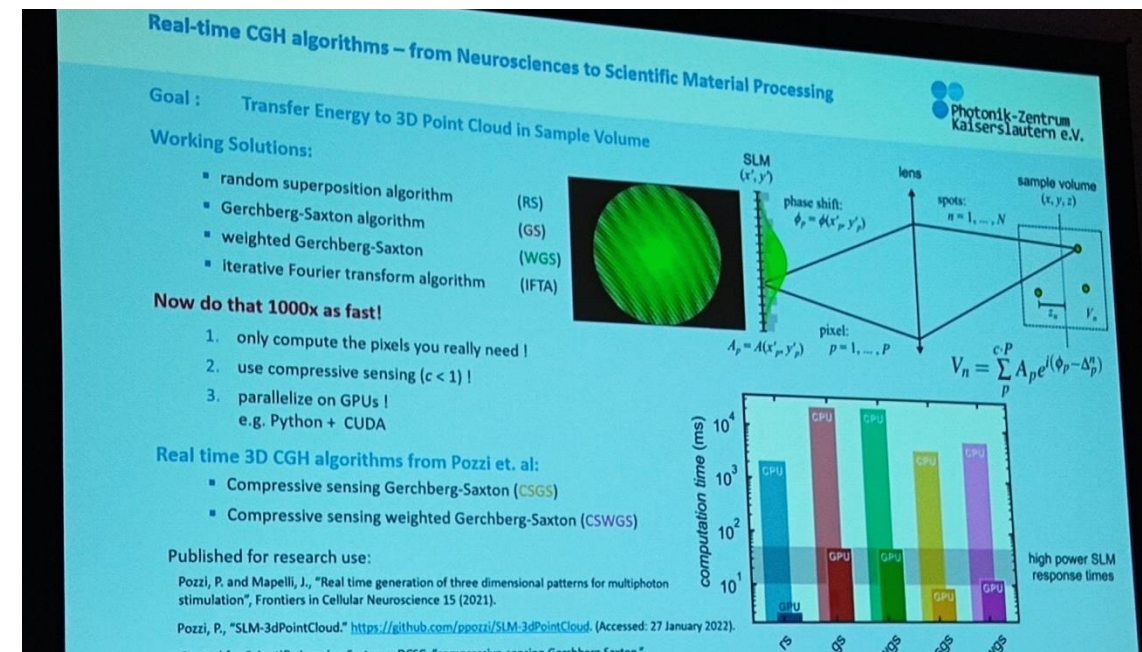
Soc. / Lab. Photonic Center Kaiserslautern (Ger.)

Intérêts • MEF 3D SLM Haute vitesse

Informations clés

3 photos

- High speed CGH. : compute only required pixels + compression + parallelization (CSGS – CSWGS) Pozzi 2021
- Holoeye SLM
- Demo movie on the fly calculation of 3D hologram spot Text
- 10it ~50ms. Test of marking to compare calculation speed vs liquid cristal response. Ok!
- Zero order is here





01/02/2023

12414-11

UV and IR fs laser irradiation on PET and PA66 textiles for liquid repellent clothing

Auteur(s) XXX Sedao

Soc. / Lab. LaHC (Fr.)

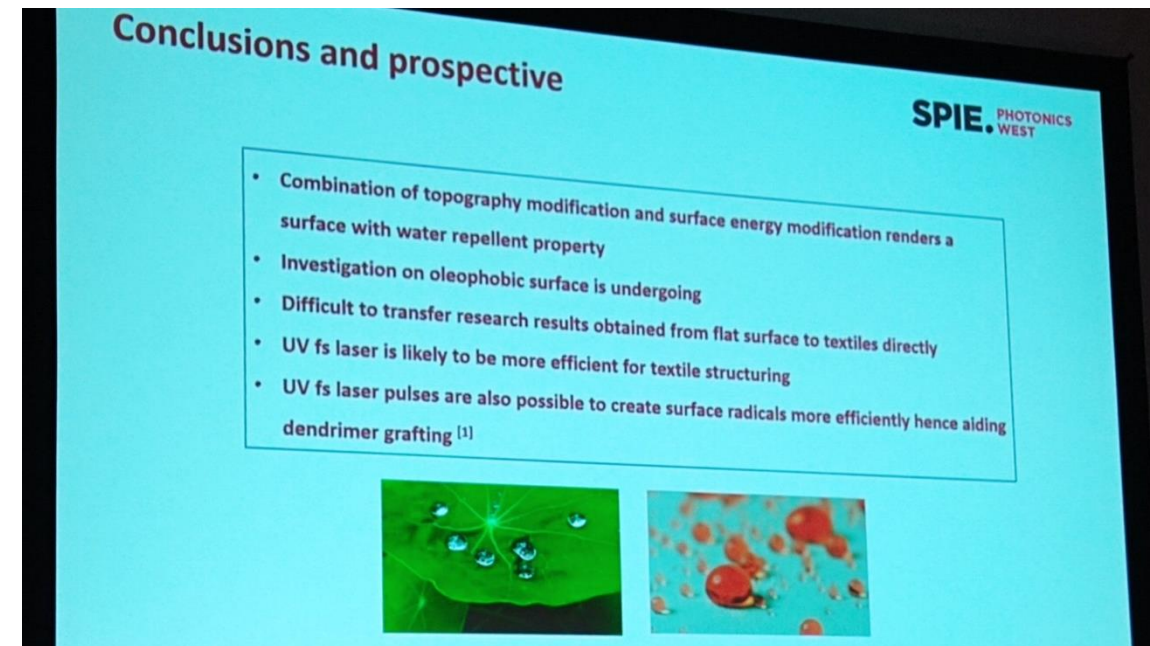
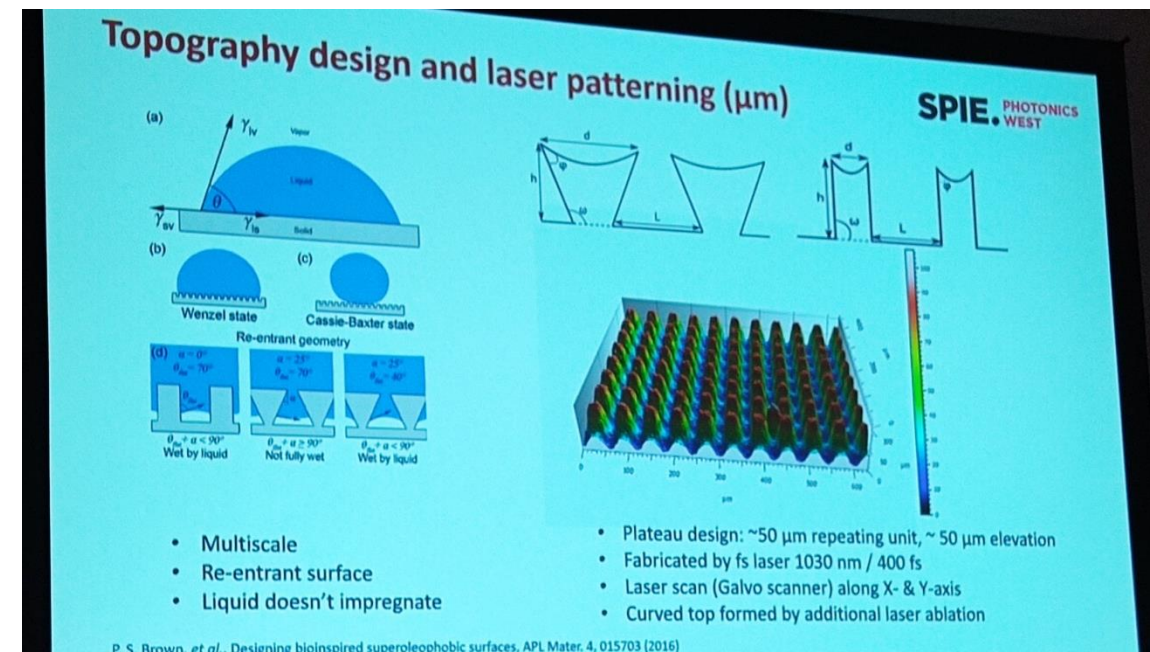
Intérêts

- Participation de Manutech
- Deperflex

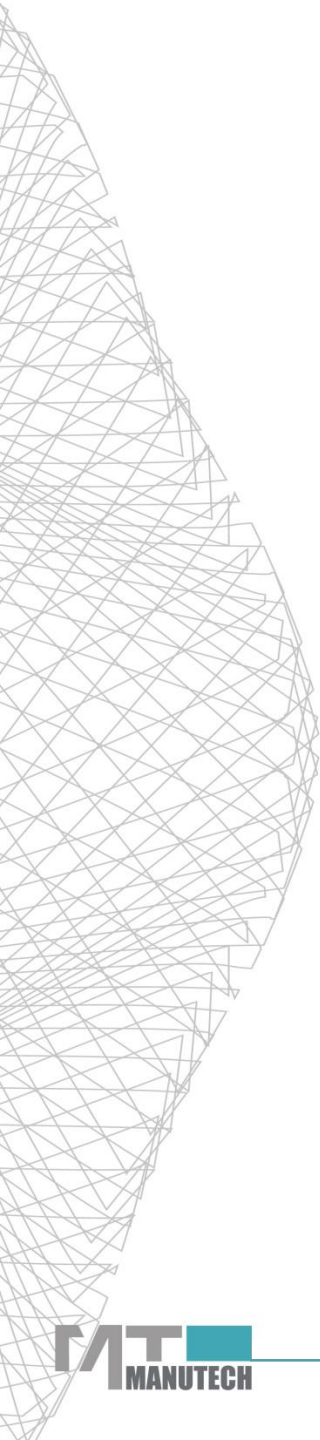
## Informations clés

- Deperflex
- Water repellent surfaces 10µm peaks in nature.
- Optimized Hydrophobicity when inverted peaks
- Laser texture + dendrimer = superhydrophobic
- Transfer to fabrics (maillage) : damage of mechanical strength, touch and appearance => Not acceptable
- Water penetration time on the textile increase with textile + dendrimer + texturing

3 photos







Jeudi 02-02-2023

02/02/2023

12409-38

kW level USP lasers for high rep. Rate drilling of airplanes structures

Auteur(s) Emeric Biver

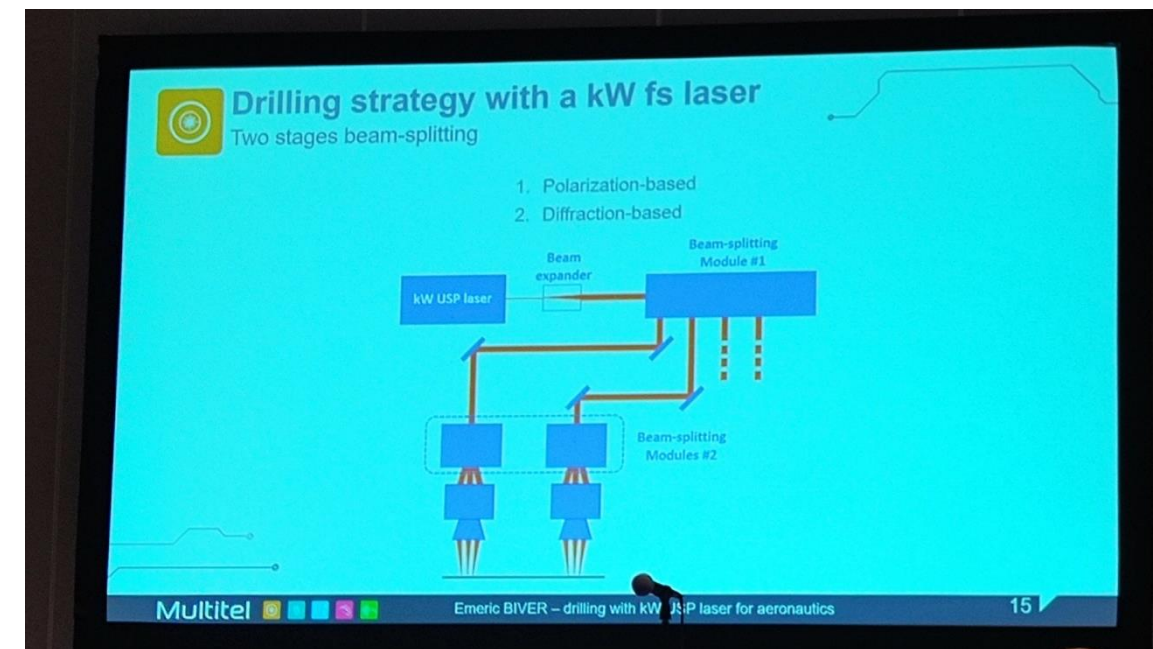
Soc. / Lab. Multitel (Bel.)

Intérêts • kW + Split + Multi-têtes + DOE

## Informations clés

- Multipoint EU project
- kW femto laser (amplitude) for aeronautic drilling applications
- Better quality with trepanation but much longer
- 570fs – 7mJ
- 2 splitting modules : one for different optical paths, one just before focusing : DOE. Multitel developped the splitting strategy based on polarisation
- Machine 2m width (Lasea + Tekniker)
- Standard scanner : Laser. High pressure assisted gas scanner : Tekniker
- 500µm Ti foils : 15s / 5 holes
- Questions : DOE transmission (15% losses)

7 photos



**kW-level USP lasers for high-rate drilling of airplane structure**

- Process preliminary conclusions:
  - Limit Ti oxidation (inert atmosphere)
  - Optimize beam management: TREPPANNING > PERCUSSION
- Laser with output power > 1 kW
  - In practice, P < 1 kW for better beam quality
- High-speed drilling machine
  - Two-steps beam-splitting strategy
  - Handling kW-level USP laser beam
  - Live control of drilling process
- Final steps:
  - Complete the integration
  - Study higher fluence regime: thermal vs. ablation processes
  - Optimize drilling speed vs. hole quality

Logos: Tekniker, BURULAN, AERINNOVA, Prosumertab, LASEA, Amplitude.

Footer: MULTIPOINT, Multitel, LPM22 – 8th June 2022, 27



# Thermal accumulation and its threshold repetition rate in ultrafast laser materials processing

Auteur(s) Xin Zhao

Soc. / Lab. Clemson Univ (USA)

Intérêts

- Temps de relaxation matériaux et accumulation thermique

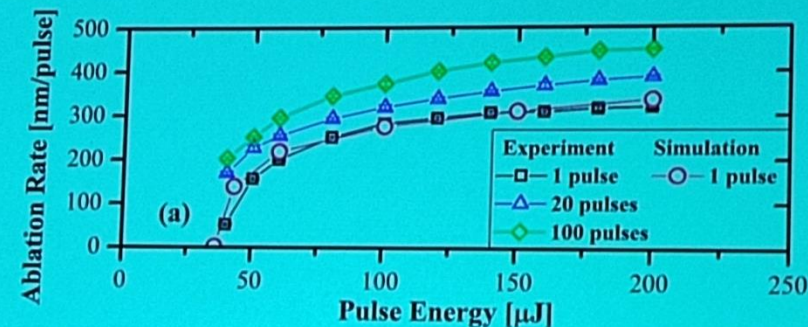
## Informations clés

- Laser 190fs, fused silica
- 2 temperature model
- First step : valence => conduction few fs, then valence excitation => heating
- With thermal accumulation : increase of ablation rate even at low rep. Rate. Then >100Hz, increase of heat and even more ablation rate
- Thermal relaxation ms range : fit with heat influence at 1kHz
- 10kHz : increase of temperature
- Copper : >1MHz thermal accumulation occurs (very different from glass)
- Thermal diffusivity is the number one factor for thermal diffusion

9 photos

## Ablation rate

- Ablation increases with pulse number
- Incubation effect
- Model validation



## Threshold repetition rate prediction

➤ TTM

➤ Simple thermal diffusion model:

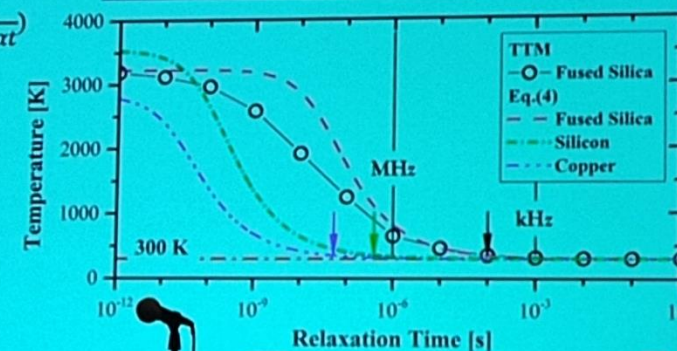
$$\Delta T_0(t, z) = \Delta T_0 \left( \frac{l_z^2}{l_z^2 + 4at} \right)^{0.5} \exp\left(-\frac{z^2}{l_z^2 + 4at}\right)$$

$\Delta T_0$ : maximum temperature change

$l_z$ : thermal penetration depth

$\alpha$ : thermal diffusivity

| Parameters                    | Fused Silica | Copper | Silicon |
|-------------------------------|--------------|--------|---------|
| $\alpha$ [mm <sup>2</sup> /s] | 0.85         | 111    | 88      |
| $T_m$ [K]                     | 3223         | 2833   | 3538    |
| $l_z$ [nm]                    | 326.5        | 150    | 200     |



M. Shimizu et al, J. Appl. Phys. 108, 073533 (2010)



02/02/2023

12409-40

High speed processing with ultrafast lasers and resonant scanning systems

Auteur(s) Bastian Kaiser

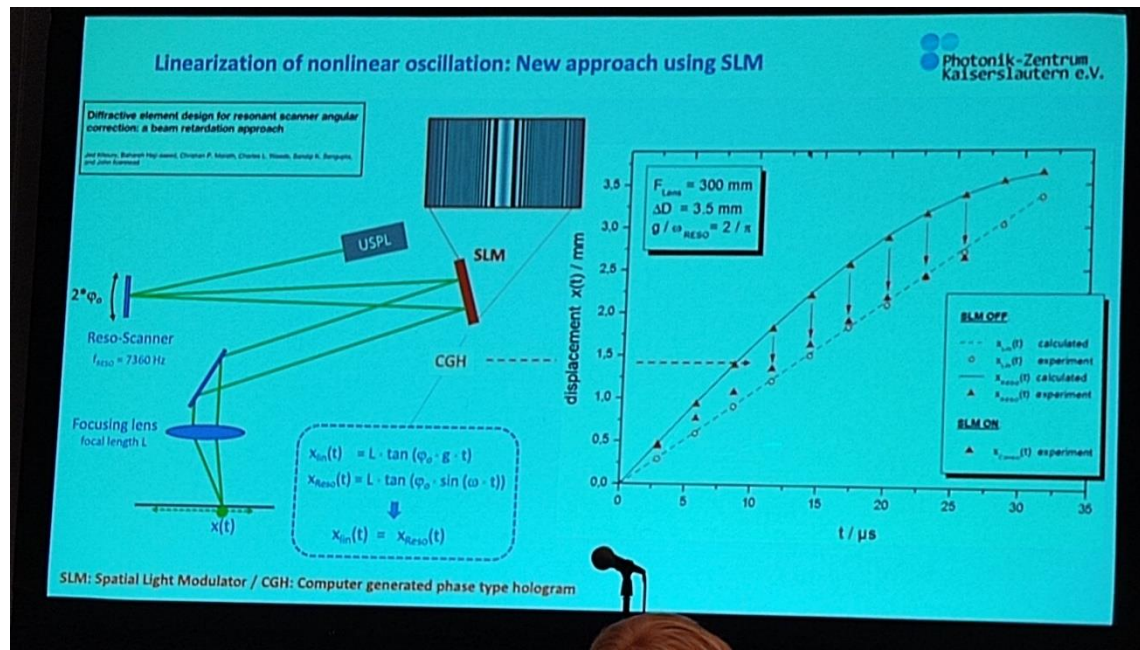
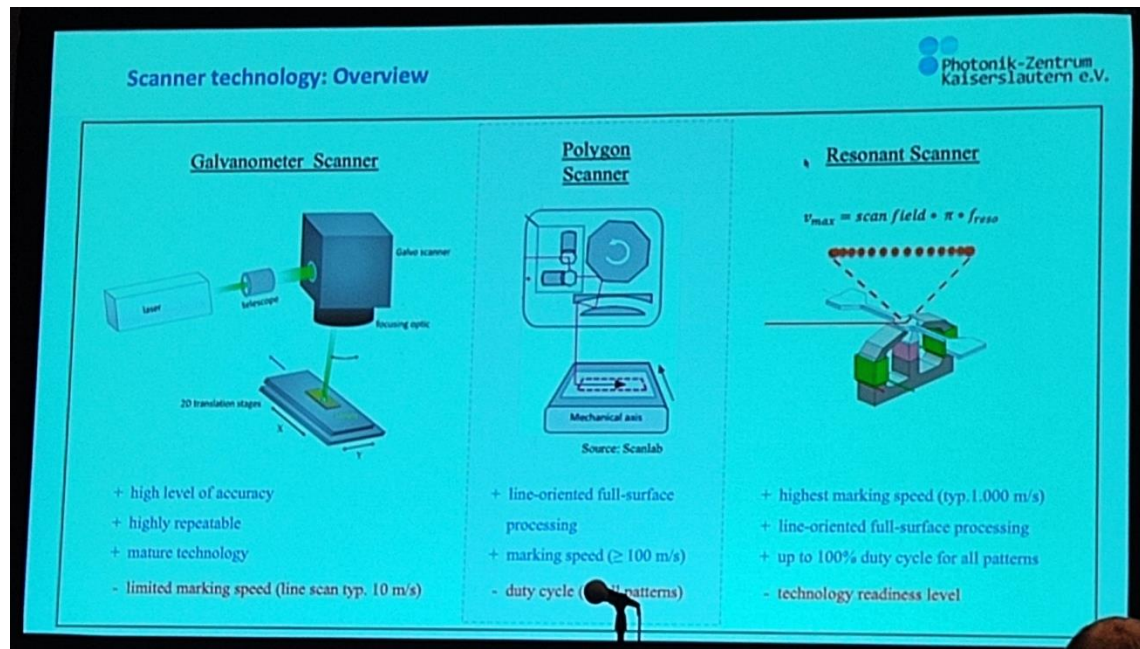
Soc. / Lab. Photonic Center Kaiserslautern (Ger.)

Intérêts

- Scanner résonnant et correction de trajectoire par SLM

Informations clés 6 photos

- Previous RESOMACH project Femtotech gmbh dev resonant scanner
- Now how to apply it for processing applications
- Resonant scanner : SF : scanning field size PO : pulse overlap
- Non-linearity of the speed to carry out.
- Resonant scanner : fill the gap between speed and small area. (polygon scanner not efficient for small areas)
- Use of an SLM to correct the non linearity of the positioning! Ref : Diffractive element design for resonant scanner angular correction : a beam retardation approach
- Resonant vs galvo ablation coherent.





02/02/2023

12442-16

Characteristics of large active area phase only SLM with dielectric mirror

Auteur(s) Hiroshi Tanaka

Soc. / Lab. Hamamatsu (Jap.)

- Intérêts
- Nouveau SLM 30x30mm
  - 60W démontré sur femto

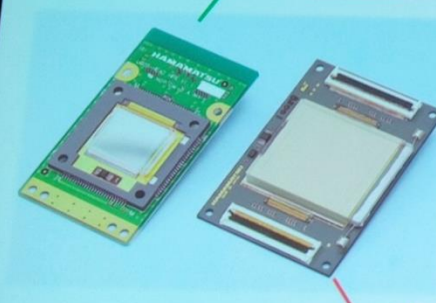
Informations clés

4 photos

- Application pour l'aéronautique et high number of data management
- High laser power irradiation improvements to take into account
- SLM 30x30mm to improve laser damage. Pitch  $30\mu\text{m}$ , 96% efficiency
- Test sur Monaco 260fs, 60W, 1MHz, IR
- Still 60Hz

### Development of large area LCOS-SLM

Specification of prototype large area LCOS-SLM



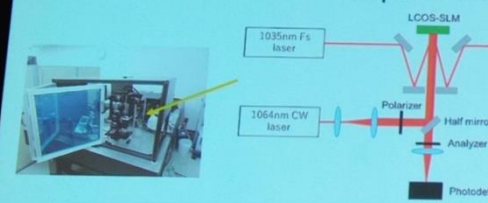
|                              | Conventional LCOS-SLM | Large area prototype LCOS-SLM |
|------------------------------|-----------------------|-------------------------------|
| Active area [mm]             | 15.9 x 12.8           | 30.24 x 30.7                  |
| Pixel Number                 | 1272 x 1024           | 1008 x 1024                   |
| Pixel size [ $\mu\text{m}$ ] | 12.5                  | 30.0                          |
| Fill factor [%]              | 96.8                  | 96.7                          |

Conventional device (X13138)

Large area prototype device

### Development of large area LCOS-SLM

Experiments Phase Measurement



Method

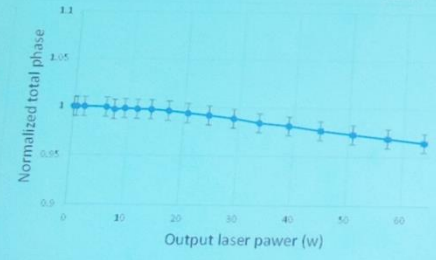
- ✓ Polarization interferometer
- ✓ Voltage-dependent birefringence of the device
- ✓ Investigation of change in maximum phase value with laser intensity

Condition

- ✓ Laser for irradiation of the LCOS-SLM:  
Monaco (Coherent Inc) 60W, 1MHz, 260fs, 1030nm  $\phi 3\text{mm}$  (Surface of the LCOS)
- ✓ Laser for examination of the birefringence  
Forte (Laser Quantum) continuous-wave, 1064nm

Result

- ✓ Total amount of the phase modulation  $> 1\lambda$
- ✓ NO Irreversible changes in case of full power of Monaco Laser.
- ✓ Degradation in the total amount of phase modulation  $< 5\%$



Normalized total phase

Output laser power (w)

02/02/2023

12409-42

Microprocessing with MPLC beam shaper & a 515nm fs laser

Auteur(s) Pu Jian

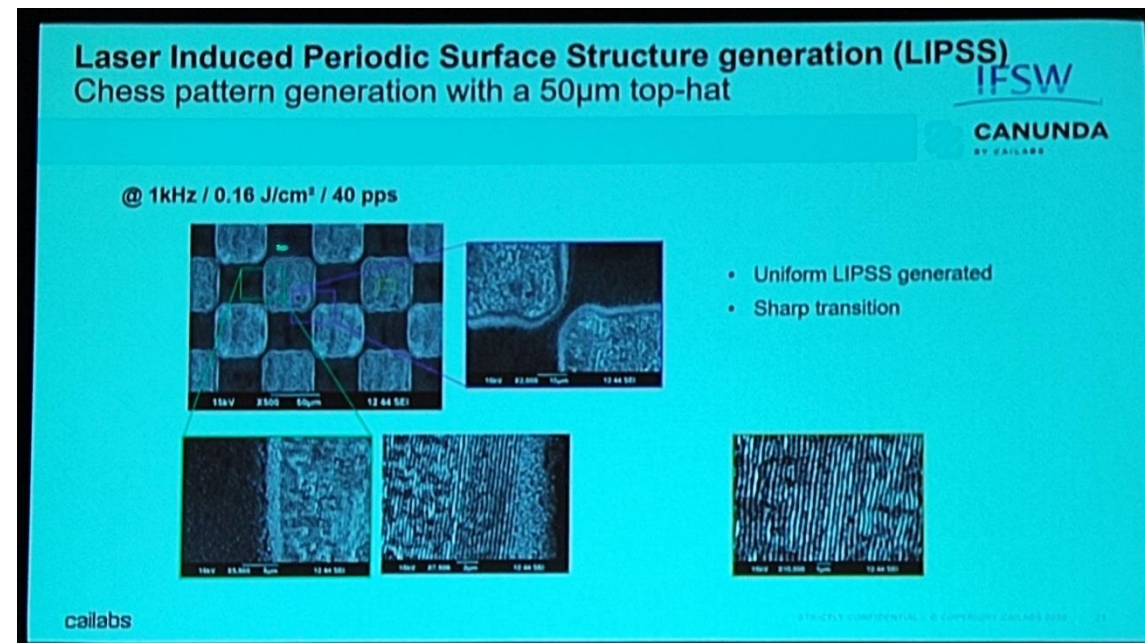
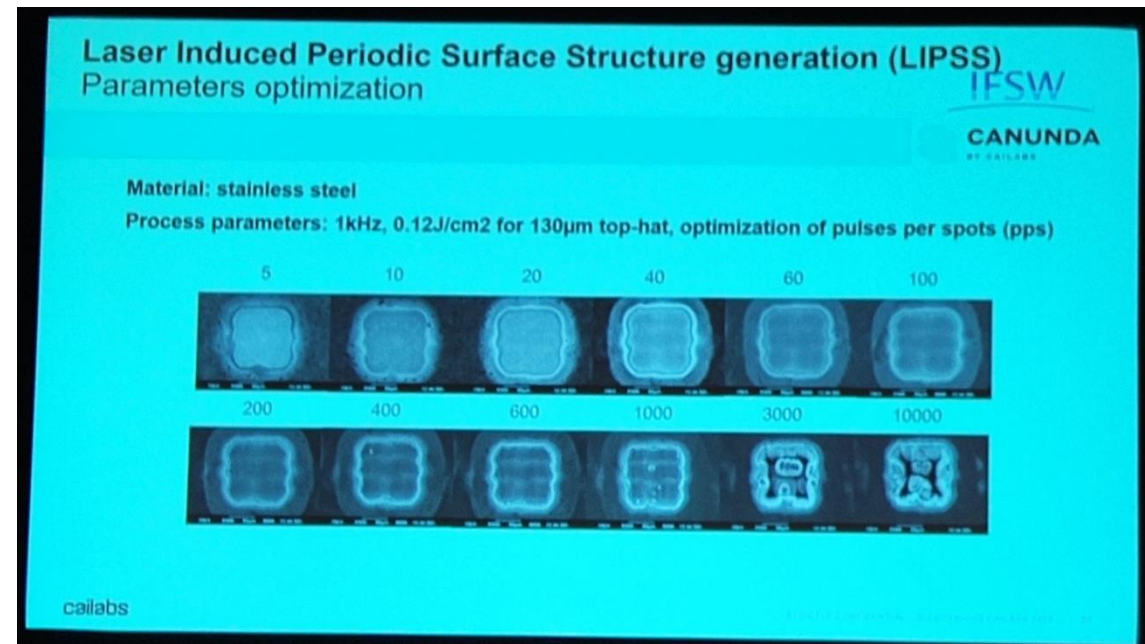
Soc. / Lab. CAILabs (Fr.)

Intérêts • MEF TopHat par MPLC en Vert

Informations clés

- 3W 500fs 515nm f100mm & 260mm

0 photos





## Sub $\mu\text{m}$ structuring of surfaces with DUV lasers

Auteur(s) Serhiy Danylyuk

Soc. / Lab. Fraunhofer ILT (Ger.)

Intérêts • DOE UV sur mesure

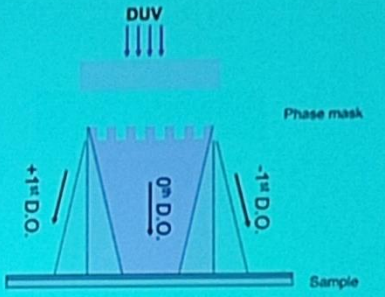
## Informations clés

- Multiflex project
- Dev d'un DOE champ proche pour se rapprocher d'une configuration de lithographie en DUV

7 photos

**Productivity considerations**  
Proximity phase masks

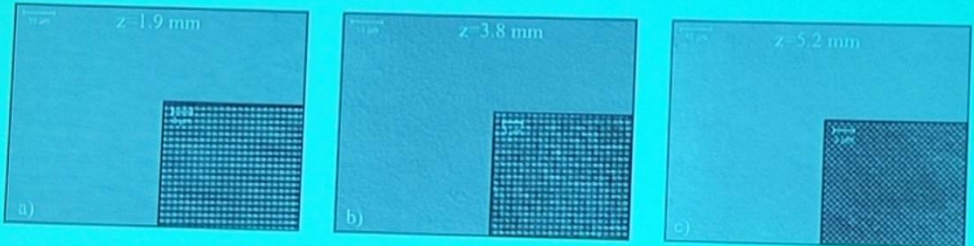
- Large area structures with sizes down to  $\lambda/4$
- Simple optical setup with low system losses
- Tolerant to mask defects
- Throughput directly scales with available laser intensity
- Only periodic structures
- Short distance between mask and sample



Page 11

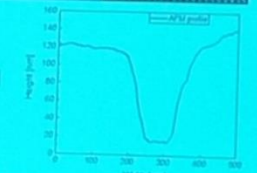
COHERENT Fraunhofer ILT

**Intensity distribution measurements with photoresist**  
LSM characterisation



Both 1:1 imaging and achromatic demagnification  $\sqrt{2}$ :1 has been confirmed

Period reduced to 670 nm, hole size to ~200 nm



Page 21

COHERENT Fraunhofer ILT

02/02/2023

12414-28

Application of machine learning to overcome challenges of generating phase masks for dynamic beam shaping in complex optical elements

Auteur(s) Robin Kurth

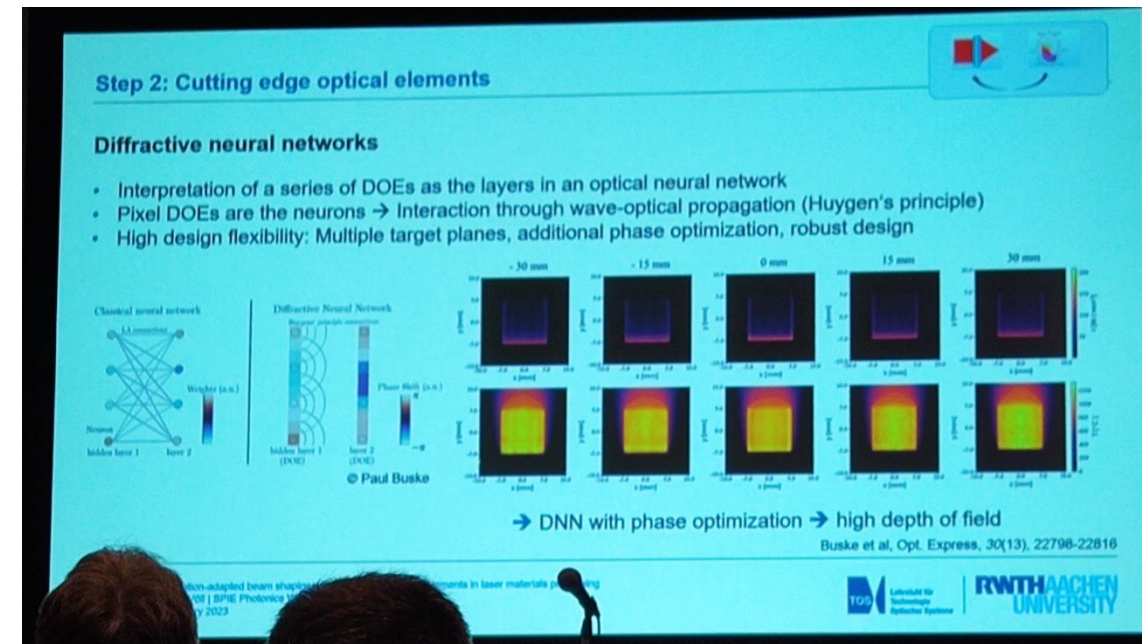
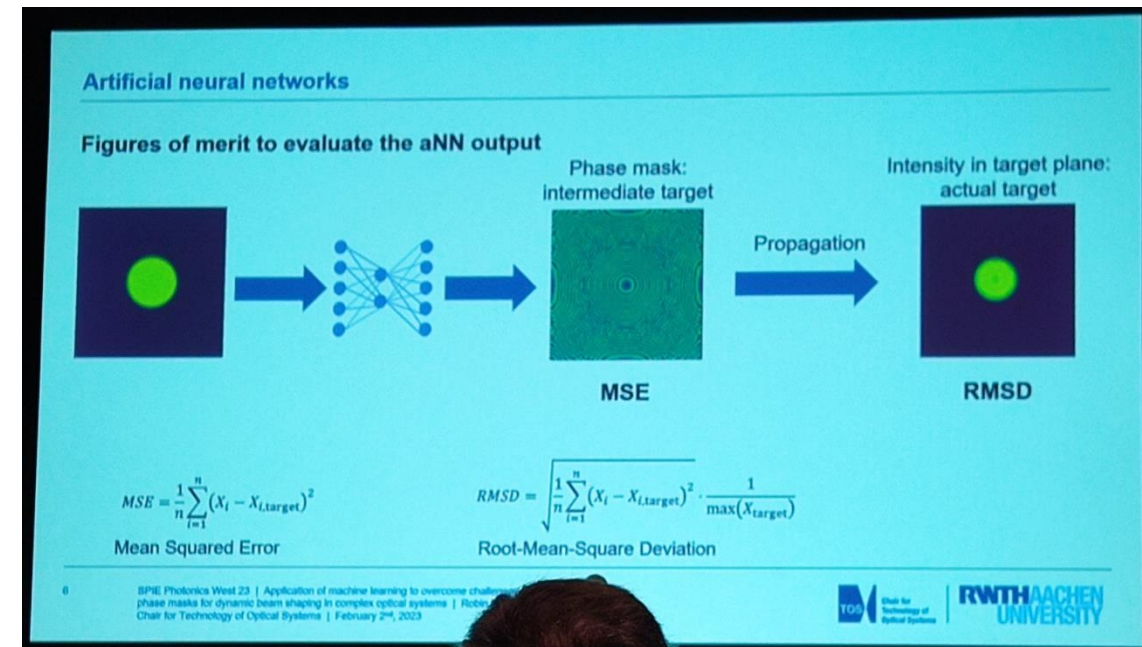
Soc. / Lab. Aachen Univ (Ger.)

Intérêts • Couplage IA + SLM + TopHat adaptation

## Informations clés

2 photos

- Motivation : Retroaction for SLM (phase retrieval)
- Iterative calculation or neural/machine learning
- Artificial Neural Network approximates function to determine phase masks without prior knowledge of optical system = « 1 iteration ». But results highly dependent on the training process and time consuming to train
- Goal : arbitrary beam shapes
- Tophat : much better theoretical fit for continuous phases than discontinued (pi 0->255)...





02/02/2023

12414-29

High throughput SLM based multibeam laser marking system

Auteur(s) Gregory Jacob

Soc. / Lab. Silicon Light Machines (USA)

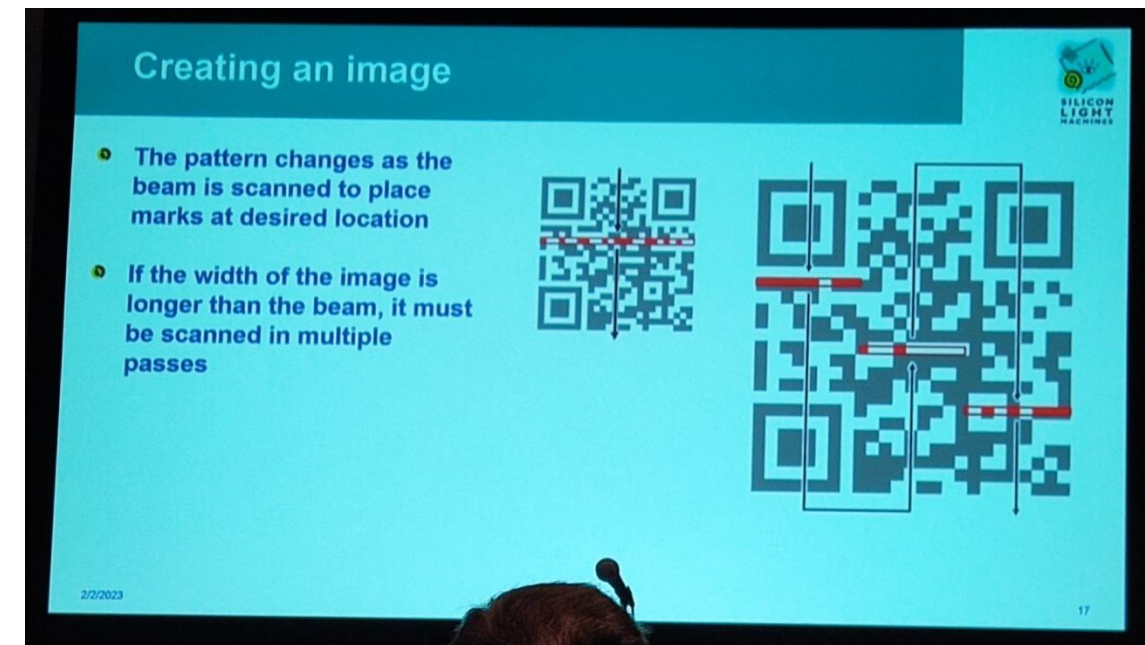
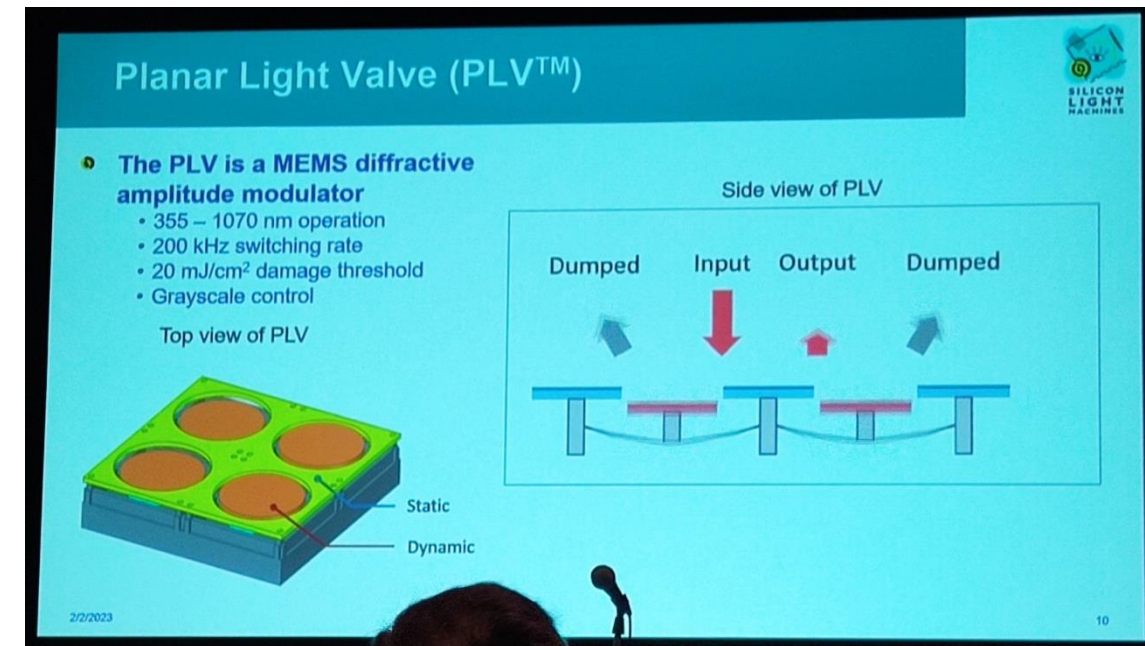
Intérêts

- Nouveau type de modulateur mécanique
- Stratégie d'usinage par bande

Informations clés

10 photos

- MEMS piston SLM
- Grayscale control /  $20\text{mJ}/\text{cm}^2$  threshold
- $1088 \times 40$  pistons ( $27 \times 1\text{mm}$ )
- 90W 10ps  $200\mu\text{J}$
- High speed demonstration of black marking by bands



02/02/2023

12414-32

Application adapted beam shaping with cutting edge optical elements in laser materials processing

Auteur(s) Annika Völl

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Intérêts • MEF neuronale

Informations clés

1 photos

- Adaptation of tophat répartition with répartition of temperature on sample
- Diffractive neural network
- Buske Opt Express 30 (13) 22798 22816



The image shows a presentation slide titled "Step 2: Cutting edge optical elements" with a "Comparison" table. The table compares various beam shaping elements across several criteria. A person's hand is visible in the foreground, holding a smartphone to take a photo of the slide.

| Beam shaping element          | Dynamic | 2D control | High Power | „Low -cost“ | Separat component | Special laser beam | Other                                                 |
|-------------------------------|---------|------------|------------|-------------|-------------------|--------------------|-------------------------------------------------------|
| Freeform optics               | ✗       | ✓          | ✓          | ✓           | ✓                 | ✗                  | Only reflective (for high power)<br>Low beam quality  |
| VCSELs                        | ✓       | ✗          | ✓          | ✓           | ✗                 |                    |                                                       |
| DOEs                          | ✗       | ✓          | ✓          | ✓           | ✓                 | ✓                  | „Design for manufacturing“<br>„0th diffraction order“ |
| LCoS                          | ✓       | ✓          | ✗          | ✓           | ✓                 | ✓                  |                                                       |
| Diffractive neural networks   | ✓       | ✓          | ✓          | ✗           | ✓                 | ✓                  | New approach with no rigorous validation              |
| Fast modulation with scanners | ✓       | ✓          | ✓          | ✓           | ✓                 | ✗                  | Only quasi distribution                               |
| Optical phased arrays         | ✓       | ✗          | ✓          | ✗           | ✗                 |                    |                                                       |

Logos at the bottom of the slide: TOS, Leibniz-Institut für Technologie-Optische Systeme, and RWTH AACHEN UNIVERSITY.



# RÉVISIONS

| Révision | Date       | Description / Modifications |
|----------|------------|-----------------------------|
| A        | 06/02/2023 | Création du document        |
|          |            |                             |
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*Avec le soutien de*



*Partenaires*

